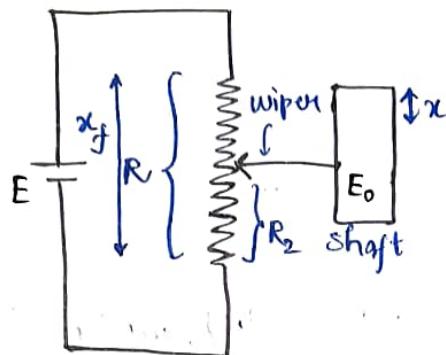


# Potentiometric Displacement Sensing

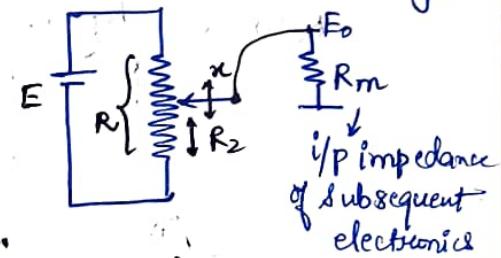


$$R_2 = \frac{x}{x_F} R$$

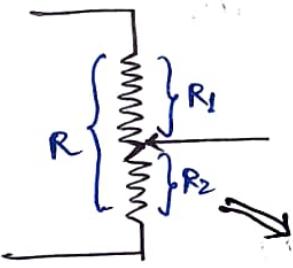
$$E_0 = \frac{R_2}{R} E = \frac{x}{x_F} E$$

↳ Contact-based measurement :

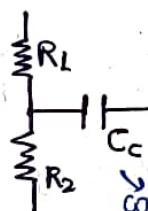
- wear and tear (as wiper is in contact with fixed resistance winding)
- limited lifespan
- loading effect (due to  $R_m$ ).  
[ $R_2$  and  $R_m$  in parallel.]



Non-contact-based measurement :



→ wiper is separated by a small air-gap.



$$R_2 = \frac{x}{x_F} R$$

$$\text{As } R_1 + R_2 = R,$$

$$R_1 = \left[ 1 - \frac{x}{x_F} \right] R$$

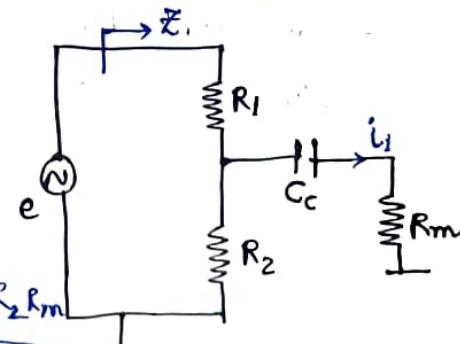
coupling capacitor  
to model the air-gap.

$$Z = R_1 + R_2 \parallel \left( R_m + \frac{1}{j\omega C_c} \right)$$

$$= R_1 + R_2 \left[ R_m + \frac{1}{j\omega C_c} \right] \overline{R_2 + R_m + \frac{1}{j\omega C_c}}$$

$$= \frac{R_1 R_2 + R_1 R_m + (R_1 + R_2) \frac{1}{j\omega C_c} + R_2 R_m}{R_2 + R_m + \frac{1}{j\omega C_c}}$$

$$= \frac{R_1 R_2 + R_m (R_1 + R_2) + \frac{1}{j\omega C_c} (R_1 + R_2)}{R_2 + R_m + \frac{1}{j\omega C_c}}$$



$$\Rightarrow E = \frac{N}{R_2 + R_m + \frac{1}{8C_c}}$$

$$i_1 = \frac{e}{Z} \times \frac{R_2}{R_2 + R_m + \frac{1}{8C_c}}$$

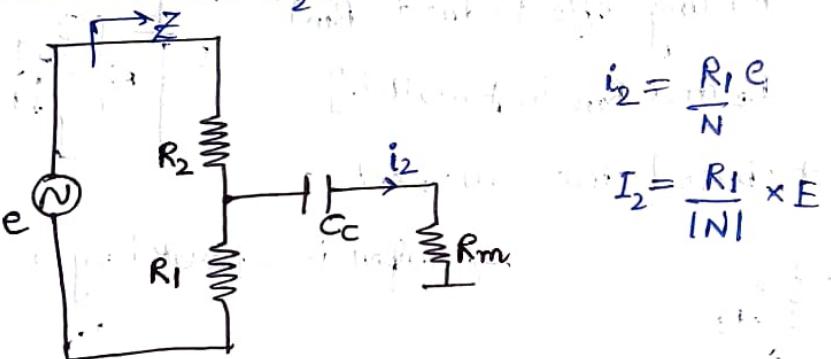
$$= \frac{eR_2}{N} \quad (\text{substitute } Z)$$

Let  $e = E \sin(\omega t)$ ,

(mag.)  $I_1 = \frac{R_2}{|N|} \times e \rightarrow \text{dependent on } |N|, \text{ which is dependent on } R_m \text{ and } C_c.$

$$N = R_1 R_2 + R_m (R_1 + R_2) + \frac{1}{8C_c} (R_1 + R_2)$$

Reverse  $R_1$  and  $R_2$ :



$$i_2 = \frac{R_1 e}{N}$$

$$I_2 = \frac{R_1}{|N|} \times e$$

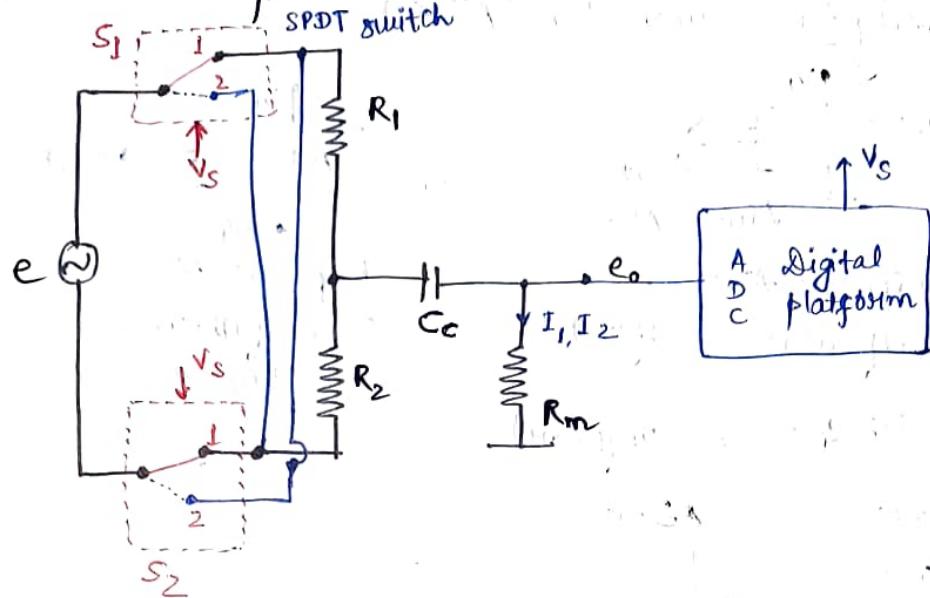
Ratiometric function,

$$F = \frac{I_1 - I_2}{I_1 + I_2} = \frac{R_2 - R_1}{R_2 + R_1}$$

$$F = 2 \left( \frac{x}{x_F} \right) - 1$$

- Linear estimation of "x".
- No dependence on  $C_c, R_m, R$ .
- No wear & tear, loading.

## Two-mode operation (Non-contact Potentiometer):



Mode-1:

$v_s$ : logic-high

$S_1, S_2 \rightarrow 1$

Measure amplitude  $e_{o1}$  of  $e_o$ :

$$E_{o1} = I_1 R_m = \frac{R_2}{|N|} \times E R_m$$

Mode-2:

$v_s$ : logic-low

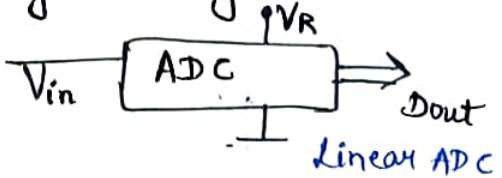
$S_1, S_2 \rightarrow 2$

Measure amplitude  $(E_{o2})$  of  $e_o$ :

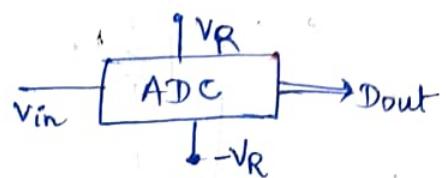
$$E_{o2} = I_2 R_m = \frac{R_1}{|N|} \times E R_m$$

$$\therefore F = \frac{E_{o1} - E_{o2}}{E_{o1} + E_{o2}} = \frac{I_1 - I_2}{I_1 + I_2} = 2 \left( \frac{x}{r_f} \right) - 1$$

# Analog-to-Digital Converter (ADC)

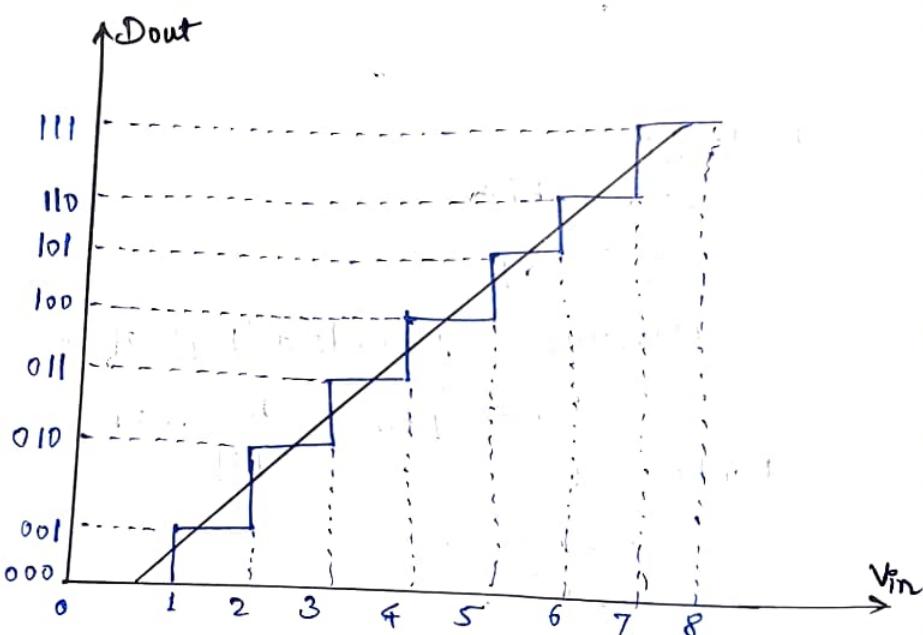


Unipolar ADC  
(Four half wave rectified)



3-bit ADC with  $V_R = 8V$  (unipolar):

<u>Vin</u>	<u>Dout</u>
[0, 1]	000
[1, 2]	001
[2, 3]	010
[3, 4]	011
[4, 5]	100
[5, 6]	011
[6, 7]	101
[7, 8]	110
	111



Resolution ( $q$ ): Min<sup>m</sup> detectable voltage → depends on reference voltage, polarity, and no. of bits.

$$q = \frac{V_R}{2^n} : \text{Unipolar ADC}$$

$$q = \frac{2V_R}{2^n} = \frac{V_R}{2^{(n-1)}} : \text{Bipolar ADC}$$

In our case, input  $\approx 8V$ ,  $q = \frac{8V}{2^3} = 1V$ .

To reduce  $q$ , either reduce  $V_R$  or increase  $n$ .

$$V_{in} \in [0, V_R]$$

$n \uparrow \Rightarrow$  size  
wgt power ↑

$V_R \downarrow \Rightarrow$  span of ADC decreased

For  $V_R = 8V$ ,  $n = 16$ ,

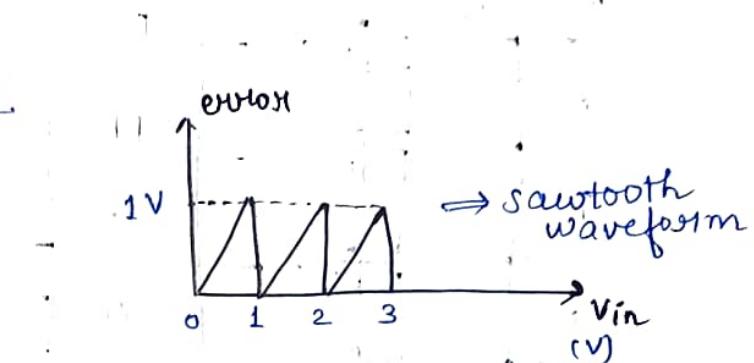
$$q = \frac{V_R}{2^n} = \frac{8}{2^{16}} = 120 \mu V$$

In case of noisy sensor, if we decrease  $q$ , false detection may happen. so, we have to reduce noise as well.

$$\text{Quantization Error} = V_{in} - \text{Analog Equivalent (D}_{out}\text{)}$$

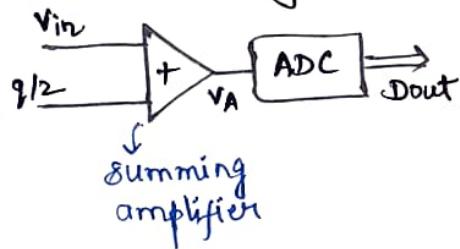
For  $V_R=8$ ,  $n=3$ ,

<u><math>V_{in}</math></u>	<u><math>A(D_{out})</math></u>	<u>error</u>
0	0	0
0.5	0	0.5
1 (just below)	0	1
1 (just above)	1	0

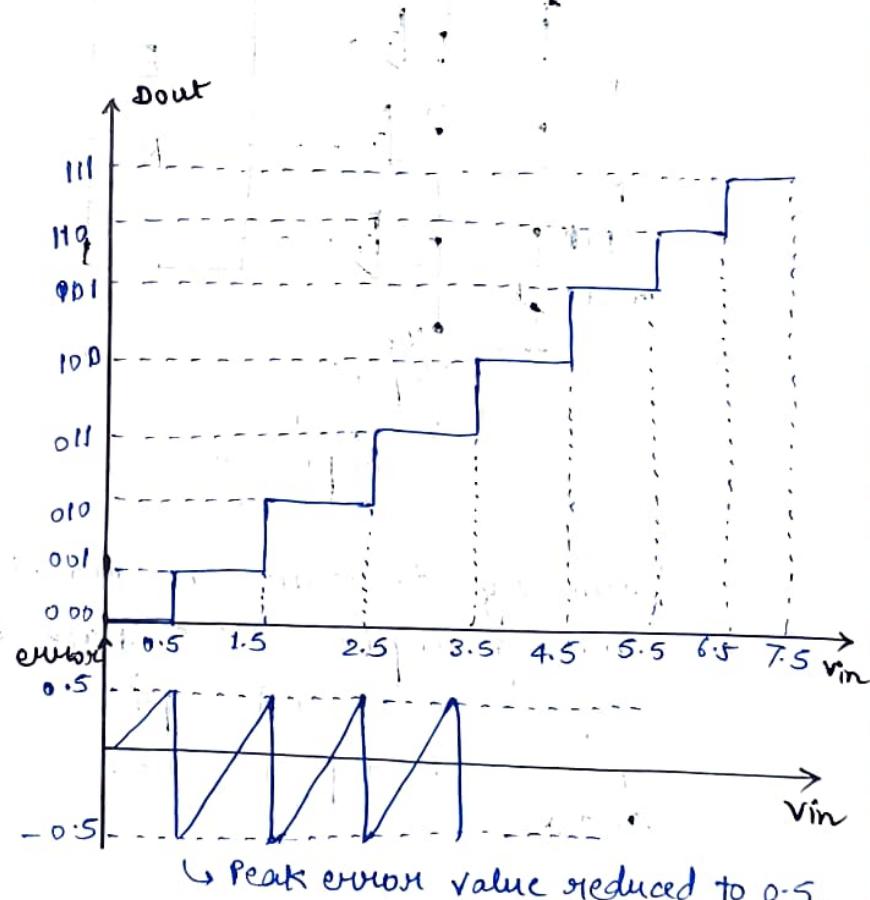


Maximum quantization error,  $q=1$ .

How to mitigate this?

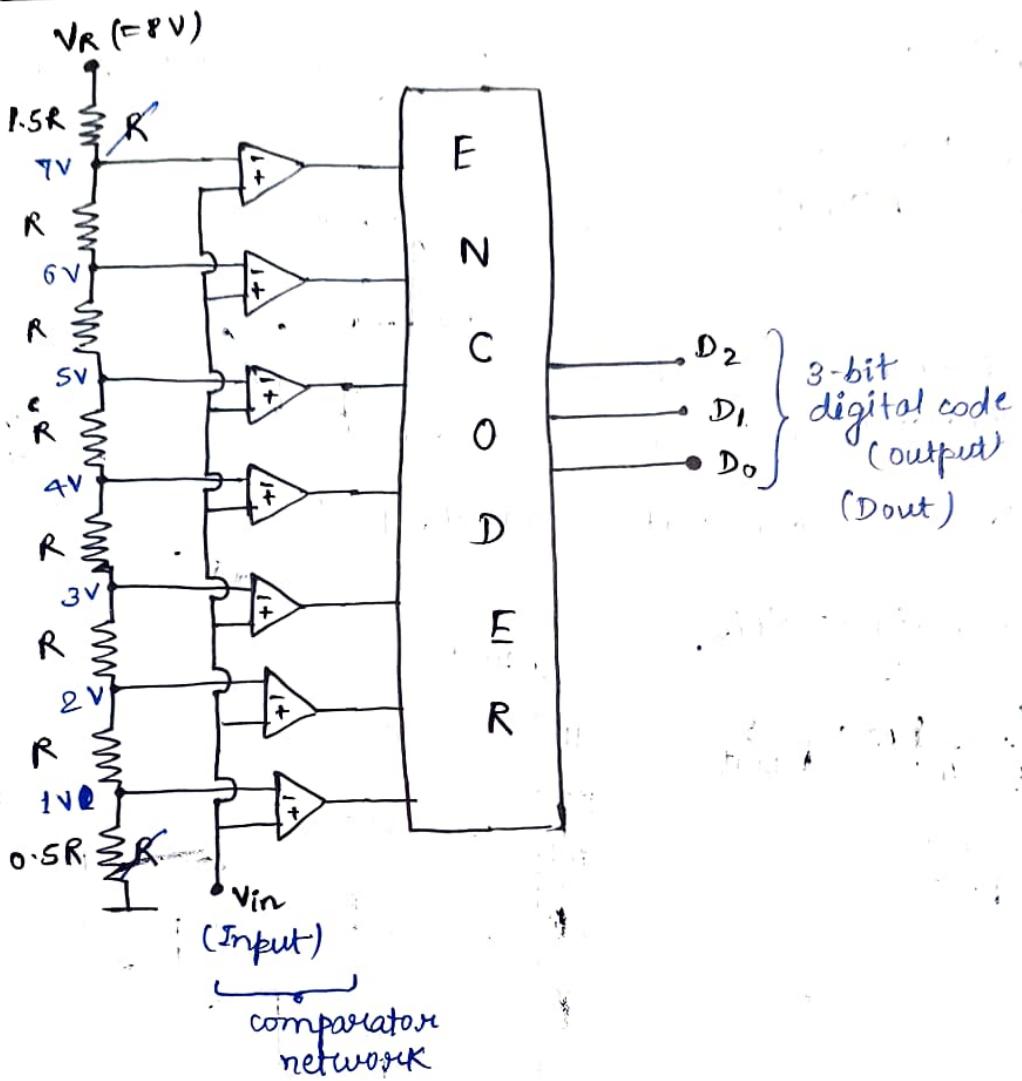


Max<sup>m</sup> quantization  
error =  $q/2$ .

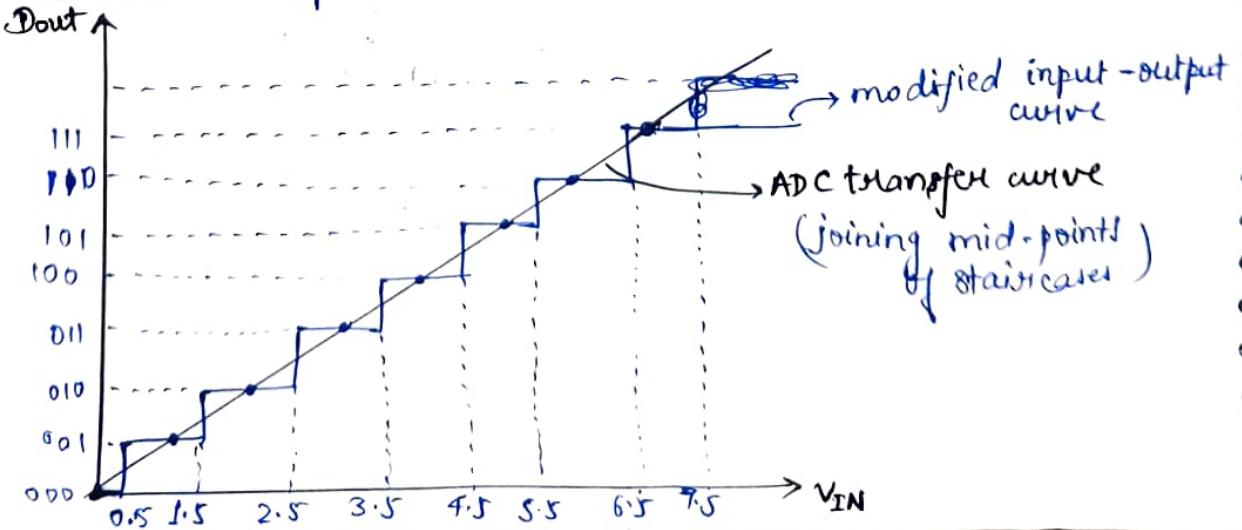


## Flash ADC

3-bit flash ADC:

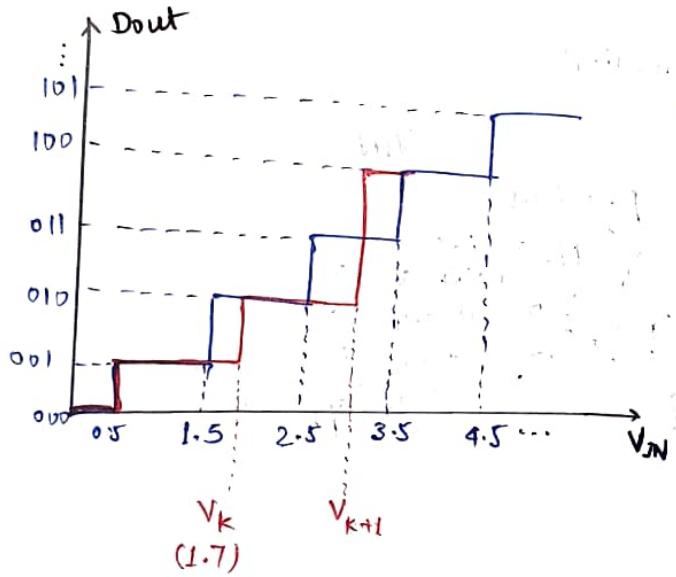
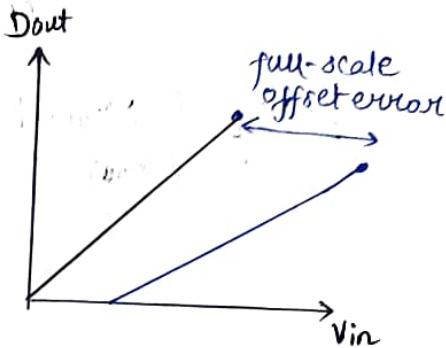
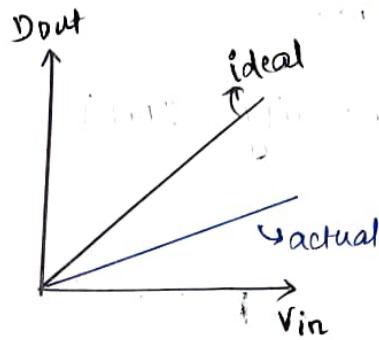
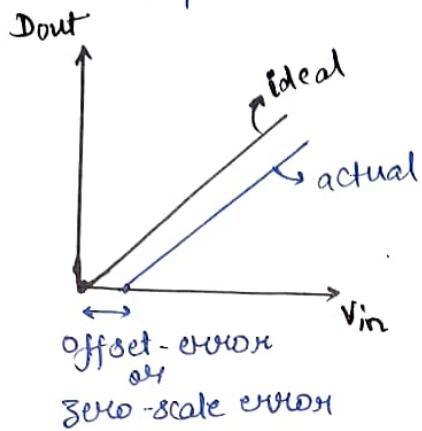


Previously, to reduce the quantization errors, we used a summing amplifier. Here, flash ADC can be modified (instead of using summing amplifier) by making bottom resistance  $R_2$  and the top one  $3R_2$ .



## Offset and Gain Errors :

Due to resistance tolerance and comparator tolerance (input offset), there will be some error in the actual response.



(e.g. all resistances have the same tolerance)

Ideal code width =  $q$

Actual code width  $\neq q$

$$\left. \begin{array}{l} = V_{K+1} - V_K \\ = 1.2q \end{array} \right\}$$

(due to different R tol. & comp. i/p offset)

$$\text{Difference} = 0.2q$$

## Differential Non-Linearity (DNL)

$$= \frac{(V_{K+1} - V_K) - q}{q}$$

$$= \frac{0.2q}{q} = 0.2$$

$$\text{For } DNL_K = -1 \Rightarrow \frac{V_{K+1} - V_K - q}{q} = -1$$

Missing code  $\Rightarrow V_{K+1} = V_K \Rightarrow 0$  code width

n-bit ADC  $\rightarrow$  (n-1) bit ADC  $\rightarrow$  one-level missing

$$\text{For } DNL_K > 1 \Rightarrow V_{K+1} - V_K - q > q$$

$$\Rightarrow V_{K+1} - V_K > 2q$$

may lead to

- missing code (may or may not)

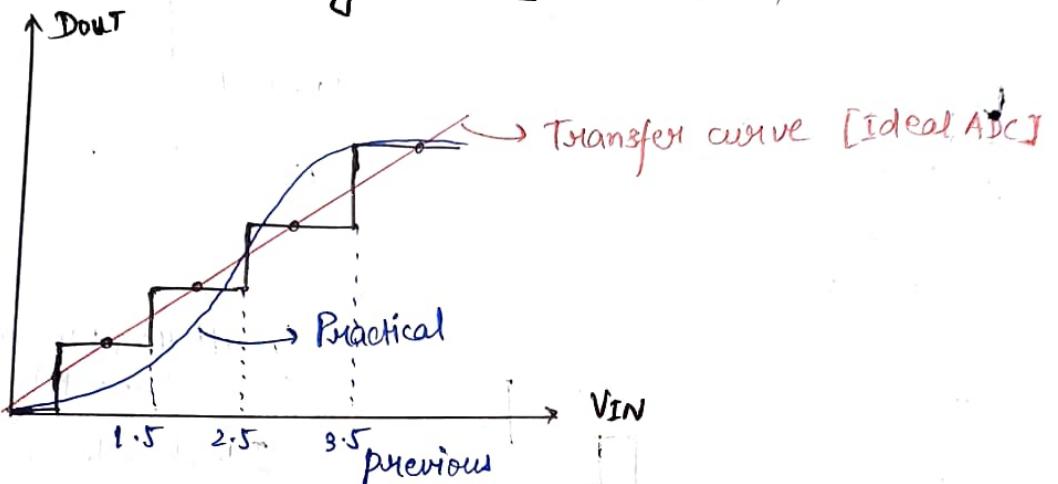
will lead to  
non-linearity

$DNL_{ADC}$ : worst-case ( $DNL_K$ )

• ↗ 8 for 3-bit ADC.

Eg: 0.2, -0.2, 0.3, -0.4 : DNL values  
 $DNL_{ADC} = \text{±} 0.4$ .

### Integral Non-Linearity (INL)



INL: Accumulation of  $DNL$ s. ideal voltage at which transition has happened

$$INL_K = \frac{V_K - [(Kq - q/2)]}{q}$$

actual voltage  $q$  at which transition happened

Eg. 0.5 1.7 3 3.5  
 1.5 2.5 → ideal transitions

$$DNL = 0.2 \quad 0.3$$

$$INL = \frac{1.7 - 1.5}{1} = 0.2 \quad \frac{3 - 2.5}{1} = 0.5$$

$$INL_{K+1} = \frac{V_{K+1} - [(K+1)q - q/2]}{q}$$

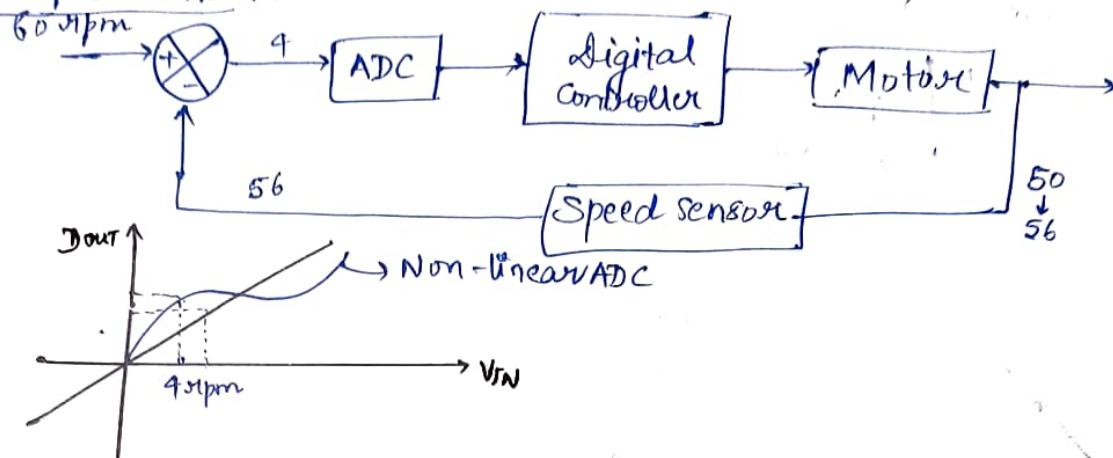
$$INL_{K+1} - INL_K = \frac{V_{K+1} - V_K - q}{q}$$

$$\therefore [INL_{K+1} - INL_K = DNL_K]$$

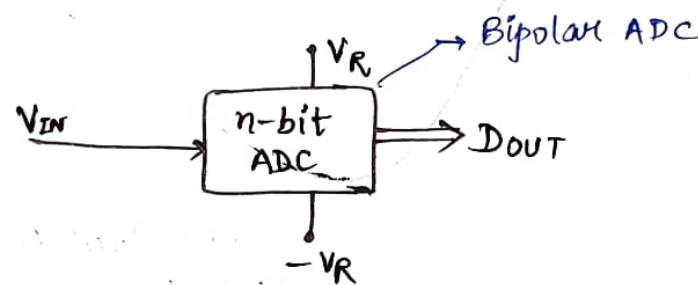
Datasheet gives:  
 - DNL  
 - INL  
 ↳ which is more imp.  
 depends on the end user

DNL → Define fine changes in ADC characteristics.  
 (fine granularities) → useful for image processing  
 INL → global → useful when ADC operates in a large span.

Eg. Motor-speed control:



### Signal-to-Noise Ratio (SNR)



$$SNR = 10 \log \left( \frac{V_{sig}^2}{V_{noise}^2} \right).$$

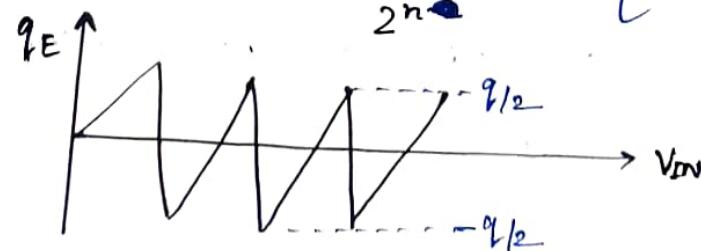
#### Source of $V_{noise}$ :

- Quantization error ( $q_E$ ) → major source
- Noise from application.
- Random transients during switching.

$$\max(q_E) = q/2$$

$$= \frac{V_R}{2^n}$$

$$\left[ \because q = \frac{V_R}{2^{n-1}} \right]$$



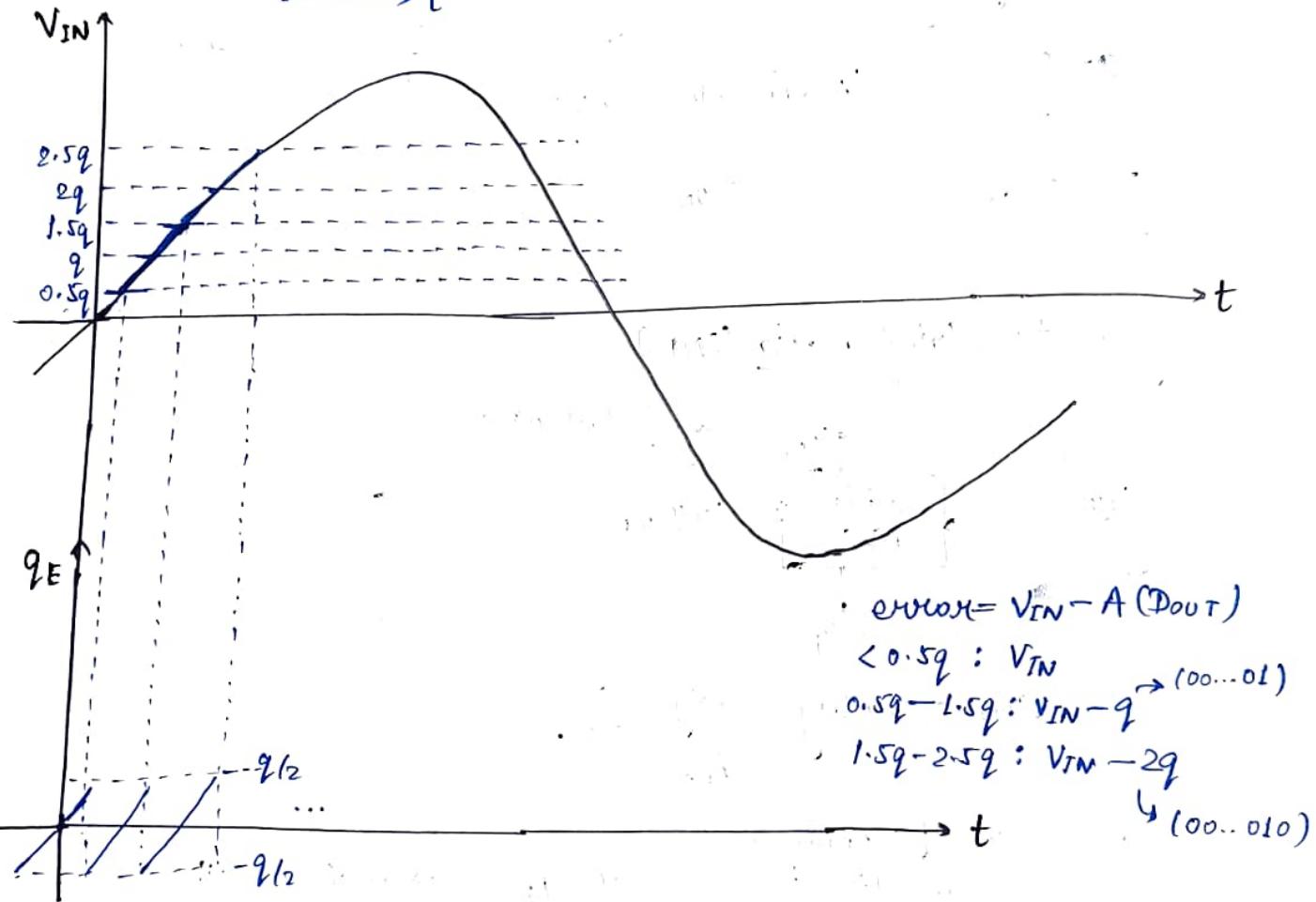
$$V_{IN} = A \sin \omega t$$

$$V_{sig.}^2 = \frac{A^2}{2} \quad [= \text{RMS value of } V_{IN}]$$

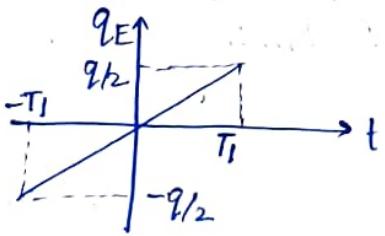
$\sim \text{power of signal}$

$V_{noise} \rightarrow ?$

$$\begin{matrix} q_E \\ ? \end{matrix} \uparrow \downarrow \quad \rightarrow t$$



↳ sawtooth  $(-\frac{q}{2}, \frac{q}{2})$



$q_E = s \cdot t$ ,  $s$ : slope  $\rightarrow$  depends on  $V_{IN}$

$$s = \frac{q}{2T_1}$$

$$\begin{aligned}
 V_{\text{noise}}^2 &= \frac{1}{2T_1} \int_{-T_1}^{T_1} q_E^2 dt \\
 &= \frac{1}{2T_1} \int_{-T_1}^{T_1} \left(\frac{q}{2T_1}\right)^2 t^2 dt \\
 &= \frac{q^2}{8T_1^3} \left[ \frac{t^3}{3} \right]_{-T_1}^{T_1} \\
 &= \frac{q^2}{24T_1^3} \quad [2T_1^3 - (-T_1^3)] \\
 &= \frac{q^2}{4T_1^2} \quad [\text{independent of } s]
 \end{aligned}$$

SNR

22-08-2025

$$\begin{aligned}
 \text{SNR} &= 10 \log \left( \frac{V_{\text{sig}}^2}{V_{\text{noise}}^2} \right) \\
 &\approx 10 \log \left( \frac{6A^2}{q^2} \right) \\
 &= 10 \log 6 + 20 \log \left( A/q \right) \\
 &= 10 \log 6 + 20 \log \left( \frac{A}{V_R} \cdot 2^{n-1} \right) \\
 &= 10 \log 6 + 20 \log \left( \frac{A}{V_R} \right) + 20(n-1) \log 2 \\
 \Rightarrow \boxed{\text{SNR} = 6.02n + 1.76 + 20 \log \left( \frac{A}{V_R} \right) \text{ dB}}
 \end{aligned}$$

$$A \in (0, V_R)$$

$$A = V_R \Rightarrow \boxed{\text{SNR}_{\max} = 6.02n + 1.76 \text{ dB}}$$

→ Better to operate the ADC near the full-scale → May require pre-amplification of  $V_{IN}$

$$\text{For } V_R = 5 \text{ V}$$

$$A = 0.1 \text{ V}$$

↓  
Poor SNR → Not wise choice

$$n=10 \Rightarrow \text{SNR}_{\max} = 61.96 \text{ dB} \approx 62 \text{ dB.}$$

$$n=12 \Rightarrow \text{SNR}_{\max} = 74 \text{ dB.}$$

$$\text{SNR}_{n+1} = \text{SNR}_n + 6.02$$

$$V_{\text{sig}}^2 = A^2 / 2$$

$$q = \frac{V_R}{2^{n-1}}$$

$$V_{\text{noise}}^2 = \frac{q^2}{12}$$

$$q_E = st$$

$$A = V_R/2, n=10 \Rightarrow SNR = 6.02 \times 10 + 1.76 + 20 \log(1/2) \\ = 56 \text{ dB}.$$

[Equivalent to one less bit]

$$DNL = -1 \Rightarrow n\text{-bit} \rightarrow (n-1)\text{ bit}$$

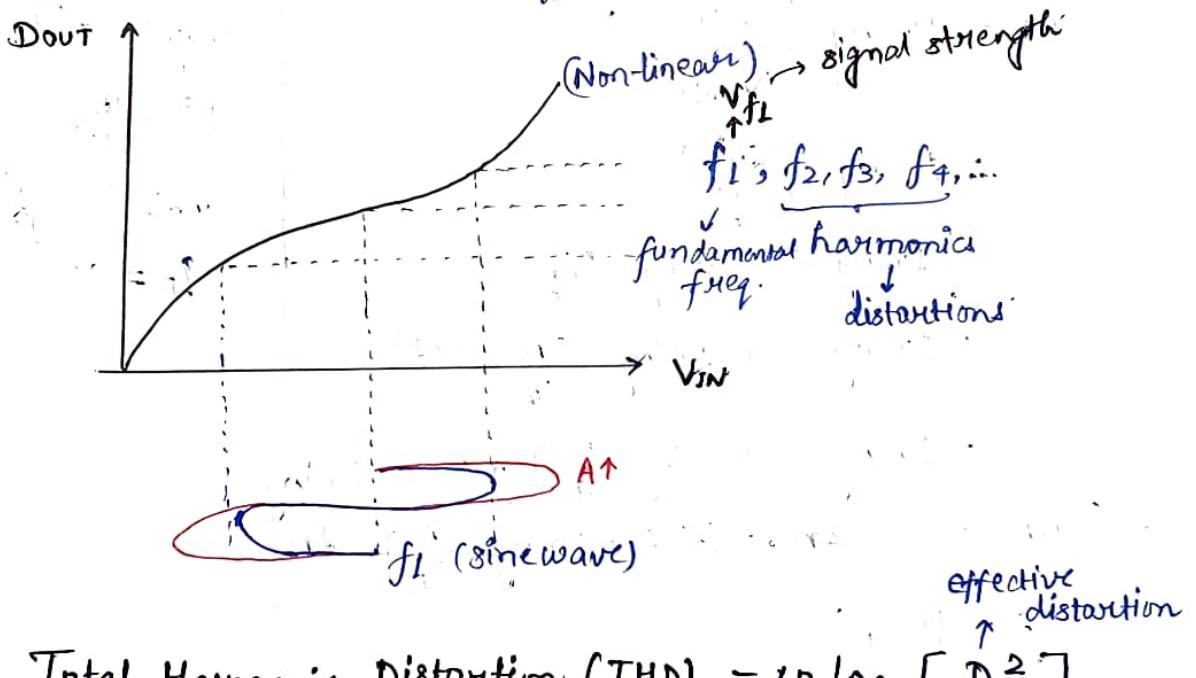
$SNR \rightarrow 6.02 \text{ dB} \downarrow$

$SNR \xleftarrow[\text{some relation}]{}$   $DNL$

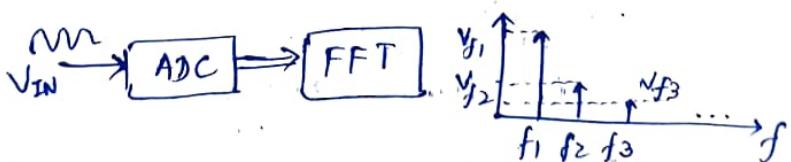
$$V_{IN} = A \sin \omega t$$

$\omega \uparrow \rightarrow$  slew-rate  $\Rightarrow SNR \downarrow$   
 (reaches near  
 (BW of ADC opamp) effects

New parameters: THD  $\xleftarrow[\text{related to}]{}$  INL



$$\text{Total Harmonic Distortion (THD)} = 20 \log \left[ \frac{D^2}{S^2} \right] \\ = 20 \log \left[ \frac{V_{f_2}^2 + V_{f_3}^2 + V_{f_4}^2 + \dots}{V_{f_1}^2} \right]$$



$A \uparrow \Rightarrow SNR \uparrow, THD \text{ will } \Rightarrow V_{fc} \uparrow$  become poorer (e.g.,  $-8 \text{ dB} \rightarrow -60 \text{ dB}$ ) (b/c we're using more position of the non-linear curve)

$$SNR = 10 \log \left[ \frac{S^2}{N^2} \right]; THD = 10 \log \left[ \frac{D^2}{S^2} \right]$$

	<u><math>q_s</math></u>	<u>harmonics</u>
SNR:	✓	✗
THD:	✗	✓
SNDR:	✓	✓

↓  
Signal-to-Noise  $\rightsquigarrow$  should capture the  
Distortion Ratio effects of both  $q_s$  & harmonics.

$$SNDR = 10 \log \left[ \frac{S^2}{N^2 + D^2} \right]$$

$$= 10 \log \left[ \frac{1}{N^2/S^2 + D^2/S^2} \right]$$

$$= -10 \log \left[ \frac{N^2}{S^2} + \frac{D^2}{S^2} \right]$$

$$= -10 \log \left[ 10^{-SNR/10} + 10^{THD/10} \right] \text{ dB} \rightarrow \text{equal weightage}$$

to SNR & THD

Eg.  $n=10$

$$SNR = 62 \text{ dB}$$

$$THD = 580 \text{ dB}$$

$$SNDR = -10 \log [10^{6.2} + 10^8]$$

$$= 61.93 \text{ dB} \rightarrow \text{SNR} \underset{\text{dictates}}{\cancel{\text{determines}}} \text{ SNDR.}$$

Eg.  $n=12$

$$SNR = 74 \text{ dB}$$

$$SNDR \approx 68 \text{ dB} \rightarrow (6 \text{ dB, } \downarrow \text{ compared to SNR})$$

$\downarrow$   
Effective no. of Bits = 11  
(2-bit decrease)

### Effective Number of Bits (ENoB):

$$ENoB = \frac{SNDR - 1.76}{6.02} \rightarrow \text{Gives the overall performance of ADC.}$$

Assignment: Look into the datasheet of any 2 commercially available ADC, and compare their parameters.

$$\boxed{SNR = 6.02n + 1.76}$$

$$SNDR = 6.02(ENOB) + 1.76$$

26-08-2025

$$SNR_{max} = 6.02n + 1.76 \text{ dB}$$

- ↳ Theoretical max value
- ↳ Only  $q_E$  considered
- ↳ Neglected application circuit noise and switching noise.
- ↳ Finite maxima, minima, discontinuities.

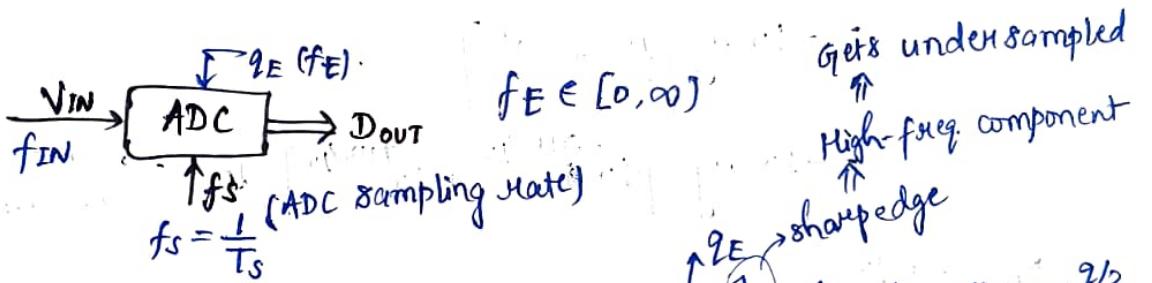
### ADC8:

Flash ADC → Fastest

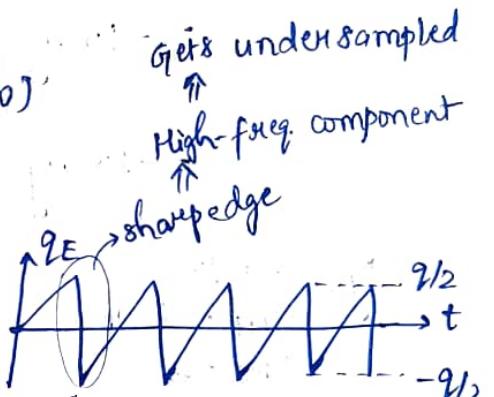
Dual-slope ADC → Slow, good resolution

Sigma-Delta ADC → Fast, good resolution

### Sigma-Delta ADC:



$f_s \geq 2f_{IN}$  : satisfy Nyquist criteria

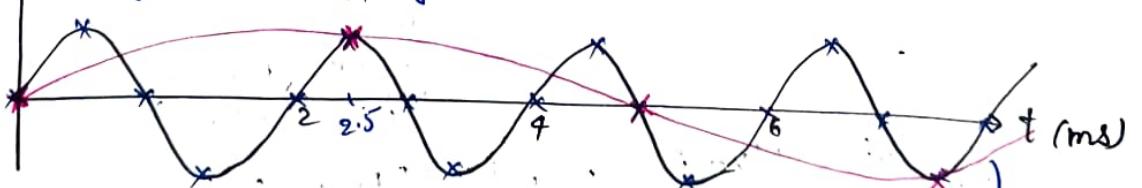


If  $f_s = 2f_{IN} \Rightarrow SNR = 6.02n + 1.76$  (impulse)

With  $q_E$ ,

$f_s < 2f_E$  or  $0 < f_E < \infty$ .

### # Effect of undersampling of $q_E$ :



$$f_s = 500 \text{ Hz}$$

$$T_s = 0.5 \text{ ms}$$

$$f_s = 400 \text{ Hz}$$

$$T_s = 2.5 \text{ ms}$$

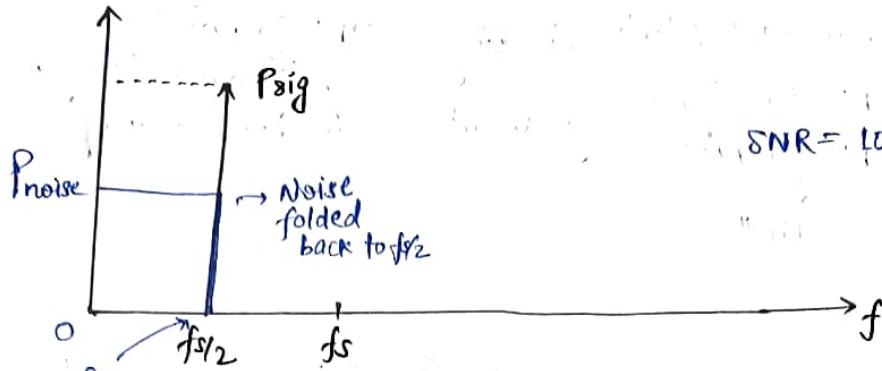
} same freq. as ip wave

}

period of sampled signal = 10 ms

$$100 \text{ Hz} < \frac{f_s}{2} = (500 - 400) \text{ Hz}$$

sub-Nyquist Sampling

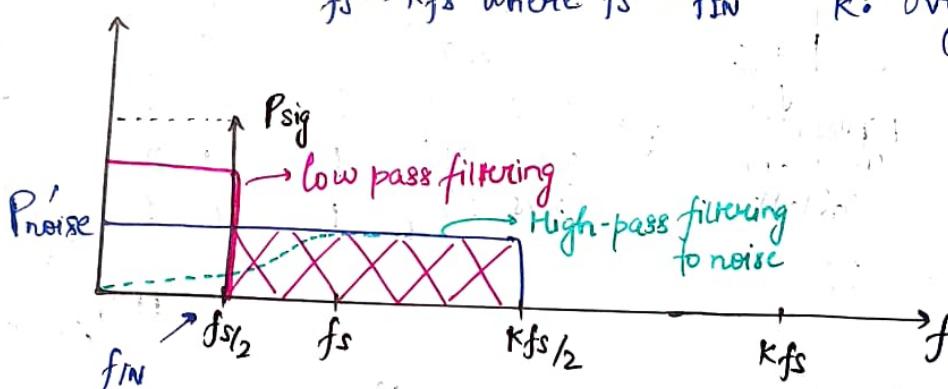


Oversampling:  $f_E$  (For improvement)



$kfs$  (Sampling at a higher freq.)

$f_s \rightarrow kfs$  where  $fs = 2f_{\text{IN}}$        $k$ : oversampling factor ( $K > 1$ )



$$P_{\text{noise}'} = \frac{P_{\text{noise}}}{K}$$

$$\text{SNR}' = 10 \log \left( \frac{P_{\text{sig}} \cdot K}{P_{\text{noise}'}} \right)$$

$$= \text{SNR} + 10 \log K$$

Improvement in SNR =  $10 \log K$   
 $(\Delta \text{SNR})$

$$K=4, \Delta \text{SNR} = 10 \log 4 = 6.02 \text{ dB}$$

1-bit ADC  $\xrightarrow{K=4}$  2-bit ADC

1-bit ADC  $\xrightarrow[m=15]{K=4^m}$  16-bit ADC

$$K=4^m, \Delta \text{SNR} = 10 \log 4^m = 6.02 m \text{ dB, for } m \text{-bit } \uparrow$$

$$\therefore K = 4^{15} = 2^{30}$$

↓ extremely large  
oversampling factor

Not practical

Further improvement: Noise Shaping  $\Rightarrow$  HPF to noise  
 very low noise floor  
 in desired region.

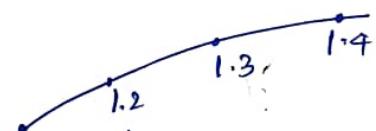
LPF to signal,  
 HPF to noise } circuit  
 SNR"

(29-08-2025)

### 2-bit ADC

X	D1	D0	
(-1, -0.5)	0	0	1/4
(-0.5, 0)	0	1	2/4
(0, 0.5)	1	0	3/4
(0.5, 1)	1	1	4/4

Represented  
using ana.  
(coded)



### 3-bit ADC

X	D2	D1	D0	
(-1, -0.75)	0	0	0	1/8
(-0.75, -0.5)	0	0	1	2/8
(-0.5, -0.25)	0	1	0	3/8
(-0.25, 0)	0	1	1	4/8
(0, 0.25)	1	0	0	5/8
(0.25, 0.5)	1	0	1	6/8 $\rightarrow \checkmark$
(0.5, 0.75)	1	1	0	7/8
(0.75, 1)	1	1	1	8/8

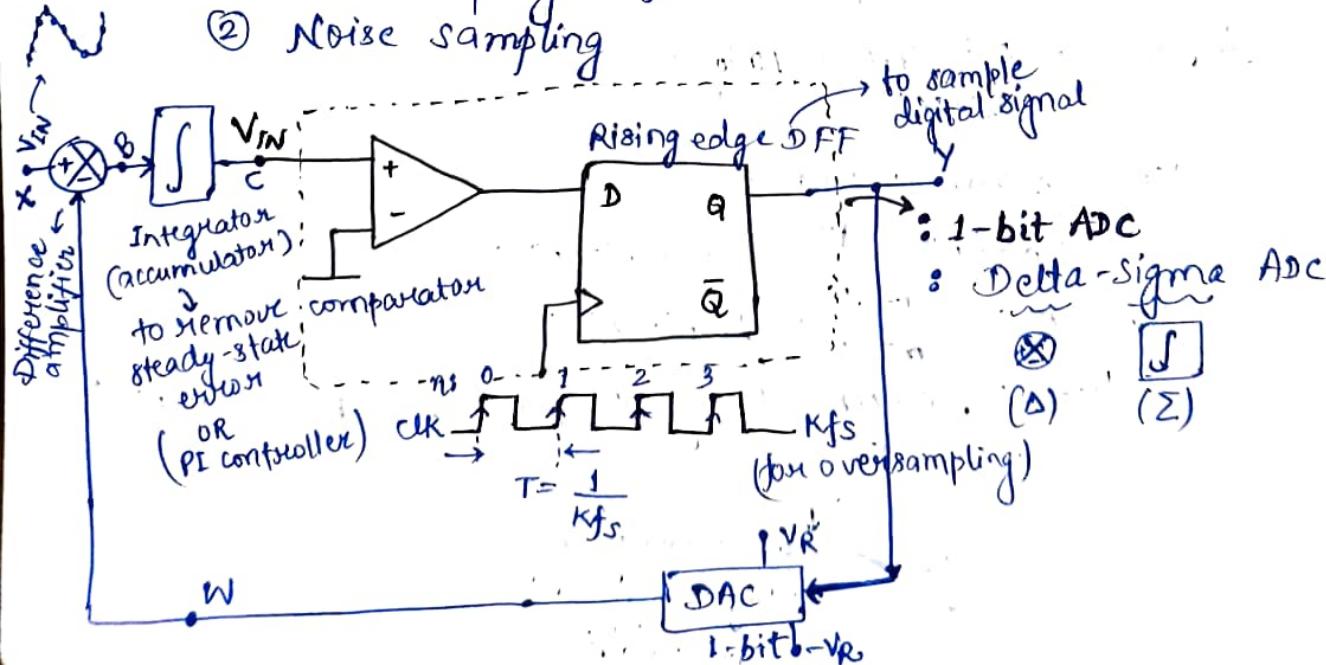
mapping no/  
fraction

To save the signal space, we send the difference between values rather than individual samples.

### Sigma-Delta ADC :

① OverSampling ( $K_{fs}$ )

② Noise Sampling



$$X \in (-V_R, V_R)$$

$\hookrightarrow$  ref voltages of ADC  
(also for DAC)

$$\begin{cases} V_R = 1 \\ X \in (-1, 1) \end{cases}$$

n: sampling instance  
stored in capacitors in  $\boxed{S}$

$$C_n = C_{n-1} + B_n$$

$$Y_n = \begin{cases} \text{logic-high (1); } C_n \geq 0 & \text{may not be the case} \\ \text{logic-low (0); } C_n < 0 \end{cases}$$

$$W_n = \begin{cases} V_R; Y_n = 1 \\ -V_R; Y_n = 0 \end{cases}$$

$$B_n = X_n - W_{n-1}$$

$= X - W_{n-1}$ ;  $X$  should be constant for atleast few clock cycles.

$$\text{Reset: } C_0 = 0 \\ W_0 = 0.$$

$$B_1 = X - W_0 = X$$

$$C_1 = C_0 + B_1 = X$$

clock cycles -  $C_2 = C_1 + B_2$

$n$	$X$	$B$	$C$	$Y$	$W(V)$
1	$3/8$	$3/8$	$3/8$	1	+
2	$3/8$	$-5/8$	$-2/8$	0	-1
3	$3/8$	$11/8$	$9/8$	1	1
4	$3/8$	$-5/8$	$4/8$	1	1

i/p should be constant for 4 clk cycles  $\rightarrow$  can be assumed to be constant for a small interval of time (for 2-bit ADC)

2-bit ADC

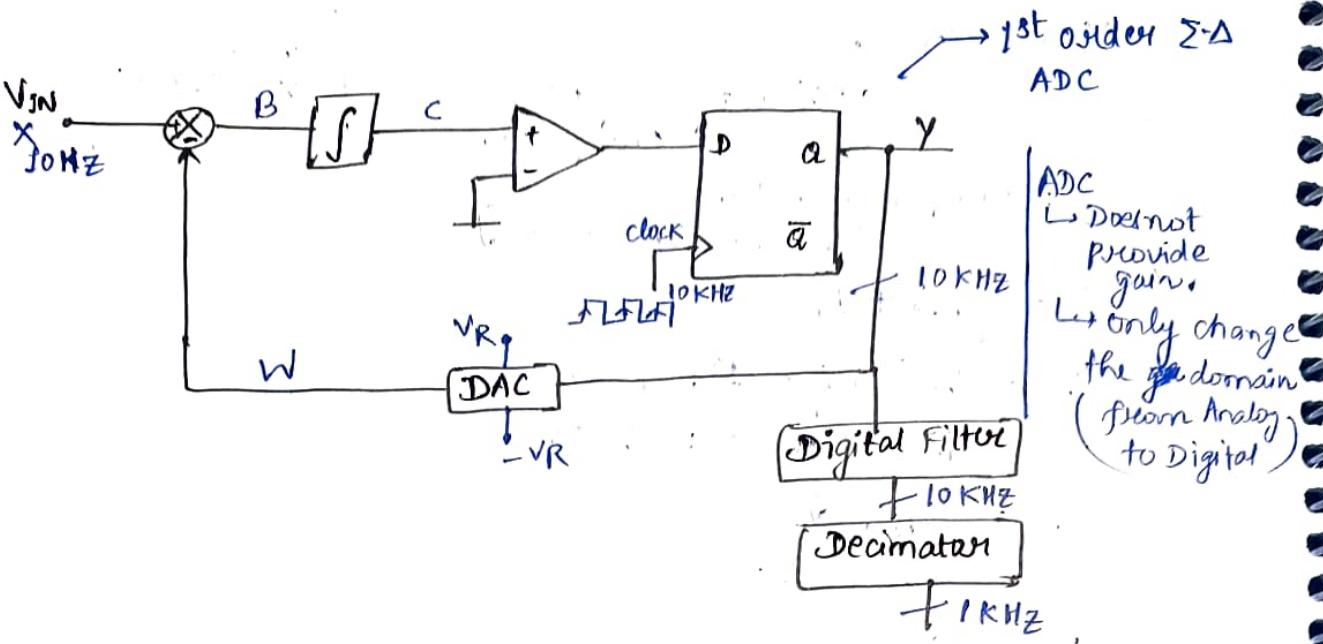
3-bit ADC

5	$3/8$	$-5/8$	$-1/8$	0	-1
6	$3/8$	$11/8$	$10/8$	1	1
7	$3/8$	$-5/8$	$5/8$	1	1
8	$3/8$	$-5/8$	0	0	1

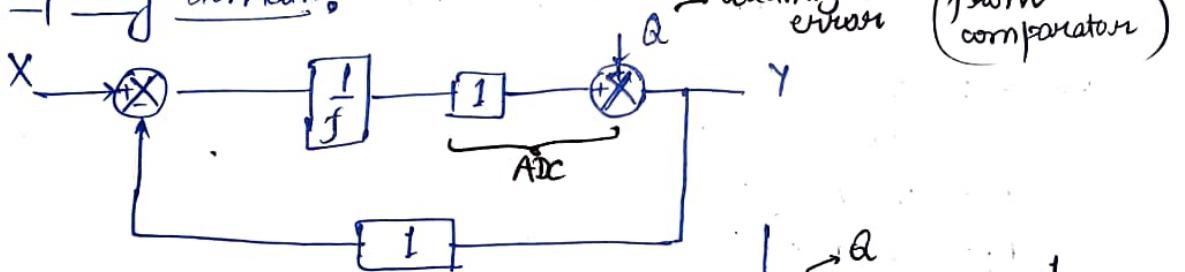
$\sum B = 0$   $\downarrow$  s.s. error  $\rightarrow 0 \Rightarrow X = \bar{W}$

due to offset voltage of comparator

For n-bit  $\Sigma-\Delta$  ADC, i/p should be constant for  $2^n$  clk cycles.



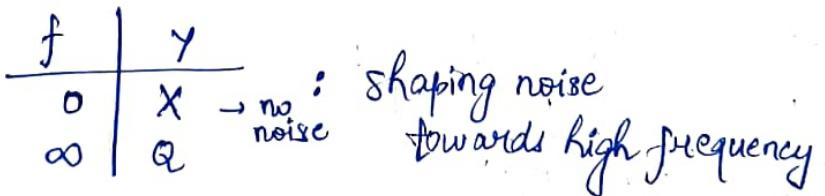
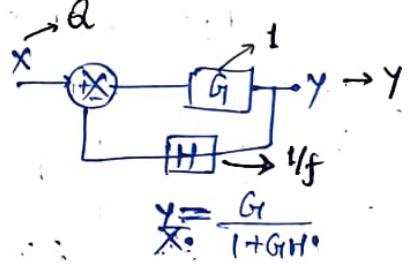
In frequency domain:



$$Y = \frac{X \cdot \frac{1}{f}}{1 + \frac{1}{f}} + \frac{Q \cdot 1}{1 + \frac{1}{f}}$$

$$\therefore Y = \frac{X}{f+1} + \frac{Qf}{f+1} \quad \because \text{Noise shaping}$$

LPF to X      HPF to noise

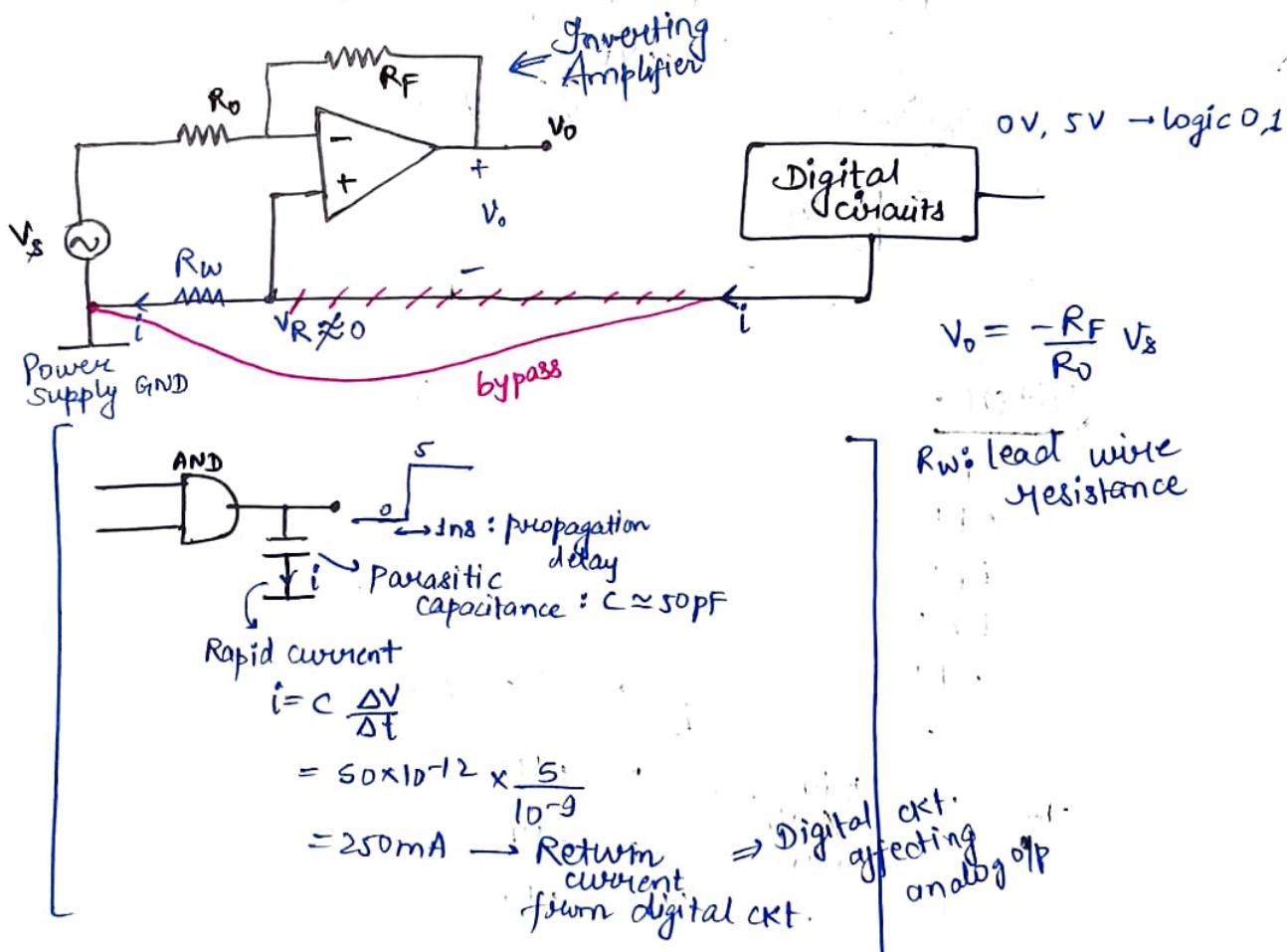
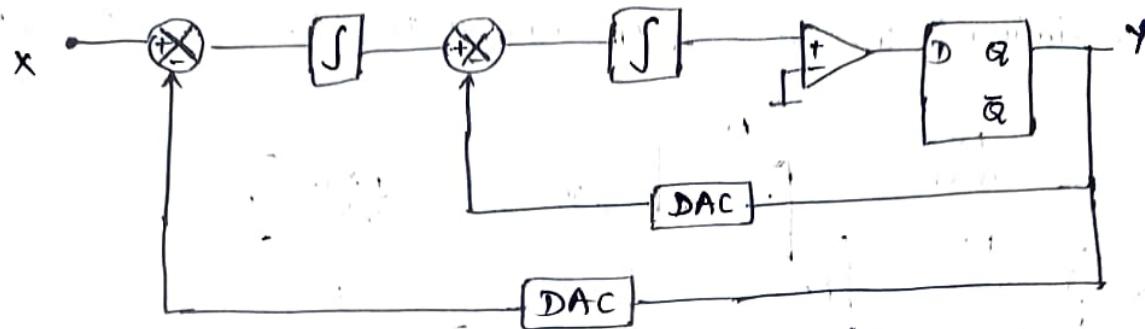


Oversampling factor, $K$	Improvement in SNR	
	without noise shaping	with noise shaping

4      6 dB

2      9 dB

## 2<sup>nd</sup> Order ADC ( $\Sigma-\Delta$ ):



$$R_W = 0.5 \Omega$$

$V_R = i R_W = 125 \text{ mV} \rightarrow \text{Return voltage} \rightarrow \text{large due to large } i.$   
 Suppose, if the bypass connection is not possible.

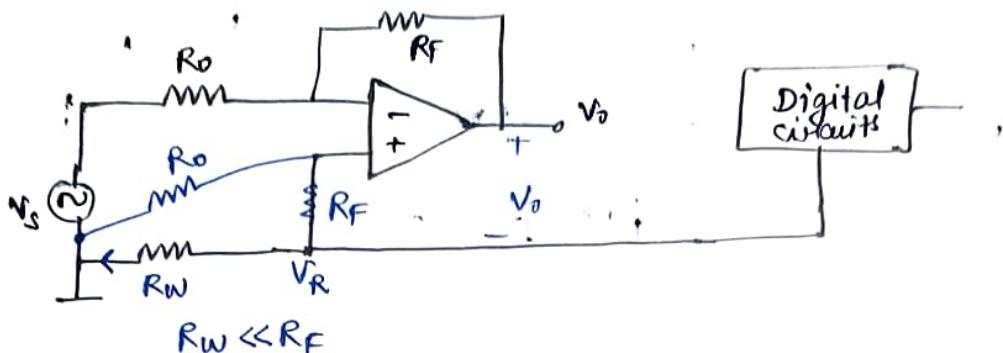
$$V_0 = -\frac{R_F}{R_0} V_S + V_R \left[ 1 + \frac{R_F}{R_0} \right] - V_R$$

superposition  
[convert to difference amplifier]

$\downarrow$   
 solution:  
 Bypass the  
 discharge current  
 directly to  
 ground.

$$\Rightarrow V_o = -\frac{R_F}{R_O} [V_S - V_R] \rightarrow \text{depends on } V_R$$

To eliminate the effect of  $V_R$ , add extra two resistors,  $R_O, R_F$ .



$$V_o = -\frac{R_F}{R_O} V_S + \frac{R_O}{R_O + R_F} V_R \left( 1 + \frac{R_F}{R_O} \right) - V_R$$

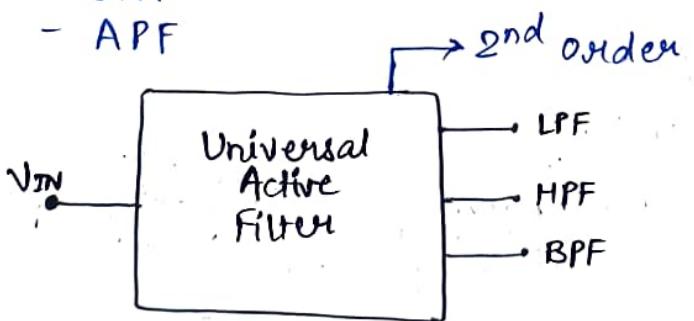
Using  $V_R = V_+ = 0$

Using  $V_S = 0$

$$\therefore V_o = -\frac{R_F}{R_O} V_S$$

## filters

- LPF
- HPF
- BPF
- BRF
- APF



↳ Ensure that we use  
minm no. of opamps.

## Universal Active Filters (UAF)

$$\text{LPF: } H(s) = \frac{K w_n^2}{s^2 + 2\xi w_n s + w_n^2}$$

$$\text{HPF: } H(s) = \frac{K s^2}{s^2 + 2\xi w_n s + w_n^2}$$

$$\text{BPF: } H(s) = \frac{K(2\xi w_0 s)}{s^2 + 2\xi w_0 s + w_0^2} \rightarrow \text{Usually } w_0 \text{ is used instead of } w_n.$$

Quality Factor ( $Q$ ):  $Q = \frac{1}{2\xi}$

$$\Rightarrow \text{BPF: } H(s) = \frac{K \frac{w_0}{Q} s}{s^2 + \frac{w_0}{Q} s + w_0^2}$$

$$\text{BRF: } H(s) = \frac{K [s^2 + w_0^2]}{s^2 + \frac{w_0}{Q} s + w_0^2}$$

$$\text{APF: } H(s) = \frac{K [s^2 - \frac{w_0}{Q} s + w_0^2]}{s^2 + \frac{w_0}{Q} s + w_0^2}$$

$$|H(j\omega)| = K$$

$$\angle H(j\omega) \rightarrow \text{finite}$$

LPF:

$$H(s) = \frac{K w_n^2}{s^2 + 2\xi w_n s + w_n^2} = \frac{V_o(s)}{V_{IN}(s)}$$

$$\Rightarrow s^2 V_o(s) + 2\xi w_n s V_o(s) + w_n^2 V_o(s) = K w_n^2 V_{IN}(s)$$

$$\text{ILT} \Rightarrow \ddot{V}_o + 2\xi w_n \dot{V}_o + w_n^2 V_o = K w_n^2 V_{IN}$$

$$\ddot{V}_o = -2\xi w_n \dot{V}_o + K w_n^2 V_{IN} - w_n^2 V_o$$

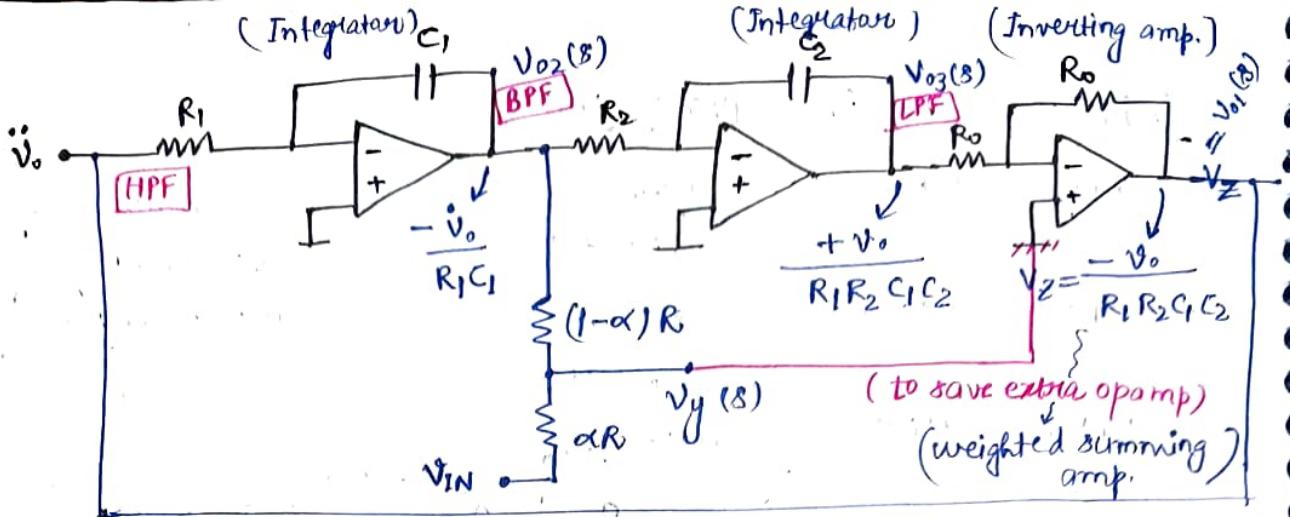
Build a circuit that obey this governing equation.

$w_n$ : natural frequency

$\xi$ : damping ratio

$K$ : band-pass gain

$w_0$ : center frequency



$$V_{y1}(s) = (1-\alpha)V_{IN} - \frac{V_o \alpha}{R_1 C_1} \quad (\text{By superposition of voltage divider})$$

$$V_z = -\frac{V_o}{R_1 R_2 C_1 C_2} + 2V_y$$

$$\Rightarrow V_z = -\frac{V_o}{R_1 R_2 C_1 C_2} + 2(1-\alpha)V_{IN} - \frac{2\alpha}{R_1 C_1} \ddot{V}_o = \ddot{V}_o$$

[Connect  $\ddot{V}_o(s)$  to  $V_z(s)$ ]

$$\Rightarrow \ddot{V}_o + \frac{2\alpha}{R_1 C_1} \ddot{V}_o + \frac{V_o}{R_1 C_1 R_2 C_2} = 2(1-\alpha)V_{IN} \quad [\text{Mimic the differential eqn}]$$

$$V_{o2}(s) = -\frac{1}{s R_1 C_1} V_{o1}(s)$$

$$V_{o3}(s) = -\frac{1}{s R_2 C_2} V_{o2}(s)$$

$$= -\frac{1}{s^2 R_1 R_2 C_1 C_2} V_{o1}(s)$$

$$V_y(s) = (1-\alpha)V_{IN}(s) + \alpha V_{o2}(s)$$

$$V_{y1}(s) [= V_{y2}(s)] = -V_{o3}(s) + 2V_y(s)$$

$$\Rightarrow V_{o1}(s) = \frac{V_{o1}(s)}{s^2 R_1 R_2 C_1 C_2} + 2(1-\alpha)V_{IN}(s) - \frac{2\alpha V_{o1}(s)}{s R_1 C_1}$$

$$\Rightarrow V_{o1}(s) \left[ 1 + \frac{2\alpha}{s R_1 C_1} - \frac{1}{s^2 R_1 R_2 C_1 C_2} \right] = 2(1-\alpha)V_{IN}(s)$$

$$\Rightarrow V_{o1}(s) \left[ \frac{s^2 R_1 R_2 C_1 C_2 + 2\alpha R_2 C_2 s - 1}{s^2 R_1 R_2 C_1 C_2} \right] = 2(1-\alpha)V_{IN}(s)$$

$$\Rightarrow \frac{V_{01}}{V_{IN}}(s) = \frac{\frac{2(1-\alpha)s^2}{s^2 + \frac{2\alpha s}{R_1 C_1} + \frac{1}{R_1 R_2 C_1 C_2}}}{: \text{HPF}}$$

Comparing with  $\frac{\kappa s^2}{s^2 + 2\xi\omega_n s + \omega_n^2}$ ,

$$\omega_n = \frac{1}{\sqrt{R_1 R_2 C_1 C_2}},$$

$$2\xi\omega_n = \frac{2\alpha}{R_1 C_1} \Rightarrow \xi = \alpha \sqrt{\frac{R_2 C_2}{R_1 C_1}},$$

$$\kappa = 2(1-\alpha).$$

At  $s = j\omega_0$ ,

$$\frac{V_{02}}{V_{IN}}(s) = \frac{-2(1-\alpha) \frac{s}{R_1 C_1}}{s^2 + \frac{2\alpha s}{R_1 C_1} + \frac{1}{R_1 R_2 C_1 C_2}} : \text{BPF}$$

$$\frac{V_{03}}{V_{IN}}(s) = \frac{2(1-\alpha) \frac{1}{R_1 R_2 C_1 C_2}}{s^2 + \frac{2\alpha s}{R_1 C_1} + \frac{1}{R_1 R_2 C_1 C_2}} : \text{LPF}$$

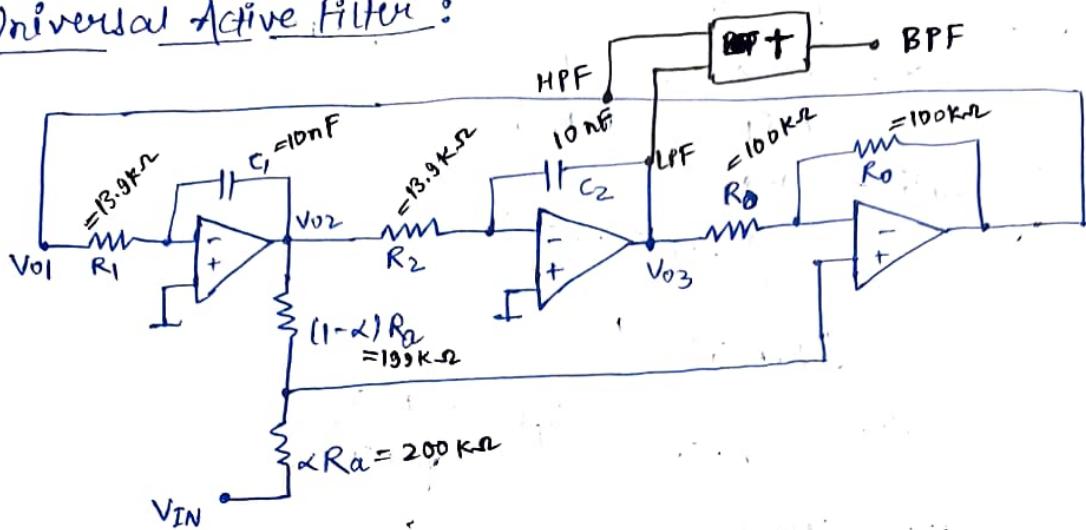
BPF: Comparing with  $\frac{\kappa \left[ \frac{\omega_0}{Q} \right] s}{s^2 + \frac{\omega_0 s}{Q} + \omega_0^2}$ ,

$$\omega_0 = \frac{1}{\sqrt{R_1 R_2 C_1 C_2}},$$

$$\frac{\omega_0}{Q} = \frac{2\alpha}{R_1 C_1} \Rightarrow Q = \frac{1}{2\alpha} \sqrt{\frac{R_1 C_1}{R_2 C_2}},$$

$$\kappa \left( \frac{\omega_0}{Q} \right) = \kappa \left( \frac{2\alpha}{R_1 C_1} \right) = 2(1-\alpha) \frac{1}{R_1 C_1},$$

$$\Rightarrow \kappa = \frac{1-\alpha}{\alpha} = \frac{1}{\alpha} - 1$$

Universal Active Filter:

Eg. Design a BPF with center frequency of 1 kHz and Bandwidth of 10 Hz.

$$\frac{V_{O2}(s)}{V_{IN}} = \frac{\kappa \omega_0 / Q}{s^2 + \frac{\omega_0 s}{Q} + \omega_0^2} = \frac{2(1-\alpha) \cdot \frac{s}{(R_1 C_1)}}{s^2 + \frac{2\alpha s}{R_1 C_1} + \frac{1}{R_1 R_2 C_1 C_2}}$$

$$\omega_0 = \frac{1}{\sqrt{R_1 R_2 C_1 C_2}} ; Q = \frac{1}{2\alpha} \sqrt{\frac{R_1 C_1}{R_2 C_2}} = 100.$$

$$f_0 = 1000 \text{ Hz}$$

$$3W = 10 \text{ Hz} = f_0/Q$$

$$Q = 100$$

$$f_0 = \frac{1}{2\pi\sqrt{R_1 R_2 C_1 C_2}} = 1000$$

$$= \frac{1}{2\pi R C} = 1000$$

$$\text{Take } C = 10 \text{ nF} ;$$

$$\Rightarrow R = 13.9 \text{ k}\Omega$$

$$\kappa = \frac{1}{\alpha} - 1$$

$$\Rightarrow \kappa = 199 \rightarrow 20 \log 199 \approx 46 \text{ dB}$$

$$\text{Take } R_1 = R_2 = R$$

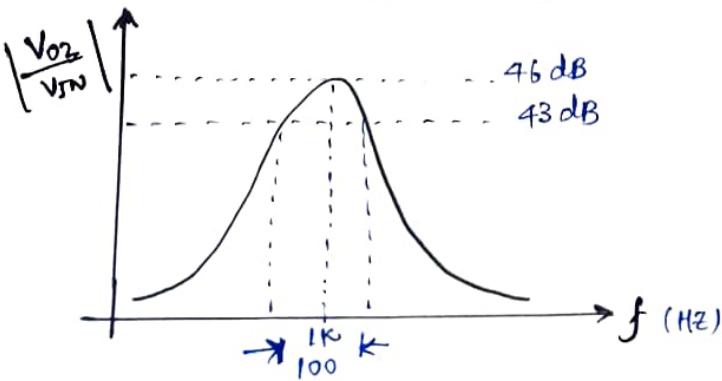
$$C_1 = C_2 = C$$

$$\Rightarrow \frac{1}{2\alpha} = 100 \Rightarrow \alpha = \frac{1}{200}$$

$$\text{Take } R_a = 200 \text{ k}\Omega$$

$$\Rightarrow \alpha R_a = 1 \text{ k}\Omega$$

$$(1-\alpha)R_a = 199 \text{ k}\Omega$$



Design for  $K = 40 \text{ dB} \Rightarrow K = 100$

$$K = \frac{1}{\alpha} - 1 = 100$$

$$\Rightarrow \alpha = \frac{1}{101}$$

$$\downarrow \text{Substitute in } Q = \frac{1}{2\alpha} \sqrt{\frac{R_1 C_1}{R_2 C_2}}$$

$$\hookrightarrow \text{May not get } R_1 = R_2 = R, \\ C_1 = C_2 = C$$

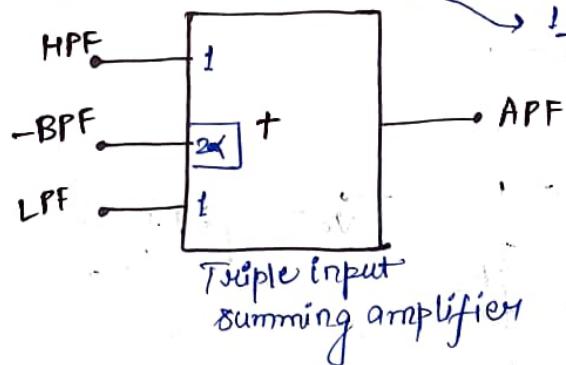
IC: UAF42

$\hookrightarrow$  Realizes this topology

$$\text{BRF: } H(s) = \frac{K \left[ s^2 + \omega_0^2 \right]}{s^2 + \frac{\omega_0}{Q} s + \omega_0^2} = \text{HPF} + \text{LPF}$$

$$\text{APF: } H(s) = \frac{K \left[ s^2 - \frac{\omega_0}{Q} s + \omega_0^2 \right]}{s^2 + \frac{\omega_0}{Q} s + \omega_0^2}$$

$$= \text{HPF} - \text{BPF} + \text{LPF}$$



$$\frac{1-\alpha}{\alpha} \times 2\alpha \\ = 2(1-\alpha)$$

$$\text{HPF} + \text{BPF} + \text{LPF} = 1$$

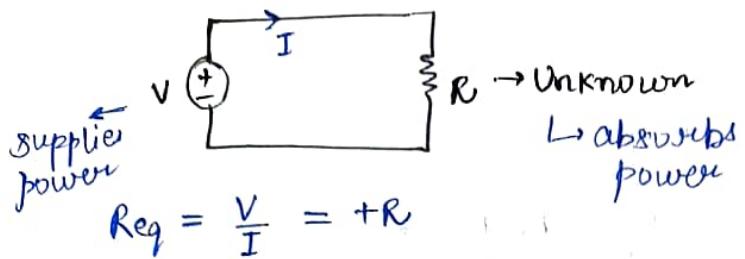
$$\Rightarrow \text{HPF} + \text{LPF} = 1 - \text{BPF}$$

$$\therefore \text{APF} = 1 - 2\text{BPF}$$

$$\Rightarrow \frac{V_{\text{APF}}}{V_{IN}} = 1 - 2 \frac{V_{\text{BPF}}}{V_{IN}}$$

$$\Rightarrow V_{\text{APF}} = V_{IN} - 2 V_{\text{BPF}} \rightarrow 2 \text{i/p summing amp. required}$$

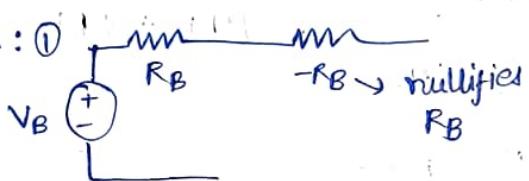
## Impedance Transformation Circuits



Negative Resistance: Delivers power ; source absorbs power.

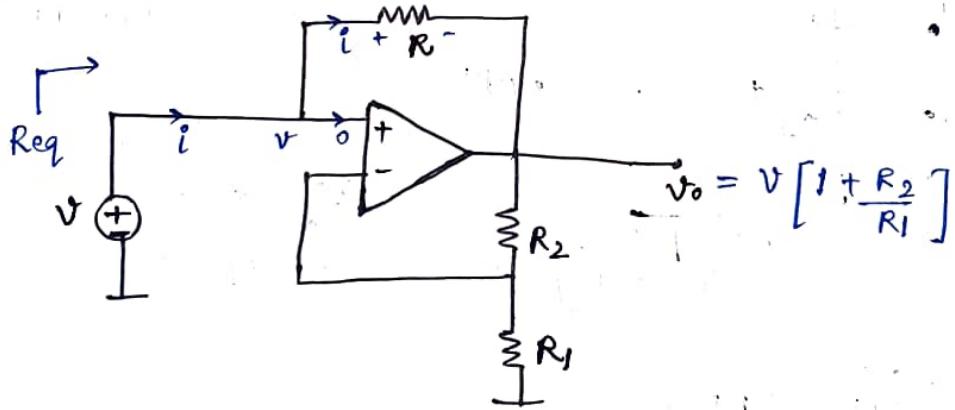
$$R_{eq} = -R$$

Applications:



② To change the damping ratio.

Negative Resistance Generator circuit:



$$iR = V - v_o$$

$$iR = -\frac{VR_2}{R_1} \Rightarrow \frac{V}{i} = -R \frac{R_1}{R_2}$$

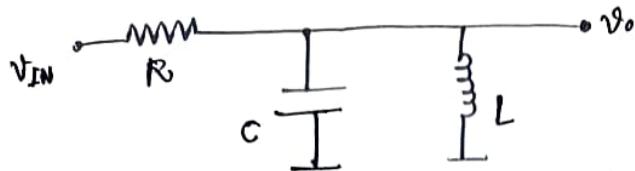
Equivalent impedance from source,

$$Req = \frac{V}{i} = -R \frac{R_1}{R_2}$$

→ Negative Resistance  
↳ Delivers power to the source.

↳ Negative Resistance circuit /  
Impedance Transformation circuit.

$L \longleftrightarrow C$



At  $\omega = \omega_0 = \frac{1}{\sqrt{LC}}$   $\rightarrow$  Parallel Resonance  
 $\hookrightarrow$  very high resistance  
 $\hookrightarrow V_O = V_{IN}$

$\omega \neq \omega_0 \Rightarrow V_O = 0$ .

$\hookrightarrow$  cannot be initialized.

$\hookrightarrow$  Mimic  $L$  using  $C$ , opamp, resistor.  
 (differential eqn of inductor)

08-09-2025

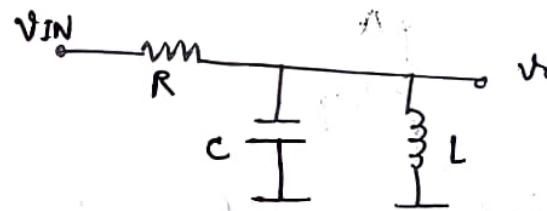
Explain

### Impedance Transformation Circuits.

$\rightarrow$  Negative Resistance Generator

$\rightarrow$  Inductance Simulator

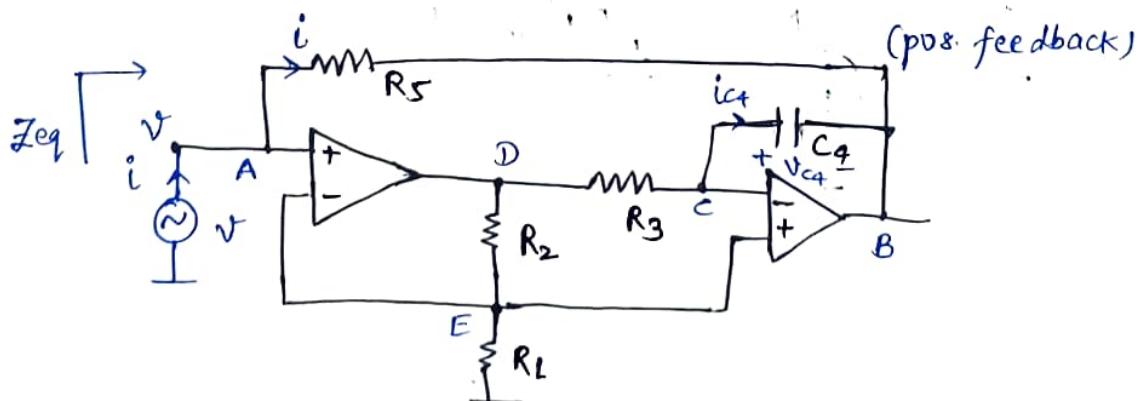
$\rightarrow$  GIC



$$\frac{V_O}{V_{IN}} = \frac{\omega_0 / Q}{\omega^2 + \omega_0^2 / Q^2 + \omega_0^2}$$

$$\omega_0 = \frac{1}{\sqrt{LC}}$$

$$Q = R \sqrt{\frac{C}{L}}$$



$$V_A = V_E = V_C = V$$

$$V_D = V \left[ 1 + \frac{R_2}{R_1} \right]$$

$$V_{DC} = V \frac{R_2}{R_1} \quad (= V_{DE} = V_D - V_E)$$

$$i_{C4} = \frac{V R_2 / R_1}{R_3} = \frac{V R_2}{R_1 R_3}$$

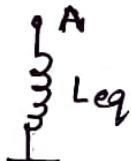
$$\begin{aligned} V_{C4} &= \frac{1}{C_4} \int i_{C4} dt \\ &= \frac{1}{C_4} \frac{R_2}{R_1 R_3} \int V dt \end{aligned}$$

$$i_{R_5} = V_C - V_B = V_{C4}$$

$$= \frac{R_2}{R_1 R_3 C_4} \int V dt$$

$$\Rightarrow V = \left( \frac{R_1 R_3 R_5 C_4}{R_2} \right) \frac{di}{dt}$$

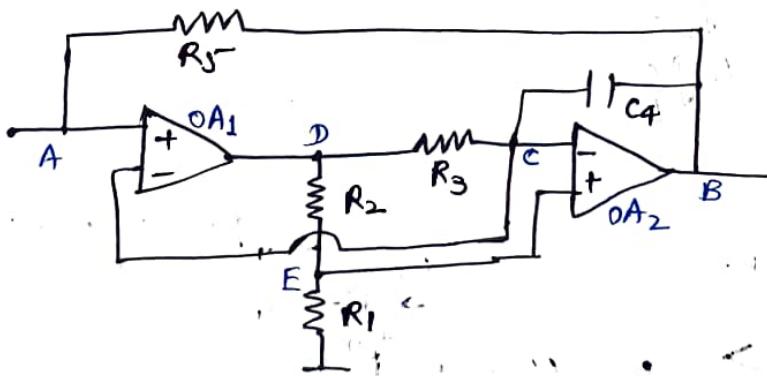
$$\therefore V = L_{eq} \frac{di}{dt}$$



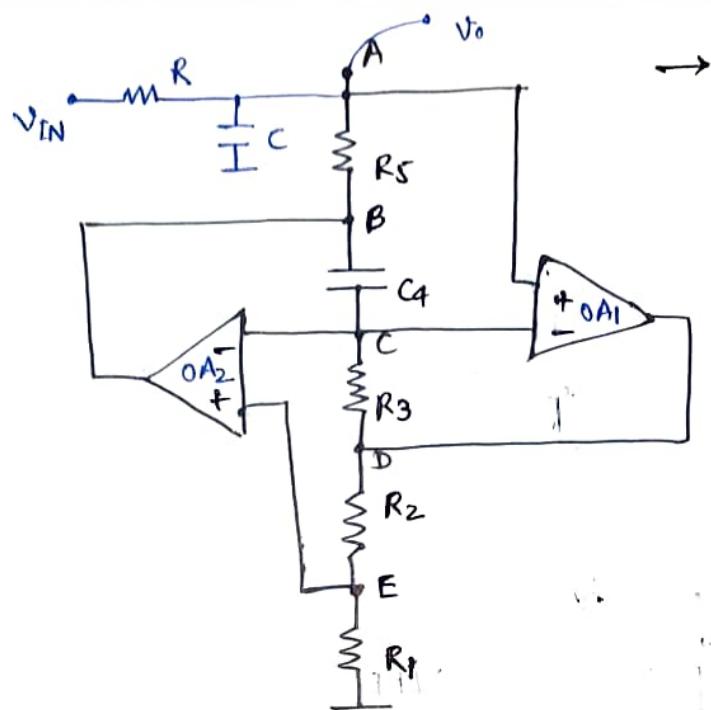
↳ Can be miniaturized (opamp, capacitor, resistor).

↳ Mimics grounded inductance.

### Modified circuit :



$$V_A = V_E = V_C = V$$



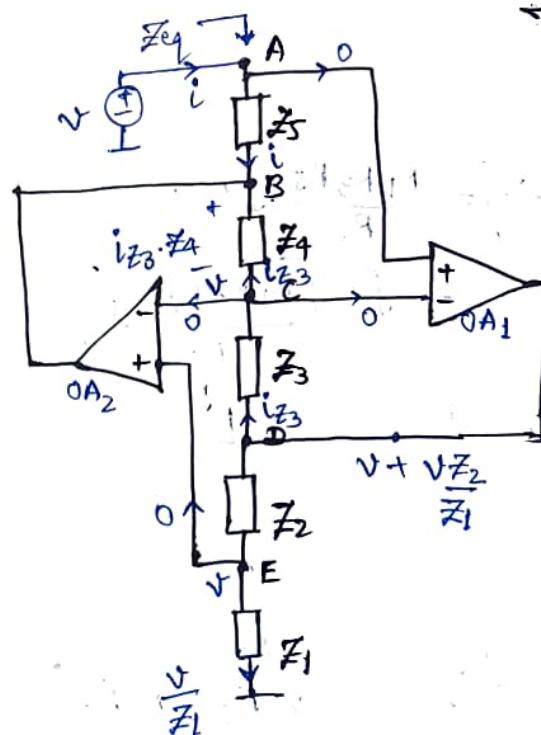
→ Easier way of  
Representation

$$\omega_0 = \frac{1}{\sqrt{\text{Leg C}}}$$

$$Q = R \sqrt{\frac{C}{L_{eq}}}$$

→ Not for discrete elements.

→ For VLSI  
miniaturization



$\leftrightarrow$  Generalized Impedance Converter (GIC)

$$i_{Z_3} = \frac{V_D - V_C}{Z_3} = \frac{V_Z}{Z_1 Z_3}$$

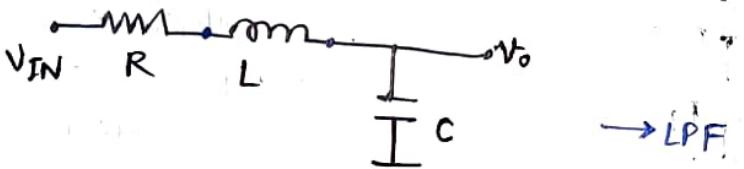
$$v_B = v - i_{z_3, z_4}$$

$$= v - v \frac{z_2 z_4}{z_1 z_3}$$

$$i = \frac{V_N - V_B}{Z_5}$$

$$\frac{V}{I} = \frac{Z_1 Z_3 Z_5}{Z_2 Z_4}$$

$$Z_{eq} = \frac{Z_1 Z_3 Z_5}{Z_2 Z_4}$$



Mimic the inductor  
to create inductor free LPF, using GIC.

09-09-2025

### Inductance Simulator:

$$Z_5 = R_5$$

$$Z_4 = 1/j\omega C_4$$

GIC  
with

$$Z_3 = R_3$$

$$Z_2 = R_2$$

$$Z_1 = R_1$$

$$\Rightarrow Z_{eq} = \frac{R_1 R_3 R_5}{R_2} j\omega C_4$$

$$= j\omega \left[ \frac{R_1 R_3 R_5 C_4}{R_2} \right]$$

$$\therefore Z_{eq}$$

With

$$Z_5 = 1/j\omega C_5$$

$$Z_4 = R_4$$

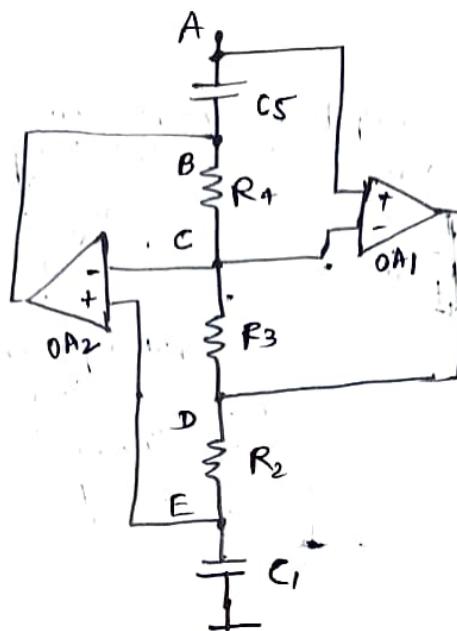
$$Z_3 = R_3$$

$$Z_2 = R_2$$

$$\Rightarrow Z_{eq} = - \frac{R_3}{\omega^2 C_1 C_5 R_2 R_4}$$

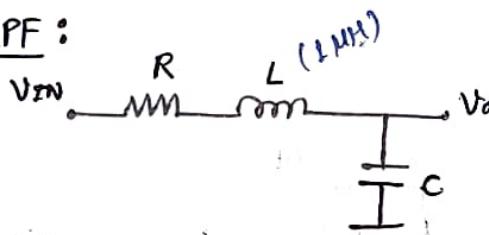
$$Z_1 = 1/j\omega C_1$$

↳ Frequency Dependent  
Negative Resistance  
(FDNR)



Application: Double integrator  $\left(\frac{1}{j\omega}\right)^2$

LPF :



$$\omega_n = \frac{1}{\sqrt{LC}}$$

$$\xi = \frac{R}{2} \sqrt{\frac{C}{L}}$$

$$\frac{V_o}{V_{IN}} = \frac{\frac{1}{j\omega C} \frac{1}{F}}{\frac{j\omega L + R}{F} + \frac{1}{j\omega C} \frac{1}{F}} ; \text{ choose } F = j\omega$$

$$= \frac{-\frac{1}{\omega^2 C}}{L + \frac{R}{j\omega} - \frac{1}{\omega^2 C}} \rightarrow \begin{array}{l} \text{can be modelled using FDNR} \\ \hookrightarrow \text{Replace capacitor by FDNR} \end{array}$$

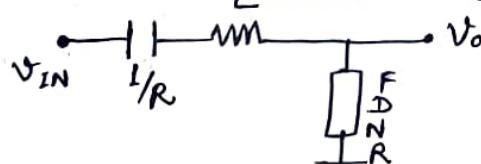
Replace by a resistor

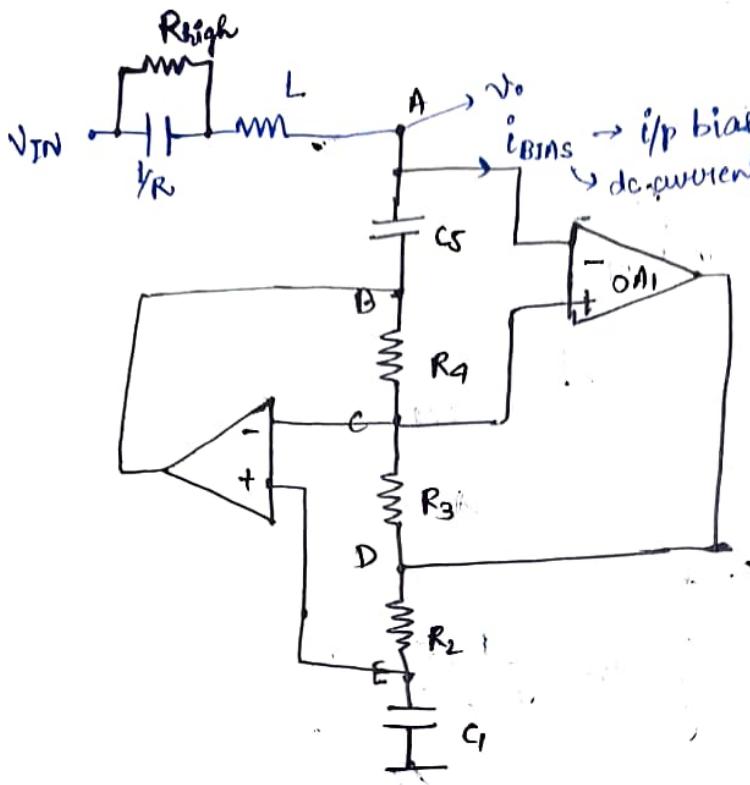
Replace by a capacitor

$L \rightarrow 10 \text{ k}\Omega$  (say)  $\rightarrow$  choose a/c to  $\omega_n, \xi$  requirement

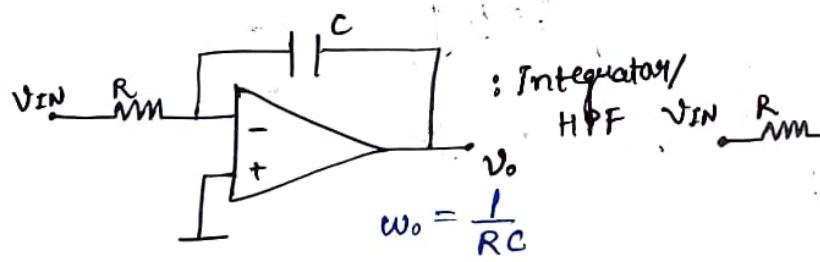
[Previous values of  $R, L, C$  may not be satisfied.]

$\leftarrow$  Modelling floating inductor.





Miniatrize the circuits:



$$V_o = -\frac{1}{RC} \int V_{IN} dt$$

$$\frac{V_o}{V_{IN}} = - \frac{1}{j\omega RC} = - \frac{1}{j\omega/w_0}$$

$$\omega = \omega_0 \Rightarrow \left| \frac{V_0}{V_{IN}} \right| = 1$$

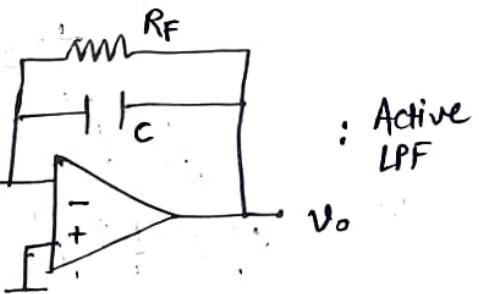
$\omega_0$ : Unity gain frequency

$$\omega_0 = 20\pi \text{ rad/s} = \frac{1}{RC}$$

For  $c = \inf$ ,

$$R = 15.9 \text{ M}_\odot$$

→ Cannot be implemented using MOS technology  
(can be max  $\sim 10 \text{ KHz}$ )



$$\frac{V_o}{V_{IN}} = \frac{-RF/R}{1 + j\omega R_F C}$$

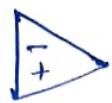
$$G_1 = -R_F/R$$

$$w_c = \frac{1}{RFC} \quad ; \text{ corner frequency}$$

$$= 2\pi \text{ rad/sec} \quad [10 \text{ Hz}]$$

For  $c = \inf$ ,

$$R = 15.9 \text{ M}_\odot$$



$\Rightarrow$  MOS



$\Rightarrow$  MOS capacitor



$\Rightarrow$  MOS triode  
( $< 10 \text{ k}\Omega$ )

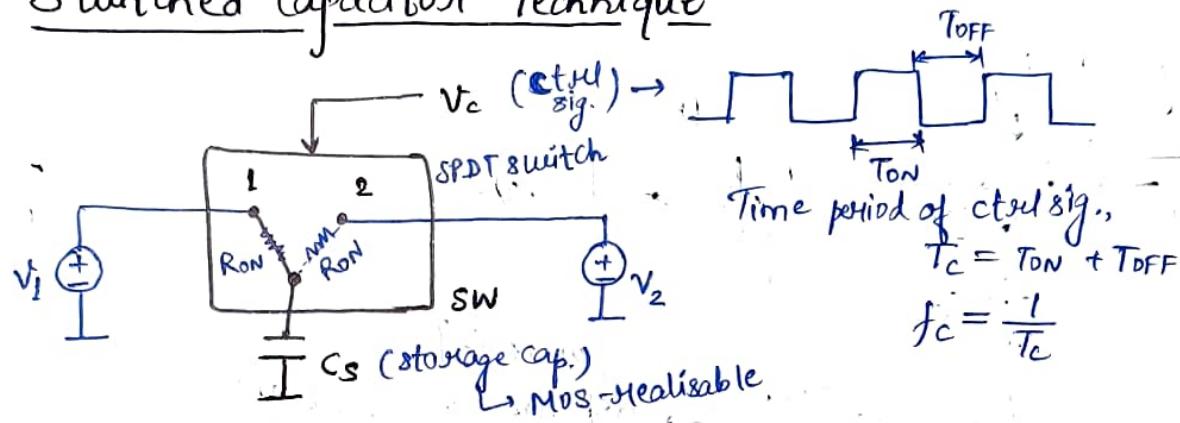


$\Rightarrow$  MDS

Switched capacitor exhibits resistive behaviour, and can be used to implement high value resistor.

12-09-2025

## Switched Capacitor Technique



$$t \in T_{ON}; SW \rightarrow 1, Q = C_S V_1$$

$$t \in T_{OFF}; SW \rightarrow 2, Q = C_S V_2$$

Differential charge:

$$\Delta Q = C_S (V_1 - V_2) \text{ every } T_c \text{ seconds.}$$

Average current flowing to the  $V_2$  side,

$$i = \frac{\Delta Q}{T_c} = \frac{C_S (V_1 - V_2)}{T_c}$$

$$\frac{V_1 - V_2}{i} = \frac{T_c}{C_S} = \left[ \frac{1}{f_c C_S} \right] = R_{eq}$$

Eqn. resistance b/w pts. 1 & 2

$V_1$  and  $V_2$  should be independent voltage sources (their voltages should not change due to capacitor charge).

$V_1$  and  $V_2 \rightarrow$  constant

Time constant associated with charging:

$$T = R_{ON} C_S$$

$$T_{ON} \geq 5T; T_{OFF} \geq 5T$$

$$\therefore T_C, \text{min} = 10\tau = 10 R_{ON} C_S$$

$$R_{ON} = \frac{T_C}{C_S} = \frac{10 \text{ ns}}{10 \text{ pF}} = 1 \text{ k}\Omega$$

$$R_{ON} = 100 \Omega$$

$$C_S = 10 \text{ pF}$$

$$\Rightarrow T_C, \text{min} = 10 \text{ ns}$$

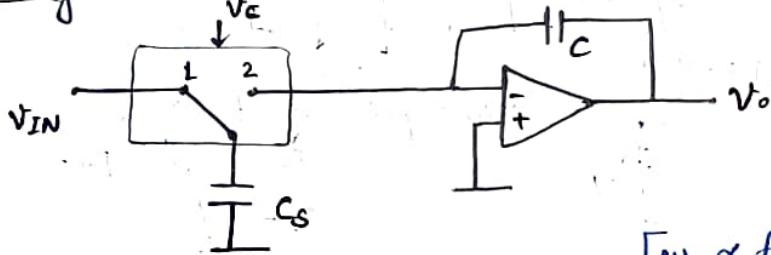
$\hookrightarrow$  I/p should remain constant for at least 10 ns.

$$\text{if } T_C = 10 \mu\text{s}$$

$$C_S = 10 \text{ pF}$$

$$\Rightarrow R_{eq} = 1 \text{ M}\Omega \rightarrow \text{A large resistance can be realised.}$$

### Integrator:



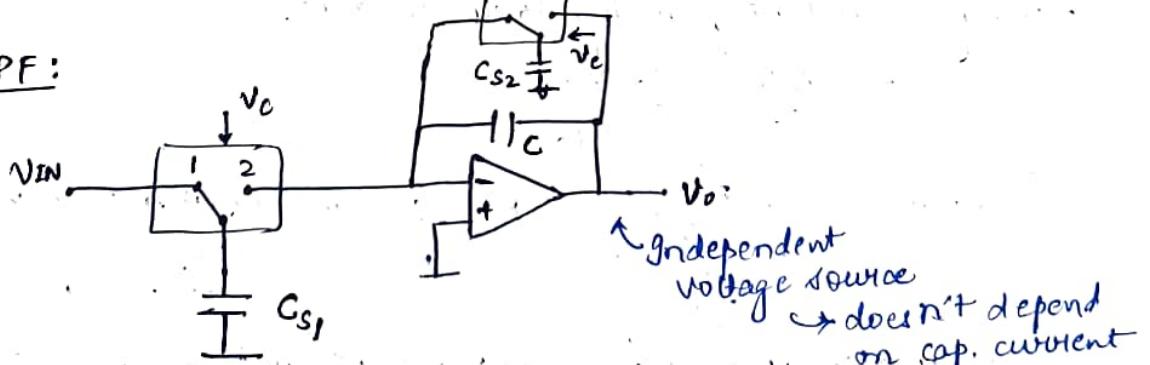
$$[\omega_0 \propto f_c]$$

$$\omega_0 = \frac{1}{R_{eq} C} = f_c \left( \frac{C_S}{C} \right) \rightarrow \text{depends on clock freq.} \rightarrow \text{stable & flexibly}$$

$C_S, C$  : MOS cap.  $\rightarrow$  Have temperature coefficient.

$$\frac{C_S (1 + \alpha T)}{C (1 + \alpha T)} \rightarrow \text{No effect of temp. coeff.}$$

### LPF:



independent voltage source  
 $\rightarrow$  doesn't depend on cap. current

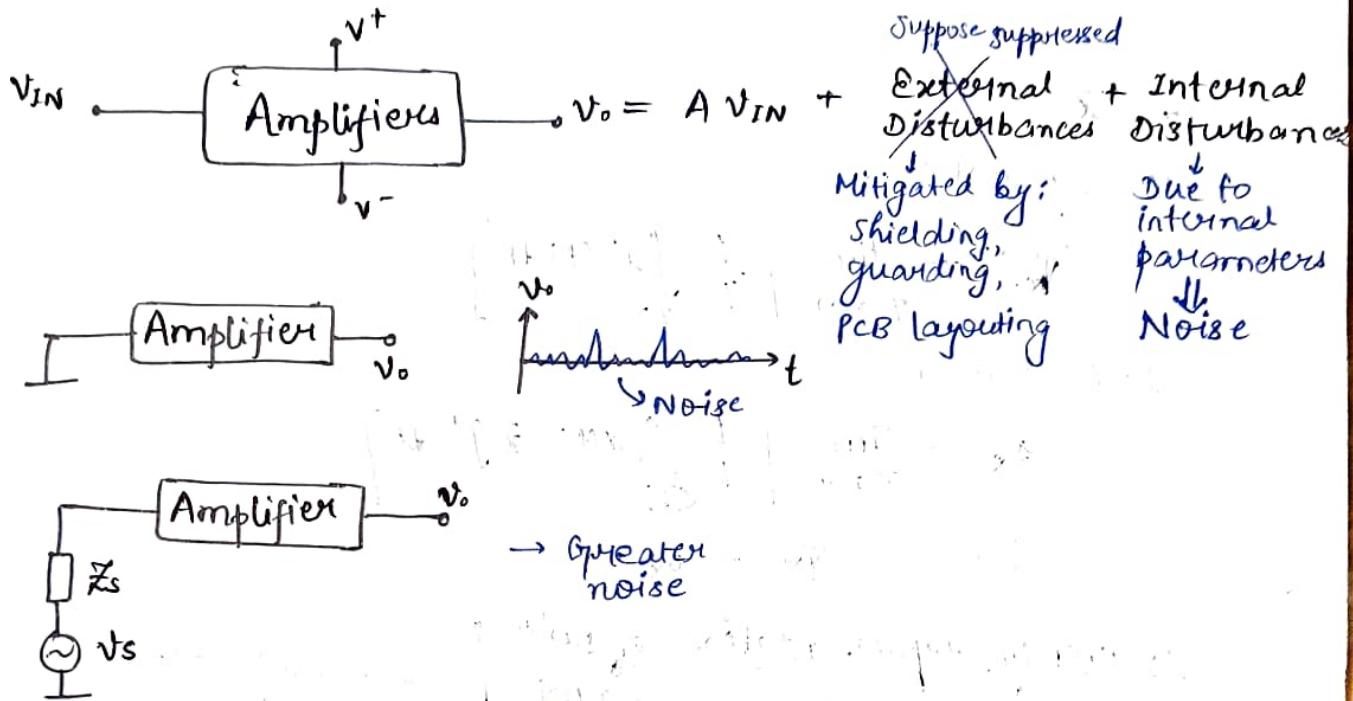
$$R_{eq1} = \frac{1}{f_c C_{S1}}$$

$$R_{eq2} = \frac{1}{f_c C_{S2}}$$

$$\text{Gain: } G = -\frac{R_{eq2}}{R_{eq1}} = -\frac{C_{S1}}{C_{S2}} \rightarrow \text{Accurate & Stable}$$

$$w_c = \frac{1}{R_{eq_2} C} = f_c \left( \frac{C_{S2}}{C} \right)$$

## NOISE



Noise → affects the resolution of the device.

Sensors  
Amplifiers  
ADC } Each have their own resolution → Design amplifiers such that the overall resolution is dominated by sensor or ADC.

15-09-2025

## Noise

- Fundamentals
- Types of electronic noise
- Noise Bandwidth (B)
- Noise analysis of passive circuits
- Noise model of opamps
- Noise analysis of opamp circuits
  - Resolution & SNR.

## Fundamentals

- Noise  $\rightarrow$  Random
- Zero mean, finite variance
- Gaussian
- $x(t) \rightarrow$  noise
- $\bar{x} = 0$

Noise power:

$$(\Psi^2) = \lim_{T \rightarrow \infty} \left[ \frac{1}{T} \int_{\langle T \rangle} x^2(t) dt \right]$$

Noise variance:

$$\sigma_x^2 = \lim_{T \rightarrow \infty} \left[ \frac{1}{T} \int_{\langle T \rangle} [x(t) - \bar{x}]^2 dt \right]$$

$$\bar{x} = 0 \Rightarrow \Psi_x^2 = \sigma_x^2$$

Frequency representation of noise:

$$PSD = \frac{\Psi^2(f, f + \Delta f)}{\Delta f}$$

Noise power from  $f$  to  $f + \Delta f$   
(in  $\Delta f$  band)

↳ Power  
spectral  
density of noise

PSD = constant  $\Rightarrow$  white noise

PSD ( $f$ )  $\Rightarrow$  Frequency-dependent noise.

White noise:

$$\begin{aligned} \Psi_x^2(f_1, f_2) &= PSD \times \Delta f \\ &= PSD(f_2 - f_1) \end{aligned}$$

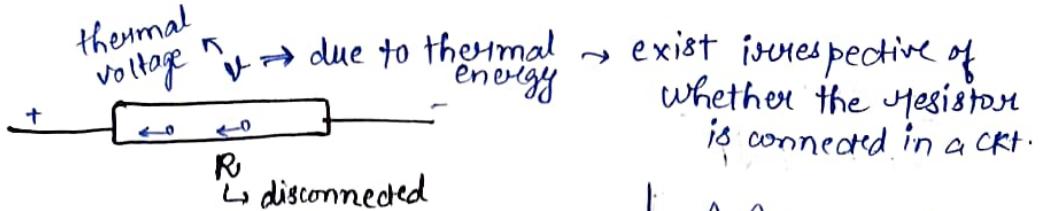
$$\Delta f = 100$$

Noise power in  $(100, 200) = (1000, 1100) = (10000, 10100)$

↳ Depends on freq. band and not its location.

$$\Psi_x^2(f_1, f_2) = \int_{f_1}^{f_2} PSD(f) df$$

Eg.



Thermal ~~noise~~ Noise : Johnson Nyquist

$$\text{noise power, } P_T = kTB$$

$k$ : Boltzmann's constant

$$= 1.38 \times 10^{-23} \text{ J/K}$$

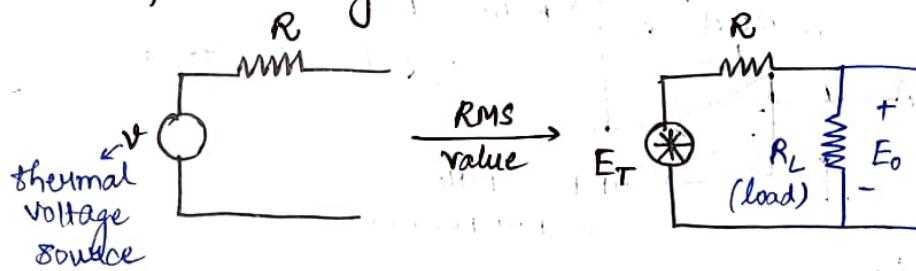
$T$ : absolute temperature

$B$ : noise bandwidth

For  $T = 298 \text{ K}$ ,  $B = 1 \text{ Hz}$ ,

$$P_T = 4.3 \times 10^{-21} \text{ W}$$

Model for a noisy resistor:



$$P_T = \left( \frac{E_0^2}{R_L} \right)_{\text{max}}$$

Max<sup>m</sup> power transfer occurs when

$$R_L = R$$

$$\Rightarrow E_0 = E_{T/2}$$

$$\therefore P_T = \frac{(E_{T/2})^2}{R}$$

Noise power,

$$E_T^2 = 4P_T R = 4kTB R \quad \dots \textcircled{1}$$

$$\text{RMS value, } E_T = \sqrt{4kTB R}$$

$$\text{PSD}_T = \frac{E_T^2}{B} = 4kTR \quad \rightarrow \text{unit: } \frac{V^2}{Hz}$$

Noise voltage density :

$$e_T = \sqrt{\text{PSD}_T}$$

$$= \sqrt{4kTR} \quad \rightarrow \text{unit: } \frac{V}{\sqrt{Hz}}$$

... \textcircled{2}

from ① and ②,

$$E_T = e_T \sqrt{B}$$

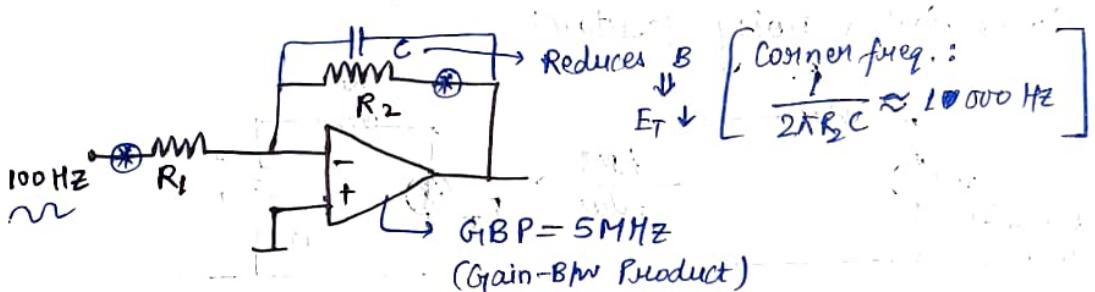
For  $R = 1\text{ k}\Omega$ ,  $B = 1\text{ Hz}$ ,  $T = 298\text{ K}$ ,

$$E_T = \sqrt{4 \times 4.1 \times 10^{-21} \times 10^3} = 4\text{ nV} \rightarrow \text{crucial for high precision applications}$$

$E_T \downarrow \Rightarrow R \downarrow, T \downarrow, B \downarrow$

$\downarrow$   
Liquid  $N_2 \Rightarrow -196^\circ\text{C} = 77\text{ K}$   
around  
electronics,  $E_T = 2\text{ nV}$

Liquid  $He \Rightarrow 4\text{ K}$



$$\frac{R_2}{R_1} = 5$$

closed-loop bandwidth

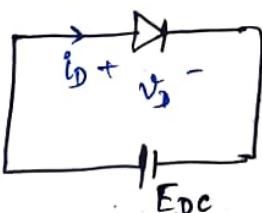
$$= \frac{5 \text{ MHz}}{5}$$

$$= 1 \text{ MHz}$$

↳ Reduce operating BW,

by connecting a capacitor.

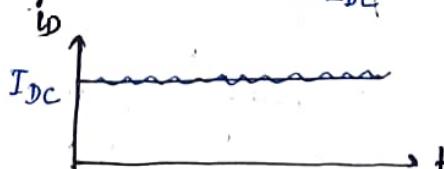
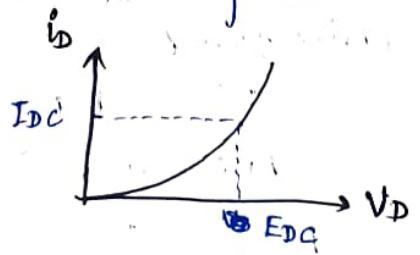
Shot Noise: observed in diodes when powered.



$$i_D = I_{DC}$$

$$+ i_{SH}(t)$$

↳ shot/noise current



↳ Noise occurs only when the device is powered ON.  
↳ shot noise

Thermal Noise:

$$v_T = \sqrt{4kTR}$$

$$e_T = \sqrt{PSD_T}$$

$$E_T^2 = e_T^2 B \xrightarrow{\text{Noise B/W}}$$

white :  $PSD_T = 4k\sigma TR$

Shot Noise:

$$i_D = I_{DC} + i_{SH}(t) \quad \xrightarrow{\text{Instantaneous}}$$

$$I_{SH}^2 = 2q I_{DC} B : \text{square of RMS} \quad [q = 1.6 \times 10^{-19} C] \quad \textcircled{1}$$

$\hookrightarrow$  Noise power

$$PSD_{SH} = \frac{I_{SH}^2}{B} = 2q I_{DC} \rightarrow \text{constant for a given excitation}$$

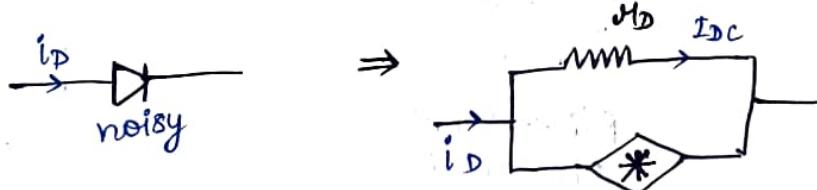
$\hookrightarrow$  white noise

Current Noise Density:

$$i_{SH} = \sqrt{PSD_{SH}} = \sqrt{2q I_{DC}} \quad \textcircled{2}$$

$$I_{SH}^2 = i_{SH}^2 \cdot B$$

#



: Noise Model of a Diode

$i_{SH}, i_{SH}$   
→ parallel, to provide a  
 $\therefore$  short path to  $i_{SH}$ .



Actual noise  
> Thermal noise



Actual noise  
> shot noise

$\hookrightarrow$  Additional noise sources :

Excess noise → source/mechanism is not well known as of today.

$\hookrightarrow$  only some observations.

- if current flows through non-homogeneous material,  
excess noise becomes large.

### Type of Resistors:

- Carbon composition → Carbon + semiconductor  
 ↓  
 Non-homogeneous  
 Large excess current noise
- Metal film
- Wire-wound → quiet  
 ↓  
 very excess noise-prone

### Transistors:

- MOSFET → Si +  $\text{SiO}_2$  → excess noise → more noisy than BJT
- BJT → traps present in BE junction.

### Excess Noise:

$$\text{PSD}_f = \frac{k^2}{f} \rightarrow \text{more dominant at low freq.}$$

$$Y_x^2 = \int_{f_1}^{f_2} \text{PSD}_f df = k^2 \ln\left(\frac{f_2}{f_1}\right)$$

↳ Noise power.

↓ Same across different decades:

$$(10, 100) = (100, 1000) = (1000, 10000)$$

### Different names:

Excess  
Low-frequency  
 $1/f$ -noise

Contact noise → occurs due to contact b/w two materials

Flicker noise

Pink noise

R O Y G B I V

$\alpha^{1/f}$

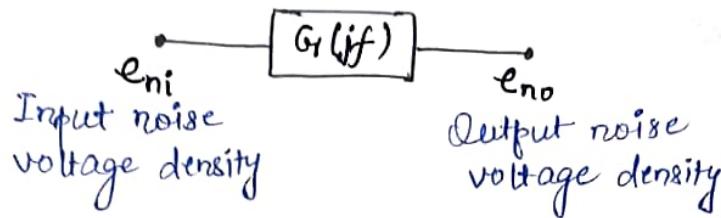
→ f

Noises: white + pink

$$\text{PSD}_{IC} = A_1 + \frac{A_2}{f} \quad (\text{in IC8})$$

## Noise Bandwidth (B)

→ Applicable only for white noise.



$$PSD_o(f) = e_{no}^2(f) = |G(jf)|^2 e_{ni}^2(f) \dots ①$$

$$(Total) RMS noise = \sqrt{\int_0^\infty PSD_o(f) df} \dots ②$$

$$= \sqrt{\int_0^\infty |G(jf)|^2 e_{ni}^2(f) df}$$

$$= e_{no}^2 \int_0^\infty |G(jf)|^2 df \quad [e_{ni} = e_{no}]$$

$$\underbrace{\int_0^\infty |G(jf)|^2 df}_B \quad [\because E_T^2 = e_T^2 B]$$

$$B = \int_0^\infty |G(jf)|^2 df \dots ③$$



$$f_c = \frac{1}{2\pi RC}$$

$$G(jf) = \frac{1}{1 + jf/f_c} \Rightarrow |G(jf)|^2 = \frac{1}{1 + f^2/f_c^2}$$

$$B = \int_0^\infty \frac{1}{1 + f^2/f_c^2} df = f_c \tan^{-1}\left(\frac{f}{f_c}\right) \Big|_0^\infty = \frac{\pi}{2} f_c$$

$$\text{for } f_c = 100 \text{ Hz,}$$

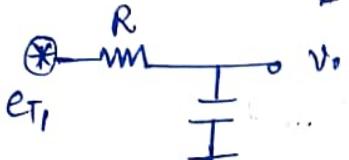
$$B = 157 \text{ Hz.}$$

## Noise Bandwidth (B)

$$B = \int_0^\infty |G(jf)|^2 df$$

$$E_{NO}^2 = e_n \omega^2 \int_0^\infty |G(jf)|^2 df$$

$\underbrace{\hspace{10em}}_B$

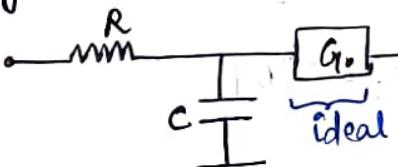


$$B = \frac{\pi}{2} f_c$$

$$E_{NO}^2 = 4 K T R B$$

$\downarrow$   
RMS o/p noise power

## More general filter:



$$G(jf) = \frac{G_o}{1 + j f / f_c}$$

$$B = \int_0^\infty |G(jf)|^2 df = \int_0^\infty \frac{G_o^2}{1 + (f/f_c)^2} df = G_o^2 \left( \frac{\pi}{2} f_c \right)$$

More generic expression: Same BW as previous.

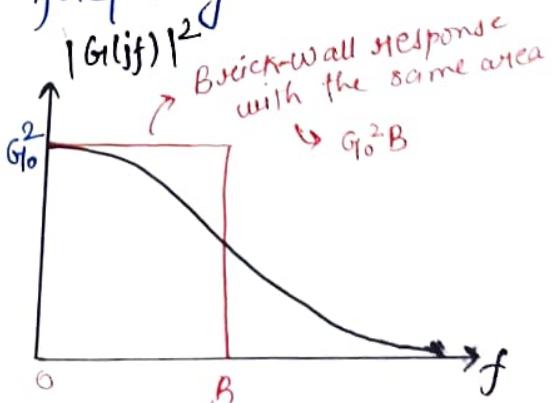
$$B = \frac{1}{G_o^2} \int_0^\infty |G(jf)|^2 df$$

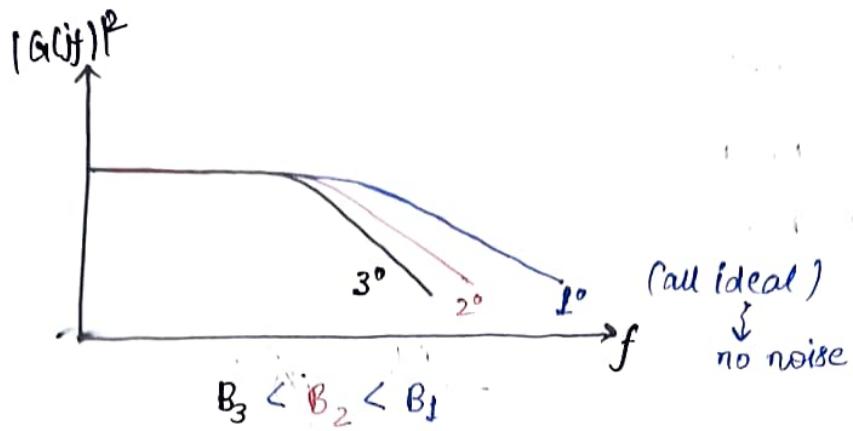
$G_o$ : pass-band gain

BPF:  $G_o \rightarrow$  gain @ center frequency

$$G_o^2 B = \int_0^\infty |G(jf)|^2 df$$

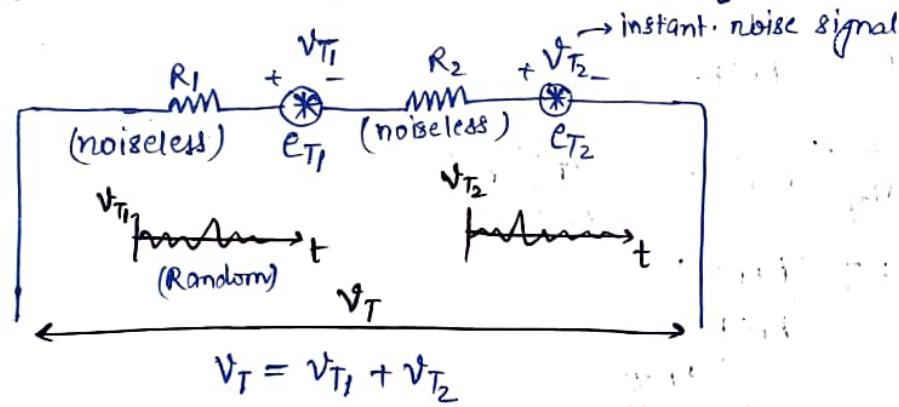
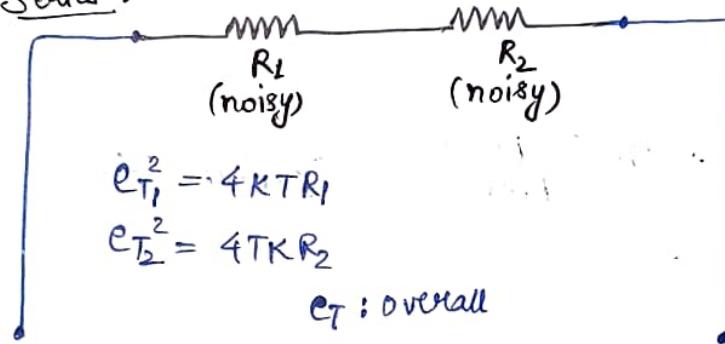
= area of power gain  
of the circuit





## Noise Analysis of Passive Circuits

Series:



$$\left\{ \begin{array}{l} X = f(w_1, w_2, w_3, \dots) \\ \sigma_x^2 = \left(\frac{\partial f}{\partial w_1}\right)^2 \sigma_{w_1}^2 + \left(\frac{\partial f}{\partial w_2}\right)^2 \sigma_{w_2}^2 + \left(\frac{\partial f}{\partial w_3}\right)^2 \sigma_{w_3}^2 + \dots \\ \text{[Propagation of variance in functions]} \end{array} \right.$$

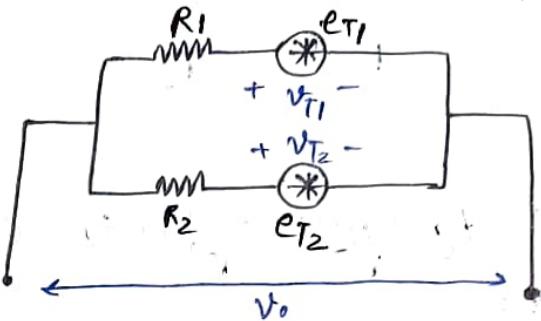
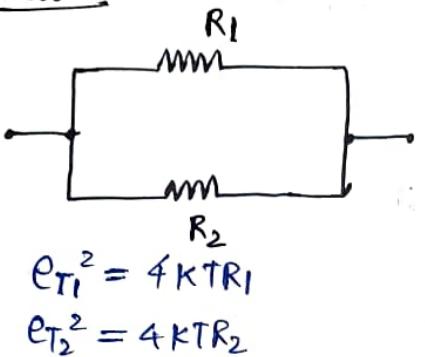
$$e_T^2 = \left(\frac{\partial v_T}{\partial v_{T1}}\right)^2 \sigma_{v_{T1}}^2 + \left(\frac{\partial v_T}{\partial v_{T2}}\right)^2 \sigma_{v_{T2}}^2$$

$$\Rightarrow e_T^2 = e_{T_1}^2 + e_{T_2}^2$$

$$\Rightarrow e_T^2 = 4KT (R_1 + R_2)$$

$$\Rightarrow e_T^2 = 4KT R_{\text{eff}}$$

Parallel:



$$V_0 = V_{T_1} \left( \frac{R_2}{R_1 + R_2} \right) + V_{T_2} \left( \frac{R_1}{R_1 + R_2} \right) \quad [\text{superposition}]$$

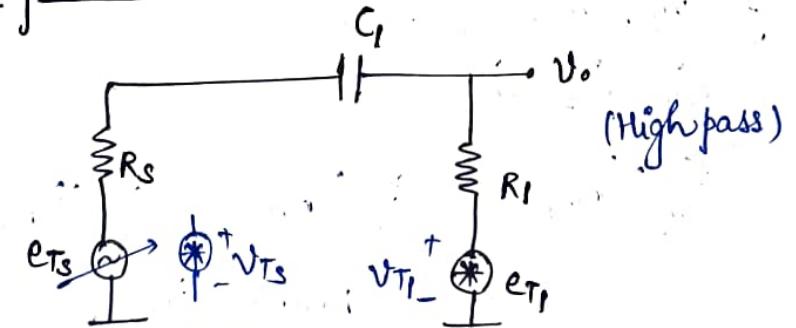
$$\frac{\partial V_0}{\partial V_{T_1}} = \left( \frac{R_2}{R_1 + R_2} \right)$$

$$\frac{\partial V_0}{\partial V_{T_2}} = \left( \frac{R_1}{R_1 + R_2} \right)$$

$$e_T^2 = \left( \frac{\partial V_T}{\partial V_{T_1}} \right)^2 e_{T_1}^2 + \left( \frac{\partial V_T}{\partial V_{T_2}} \right)^2 e_{T_2}^2$$

$$= 4KT \left( \frac{R_1 R_2}{R_1 + R_2} \right) \xrightarrow{\text{Reff}}$$

With capacitor:



(Noise at the i/p are uncorrelated)

$$e_{T_1}^2 = 4KT R_1$$

$$e_{T_S}^2 = 4KT R_S$$

$$V_o = V_{T_1} \left[ \frac{R_s + j\omega C_1}{R_1 + R_s + j\omega C_1} \right] + V_{T_2} \left[ \frac{R_1}{R_1 + R_s + j\omega C_1} \right]$$

$$= V_{T_1} \frac{(j\omega C_1 R_s + 1)}{D} + V_{T_2} \frac{j\omega C_1 R_1}{D},$$

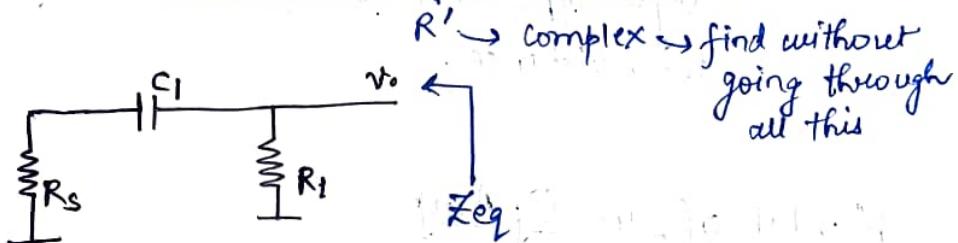
$$D = 1 + j\omega C_1 (R_1 + R_s)$$

$$|D|^2 = 1 + \omega^2 C_1^2 (R_1 + R_s)^2$$

$$e_o^2 = e_{T_1}^2 \frac{\omega^2 C_1 R_s^2 + 1}{|D|^2} + e_{T_2}^2 \frac{\omega^2 C_1^2 R_1^2}{|D|^2}$$

$$= 4kT \left[ \frac{1}{|D|^2} (\omega^2 C_1^2 R_s^2 R_1 + R_1 + \omega^2 C_1^2 R_1^2 R_s) \right]$$

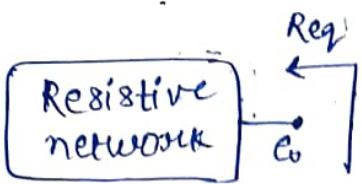
$$= 4kT \left[ \frac{1}{|D|^2} (R_1 + \omega^2 C_1^2 R_1 R_s (R_1 + R_s)) \right]$$



$$Z_{eq} = R_1 \parallel \left[ R_s + \frac{1}{j\omega C_1} \right]$$

$$\text{Real}(Z_{eq}) = R'$$

$$\therefore e_o^2 = 4kT \text{Real}(Z_{eq})$$

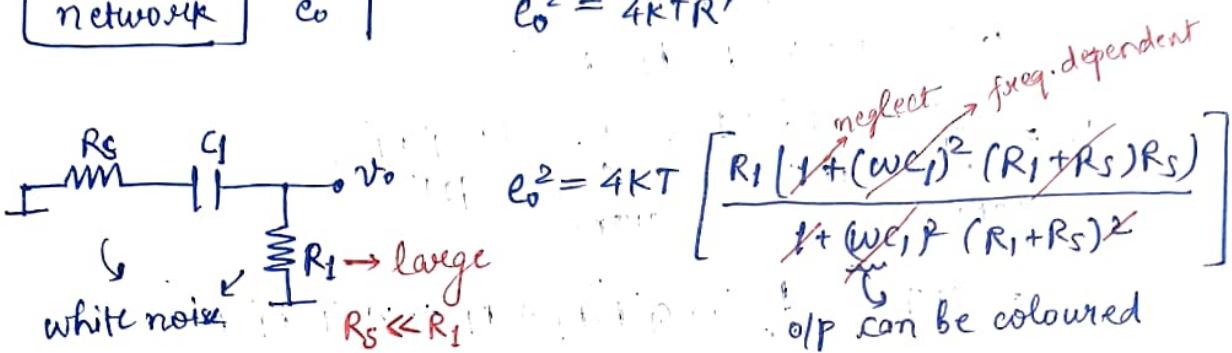


$$e_o^2 = 4KT R_{eq}$$



$R' = \text{Real part } (\text{Z}_{eq})$

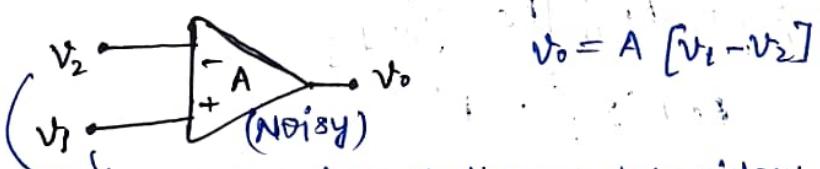
$$e_o^2 = 4KTR'$$



$$e_o^2 = 4KT \frac{R_i R_s}{R_i + R_s} \approx 4KTR_s$$

- Use of very large resistance need not lead to large o/p noise, it depends on the position of the resistance.

## Noise Model of an OpAmp



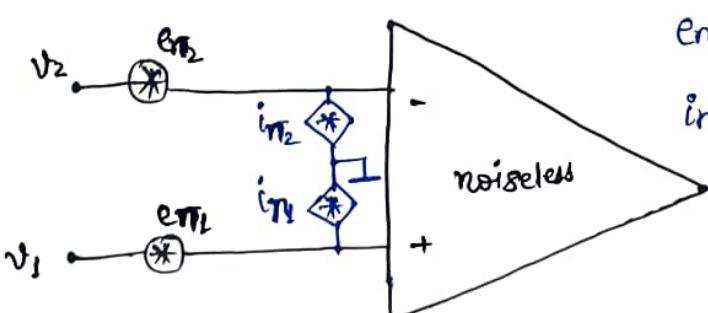
$$v_o = A [v_1 - v_2]$$

connected to base of different transistors

↳ having device resistances

↳ Noise : • Voltage noise

• Current noise



$e_{n1}, e_{n2}$ : voltage noise spectral densities

$i_{n1}, i_{n2}$ : current noise spectral densities

$$e_n^2 = e_{n_1}^2 + e_{n_2}^2 : \text{usually come in summation = white}$$

↪ equivalent voltage noise density

$$e_n^2 = A_1 + \frac{A_2}{f} = A_1 \left[ 1 + \frac{A_2/A_1}{f} \right] \xrightarrow{\text{unit of freq.}}$$

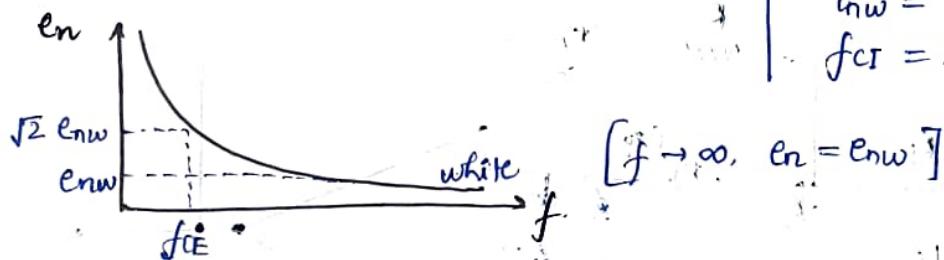
↪ voltage noise which is white in nature

$$e_n^2 = e_{nw}^2 \left[ 1 + \frac{f_{CE}}{f} \right]$$

@  $f = f_{CE}$  (corner freq.),

$$e_n^2 = 2e_{nw}^2 \quad \text{for voltage noise}$$

white noise = pink noise



# 741 IC
$e_{nw} = 20 \text{ nV}/\sqrt{\text{Hz}}$
$f_{CE} = 200 \text{ Hz}$
$i_{nw} = 0.5 \text{ pA}/\sqrt{\text{Hz}}$
$f_{CI} = 2 \text{ KHz}$

$$i_{n_1} \approx i_{n_2} = i_n \quad [\text{similar to i/p offset}]$$

$$i_n^2 = i_{nw}^2 \left[ 1 + \frac{f_{CI}}{f} \right], \quad f_{CI} : \text{corner frequency for current noise.}$$

Eg. Estimate RMS input noise of 741 IC over audio range (20 Hz to 20000 Hz).

$i_{n_1}, i_{n_2}$ : don't have resistive path to flow,

so i/p spectral density will be dictated by  $e_{n_1}, e_{n_2}$ .

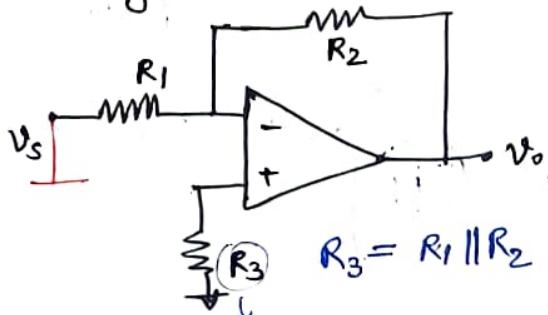
$$E_N^2 = \int_{f_L}^{f_H} e_n^2 df, \quad f_L = 20 \text{ Hz}$$

$f_H = 20 \text{ KHz}$

$$= e_{nw}^2 \left[ f_H - f_L + f_{CE} \ln \left( \frac{f_H}{f_L} \right) \right]$$

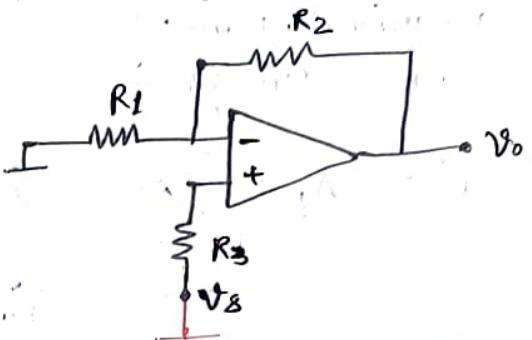
$$\approx 2.9 \mu\text{V}$$

## Inverting amplifier:

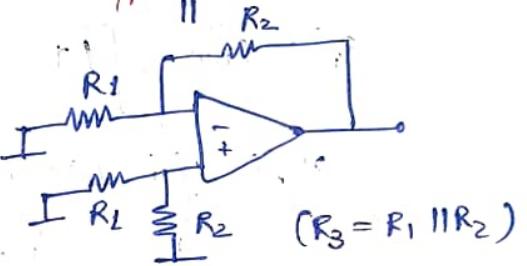


needed to compensate  
the error due to  
i/p offset current

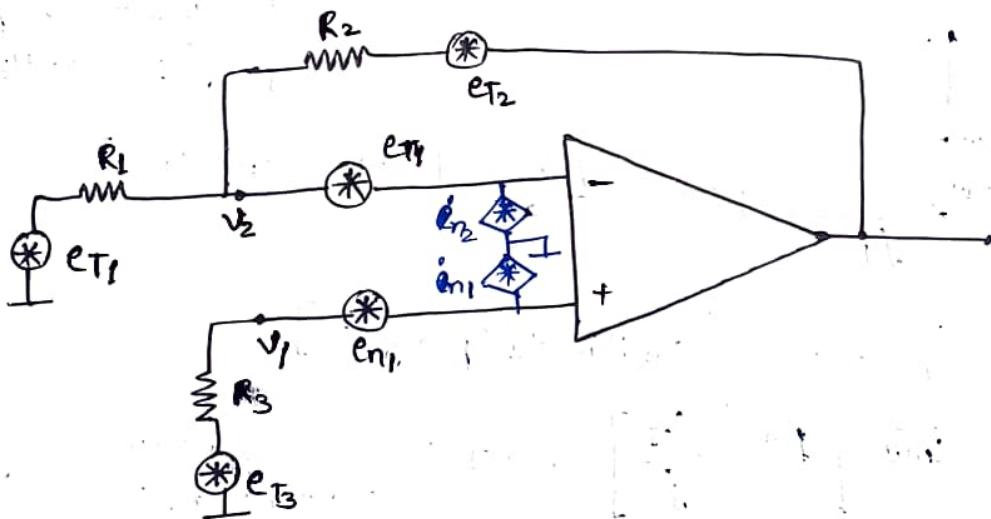
## Non-inverting amplifier:

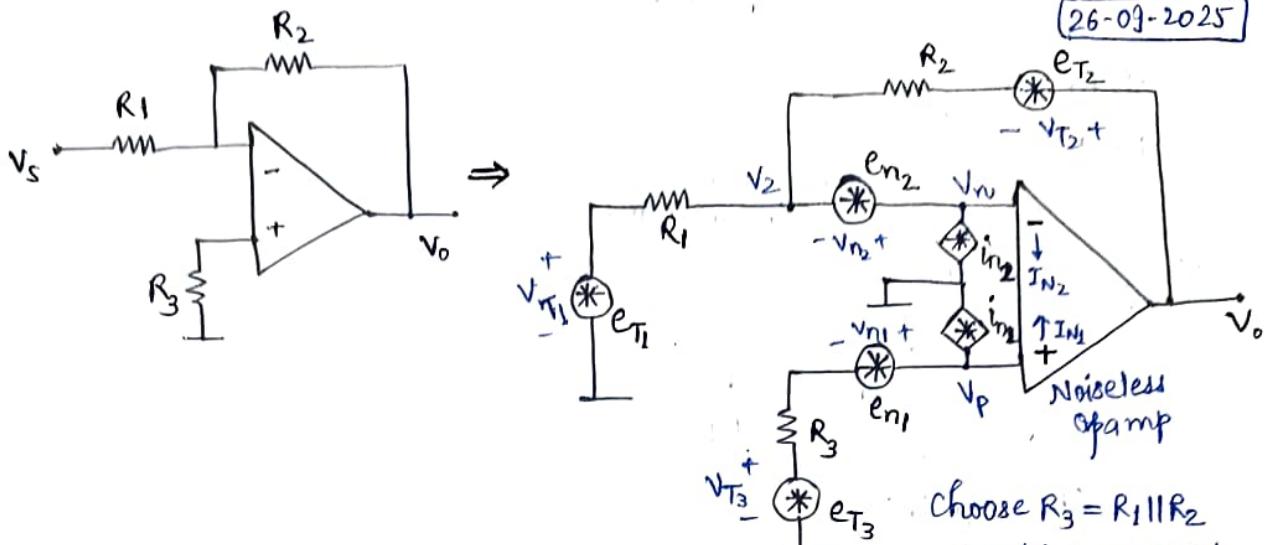


Remove the source as  
i/p & noise are uncorrelated.



- Noise analysis of a large class of configuration (inv., non-inv., summing) are the same. diff.





$$V_p = V_{n1} + V_{T3} - I_{N1} R_3 \quad \dots \textcircled{1}$$

$$V_n = V_2 + V_{n2} \Rightarrow V_2 = V_n - V_{n2} \quad \dots \textcircled{2}$$

Choose  $R_3 = R_1 \parallel R_2$   
for bias current offset mitigation.

KCL @  $V_2$ ,

$$\frac{V_2 - V_{T1}}{R_1} + \frac{V_2 - V_{T2} - V_o}{R_2} + I_{N2} = 0$$

$$\Rightarrow V_2 \left[ \frac{1}{R_1} + \frac{1}{R_2} \right] - \frac{V_{T1}}{R_1} + \frac{V_{T2}}{R_2} - \frac{V_o}{R_2} + I_{N2} = 0$$

From eqn \textcircled{2}, substitute  $V_2$ ,

$$(V_{n1} - V_{n2}) \left[ \frac{1}{R_1} + \frac{1}{R_2} \right] - \frac{V_{T1}}{R_1} + \frac{V_{T2}}{R_2} - \frac{V_o}{R_2} + I_{N2} = 0$$

$$\Rightarrow V_n = V_{n2} + V_{T1} \frac{R_2}{R_1 + R_2} - V_{T1} \frac{R_1}{R_1 + R_2} + \frac{V_o R_1}{R_1 + R_2} - I_{N2} (R_1 \parallel R_2) \quad \dots \textcircled{3}$$

We know,

$$V_o = A (V_p - V_n)$$

$$\Rightarrow \frac{V_o}{A} = V_p - V_n = 0 \Rightarrow V_p = V_n \quad (\because A \rightarrow \infty)$$

Equate eqn \textcircled{1} and \textcircled{3},

$$V_{n2} + V_{T1} \frac{R_1}{R_1 + R_2} - V_{T2} \frac{R_1}{R_1 + R_2} + \frac{V_o R_1}{R_1 + R_2} - I_{N2} (R_1 \parallel R_2) \\ = V_{n1} + V_{T3} - I_{N1} R_3$$

$$\Rightarrow \frac{V_o R_1}{R_1 + R_2} = V_{n1} - V_{n2} + V_{T3} - V_{T1} \frac{R_2}{R_1 + R_2} + V_{T2} \frac{R_1}{R_1 + R_2} - I_{N1} R_3 + I_{N2} (R_1 \parallel R_2)$$

$$\frac{V_o R_1}{R_1 + R_2} = V_{ni}$$

↓  
i/p referred noise  
(instantaneous)

$$\Rightarrow \frac{V_o}{1 + \frac{R_2}{R_1}} = V_{ni}$$

Noise gain,  $G_N = 1 + \frac{R_2}{R_1}$

$$V_o = G_N V_{ni}$$

$$e_o^2 = G_N^2 e_{ni}^2$$

spectral  
density

$$V_{ni} = V_{n1} + V_{T_3} - V_{n2} - V_{T_1} \frac{R_2}{R_1 + R_2} + V_{T_2} \frac{R_1}{R_1 + R_2} - I_{N1} R_3 + I_{N2} (R_1 \parallel R_2)$$

From  $V_{ni}$ , let's find  $e_{ni}^2$ ,

$$e_{ni}^2 = [e_{n1}^2 + e_{n2}^2] + e_{T_3}^2 + e_{T_1}^2 \left( \frac{R_2}{R_1 + R_2} \right)^2 + e_{T_2}^2 \left( \frac{R_1}{R_1 + R_2} \right)^2$$

↓                  ↓  
Opamp manufacturer    white  
specify this,  $e_n^2$       noise,       $4KTR_3$        $4KTR_1$        $4KTR_2$

$$+ i_{n1}^2 R_3^2 + i_{n2}^2 (R_1 \parallel R_2)^2$$

$$e_{ni}^2 = e_n^2 + 4KTR_3 + 4KTR_1 \left( \frac{R_2}{R_1 + R_2} \right)^2 + 4KTR_2 \left( \frac{R_1}{R_1 + R_2} \right)^2$$

$$+ i_{n1}^2 R_3^2 + i_{n2}^2 (R_1 \parallel R_2)$$

Approximation:  $i_{n1} \approx i_{n2} \approx i_n$ ,  $R_1 \parallel R_2 = R_3$

$$e_{ni}^2 = e_n^2 + 4KTR_3 + (4KTR_3) + i_n^2 R_3^2 + i_n^2 R_3^2$$

$$\Rightarrow e_{ni}^2 = e_n^2 + 8KTR_3 + 2i_n^2 R_3^2$$

Now, substitute  $e_{ni}$  in  $e_o^2 = G_N^2 e_{ni}^2$

$$e_o^2 = G_N^2 \cdot [e_n^2 + 8KTR_3 + 2i_n^2 R_3^2]$$

$$\begin{cases} e_n^2 = e_{nw}^2 \left[ 1 + \frac{f_{CE}}{f} \right] \rightarrow \text{white + pink} \\ 8KTR_3 \rightarrow \text{white} \\ i_n^2 = i_{nw}^2 \left[ 1 + \frac{f_{CI}}{f} \right] \rightarrow \text{white + pink} \end{cases}$$

Let  $R_2/R_1 = 10$

Case-A:

$$R_2 = 100 \Omega$$

$$R_1 = 10 \Omega$$

$R_3 \rightarrow \text{low}$

$$e_{ni}^2 \approx e_n^2$$

↑ short circuit noise

Case-B:

$$R_2 = 1M\Omega$$

$$R_1 = 100k\Omega$$

$R_3 \rightarrow \text{high}$

$$e_{ni}^2 \approx 2i_n^2 R_3$$

↑ open circuit noise

$E_{NO}$ : RMS Output Noise [ $f_L, f_H$ ]

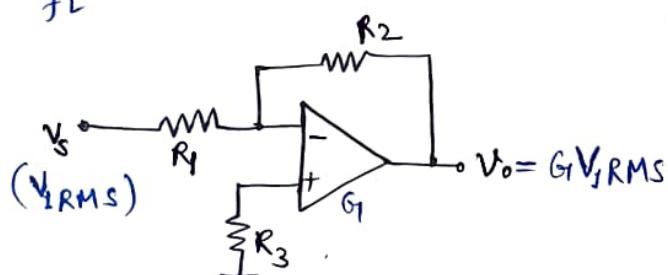
$$E_{NO}^2 = \int_{f_L}^{f_H} e_o^2 \cdot df$$

$E_{NO}$  dictates the output resolution of the amplifier.

$$\int_{f_L}^{f_H} e_n^2 \cdot df = [e_n w^2] \left[ f_H - f_L + f_{CE} \ln \left( \frac{f_H}{f_L} \right) \right]$$

$$\int_{f_L}^{f_H} 8KTR_3 df = 8KTR_3 (f_H - f_L)$$

$$\int_{f_L}^{f_H} i_n^2 df = i_n w^2 \left[ f_H - f_L + f_{CE} \ln \left( \frac{f_H}{f_L} \right) \right]$$



29-09-2025

$$SNR = 20 \log \left( \frac{G V_s RMS}{E_{NO}} \right)$$

Inverting amplifier:

$$G_1 = R_2/R_1$$

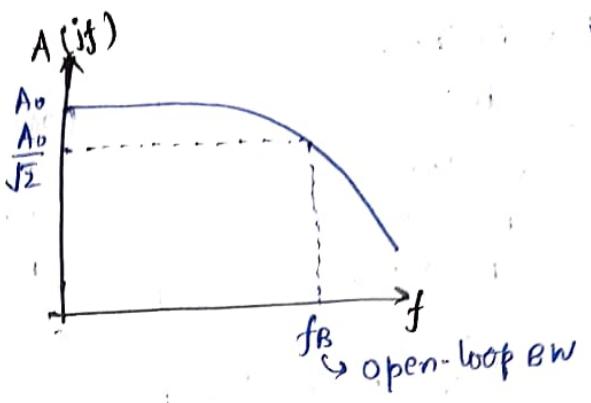
Non-inverting amplifier:

$$G_1 = 1 + R_2/R_1$$

→ We have assumed that  $A \rightarrow \infty$ , but it is still not practical.

→ We also know that gain has frequency dependency.

$$A(jf) = \frac{A_0}{1 + jf/f_B}$$



Modified eqn ( $A \neq \infty$ ):

$$\frac{V_o}{A(jf)} = V_p - V_n$$

$$V_{ni} = \frac{V_o}{G_N} \xrightarrow{\text{f dep.}} \frac{V_o}{A(jf)} + \frac{V_o}{G_N} = V_{ni}$$

$$\begin{aligned} V_o &= \frac{G_N A(jf)}{A(jf) + G_N} V_{ni} \\ &= \frac{G_N}{1 + G_N/A(jf)} V_{ni} \\ &= \frac{G_N V_{ni}}{1 + \frac{G_N}{A_0} \left( 1 + \frac{jf}{f_B} \right)} \\ &= \frac{G_N V_{ni}}{1 + \frac{G_N}{A_0} + \frac{jf}{\left( \frac{A_0 f_B}{G_N} \right)}} \end{aligned}$$

$$\text{As } G_N = 1 + \frac{R_2}{R_1} \ll A_0,$$

$$V_o = \frac{G_N V_{ni}}{1 + jf / \left( \frac{A_0 f_B}{G_N} \right)}$$

$$V_o = \frac{G_N V_{ni}}{1 + j(f/f_N)} \quad \text{, where } f_N = \frac{A_0 f_B}{G_N} \xrightarrow{\text{Gain-BW product}}$$

$$e_o^2 = e_n^2 \left( \frac{G_N^2}{1 + (f/f_N)^2} \right)^2 e_{ni}^2$$

$$\text{Now, } e_{ni}^2 = e_n^2 + 8kTR_s + 2i_n^2 R_s^2$$

$$E_{no}^2 = \int_L^H e_o^2 df : \text{RMS noise}$$

Eg.

Given;

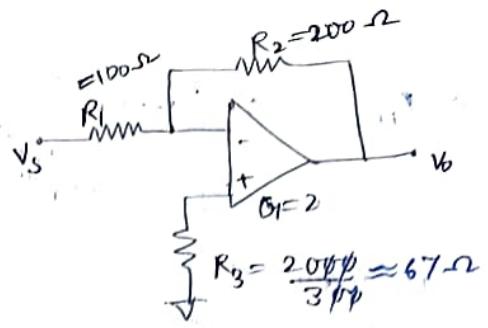
$$e_{nW} = 20 \text{ nV}/\sqrt{\text{Hz}}$$

$$f_{CE} = 200 \text{ Hz}$$

$$i_{nW} = 0.5 \text{ pA}/\sqrt{\text{Hz}}$$

$$f_{CR} = 2 \text{ kHz}$$

$$A_0 = 10^6 \text{ (DC gain)}$$



Unity-Gain-Bandwidth product = 1 MHz.

RMS output noise above 0.1 Hz.

$f_L = 0.1 \text{ Hz}$ ,  $f_H \rightarrow \infty$ . Find RMS noise.

Soln: We know,  $G_f = 2$ ,  $G_{IN} = 3$

$$f_N = \frac{A_0 f_B}{G_{IN}} = \frac{1 \text{ MHz}}{3}$$

$$e_{ni}^2 \approx e_n^2 + 8kTR_3 + 2i_n^2 R_3^2$$

$$e_n^2 \approx e_n^2 = e_{nW}^2 \left( 1 + \frac{f_{CE}}{f} \right)$$

$$e_o^2 = \text{Gain}^2 \times e_n^2$$

$$= \frac{G_{IN}^2 e_{nW}^2}{1 + \frac{f^2}{f_N^2}} (1 + f_{CE}/f)$$

$$\Rightarrow e_o^2 = G_{IN}^2 e_{nW}^2 \left[ \frac{L}{1 + f^2/f_N^2} + \frac{f_{CE}/f}{1 + f^2/f_N^2} \right]$$

$\downarrow f_H \cdot df$

$$E_{N0}^2 = G_{IN}^2 e_{nW}^2 \left[ f_N \tan^{-1} \left( \frac{f}{f_N} \right) + \frac{f_{CE}}{2} \ln \left( \frac{f^2}{f^2 + f_N^2} \right) \right]_{0.1}^{\infty}$$

( $f \ll f_N$ )

$$= G_{IN}^2 e_{nW}^2 \left[ \frac{\pi}{2} f_N + \frac{f_{CE}}{2} \ln(1) - f_N \frac{f_L}{f_N} - \frac{f_{CE}}{2} \ln \left( \frac{f_L^2}{f_L^2 + f_N^2} \right) \right]$$

$$\Rightarrow E_{N0}^2 = G_{IN}^2 e_{nW}^2 \left[ \frac{\pi}{2} f_N - f_L - \frac{f_{CE}}{2} \ln \left( \frac{f_L}{f_N} \right) \right] \approx f_N^2$$

$$\Rightarrow E_{N0}^2 = G_{IN}^2 e_{nW}^2 \left[ \frac{\pi}{2} f_N - f_L + f_{CE} \ln \left( \frac{f_N}{f_L} \right) \right]$$

$$\Rightarrow E_{N_0}^2 = (3)^2 \left( 4 \times 10^{-16} \right) \left[ \frac{\pi}{2} \left( \frac{10^6}{3} \right) - 0.1 + 200 \ln \left( \frac{10^6}{3 \times 0.1} \right) \right]$$

~~$\approx 5665.68 \times 10^{12} \text{ V}^2$~~

$$= 5665.68 \times 10^{12} \text{ V}^2 \quad \left| \begin{array}{l} E_{N_0} \rightarrow \text{Resolution of opamp.} \\ = 43.5 \mu\text{V} \end{array} \right.$$

for input  $V_s$ ,

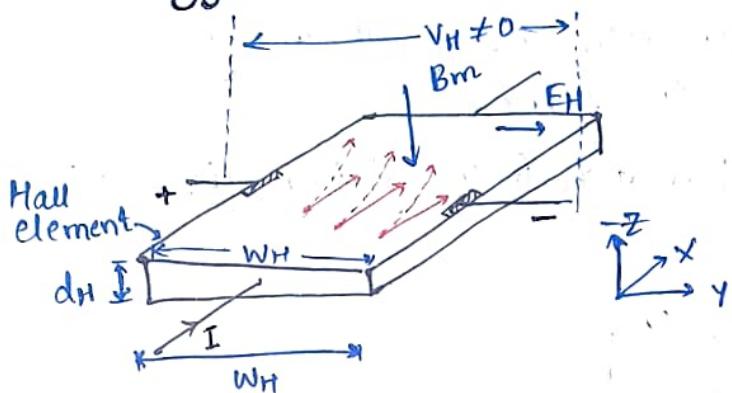
$$V_s = 8 \sin \omega t$$

$$V_i \text{ RMS} = 1/\sqrt{2} \Rightarrow G_i V_i \text{ RMS} = \sqrt{2}$$

$$\text{SNR} = 20 \log \left( \frac{\sqrt{2}}{43.5 \mu\text{V}} \right)$$

$$\approx 0.2 \text{ dB}$$

→ We may have to put a capacitor across  $R_2$  if  $f_H \neq \infty$ , to increase SNR.

Magnetic Sensors:Hall Effect Sensors

When the magnetic field is applied, the force deflects the charges in y-dir.

$E_H$ : Induced electric field

$B_m$ : Measured magnetic field

Lorenz Magnetic force,

$$F_B = q (\underline{V_D} \times \underline{B_m}) = q V_D B_m$$

Force due to Electric field,  $V_D$  charge drift velocity of charged

$$F_E = q E_H = q V_D B_m$$

At equilibrium,  $F_B = F_E$

Induced electric field,  $E_H = V_D B_m$

Induced voltage:  $V_H$  (Hall voltage)

$$E_H = V_H / W_H \neq 0$$

$$\Rightarrow \frac{V_H}{W_H} = V_D B_m$$

$$\Rightarrow V_H = V_D B_m W_H$$

Drift velocity,

$$V_D = \frac{I}{n q W_H d_H}, n: \text{no. of e\&#8782;/volume}$$

$$\therefore V_H = B_m \left( \frac{I}{n q d_H} \right)$$

$$\Rightarrow V_H = B_m \cdot K, K = \frac{I}{n q d_H} : \text{sensitivity}$$

Linear Magnetic field sensor

For metal,  $n \rightarrow$  high,  $K \rightarrow$  low

Generally doped semiconductor is used.

$\hookrightarrow n \rightarrow$  low  
 $K \rightarrow$  flexible

→ For pure Hall element, charge carriers will move in a straight line.

Assumption so far: Drift velocities of all charge carriers are the same.

There may be minor mismatch in  $v_D$ , giving different magnetic force.

$$v_{D_1}, v_{D_2}, v_{D_3}$$
$$\downarrow \quad \downarrow \quad \downarrow$$
$$qV_{D_1}B_m \quad qV_{D_2}B_m \quad qV_{D_3}B_m$$

Induced electric field will balance the average magnetic fields.

$$qV_{DAVG}B_m = qEH \Rightarrow V_H = B_m \cdot V_{DAVG} \cdot W \cdot H$$

↳ Path length of charge carriers increase  $\Rightarrow$  Resistance  $\uparrow \Rightarrow$  Magneto-Resistance

### Magneto-Resistance Technology:

↳ Invented by Lord Kelvin

↳ Material used: Germanium

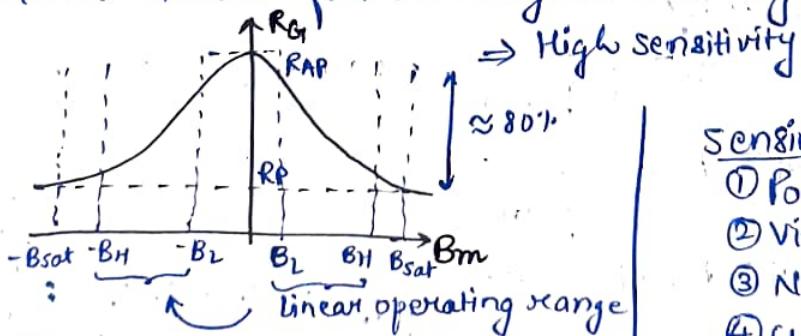
↳ Change in resistance with magnetic field.

↳ Low sensitivity ( $\approx 2\%$ )

### New technology: GMR

### Giant Magneto-Resistance (GMR):

↳ 'Giant' stands for the huge sensitivity of the material.



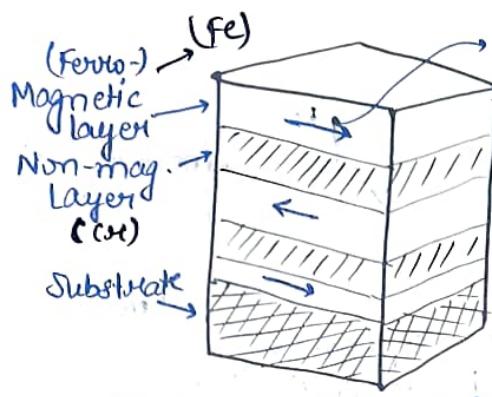
### Sensing Applications:

- ① Position sensing
- ② Vital-sign monitor
- ③ Non-Destructive Evaluation
- ④ Current sensing

↳ Low cost, compact size

↳ Rugged nature

↳ Non-contact sensing

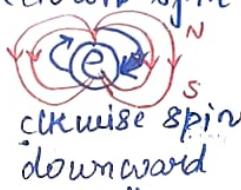
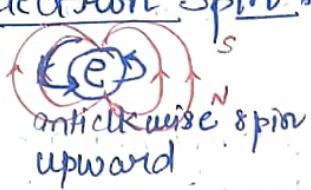


Dimn of mag. moment

- Ferromagnetic layers sandwiched around a non-magnetic layer.

- Magnetic moments of Fe layers are in anti-parallel configuration (mag. field = 0)

Electron Spin: Electrons spin around their axis (apart from revolving around nucleus)



UpSpin ( $m_s = +\frac{1}{2}$ )

DownSpin ( $m_s = -\frac{1}{2}$ )

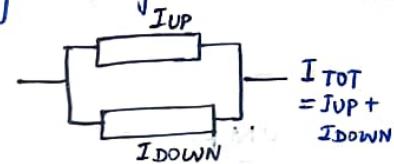
- Electrons spin motion occurs in 2 separate parallel channels.

- For normal metals,  $\rightarrow$  no. of  $e^-$

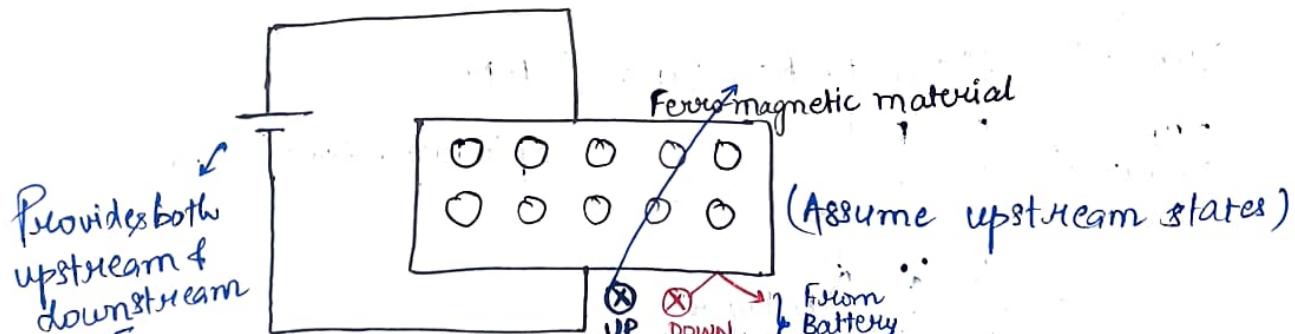
$$N_{UPSPIN} = N_{DOWNSPIN}$$

- For ferromagnetic materials,

$$N_{UPSPIN} \neq N_{DOWNSPIN}$$

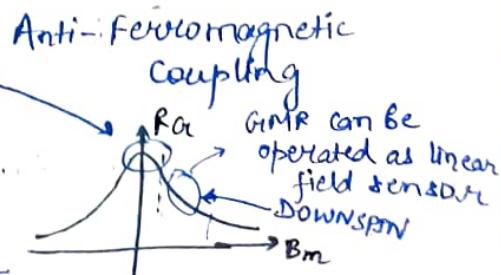
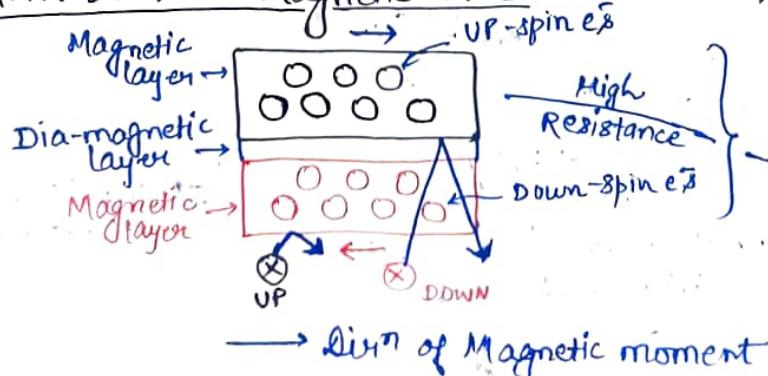


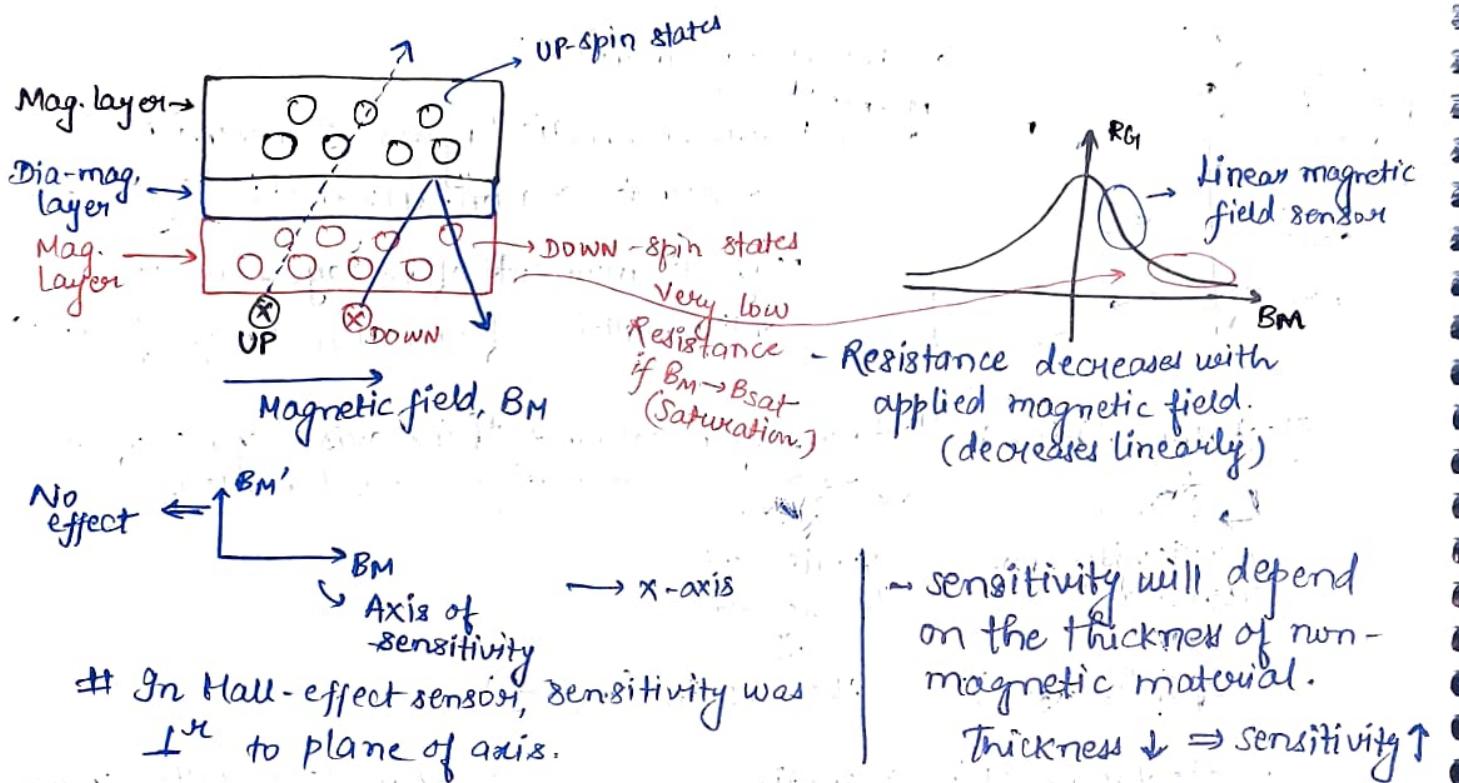
Spin-Dependant Conduction:



- Upstream  $e^-$  pass (dominate the conduction).
- Downstream  $e^-$  get scattered (blocked).

GMR at Zero Magnetic Field:





21-10-2025

### GMR

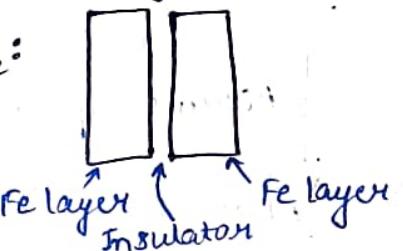
$$R_G = R_0 [1 - k_B]$$

GMR      Base  
 Resistance      Resistance      Sensitivity

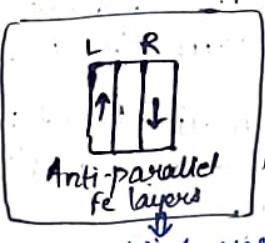
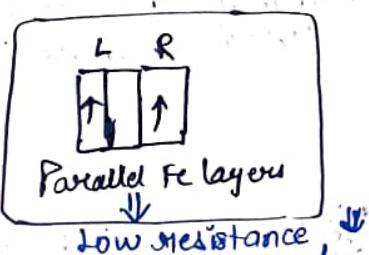
: Linear

### Tunneling Magneto-Resistance (TMR)

TMR structure:



- Spin dependent Tunneling

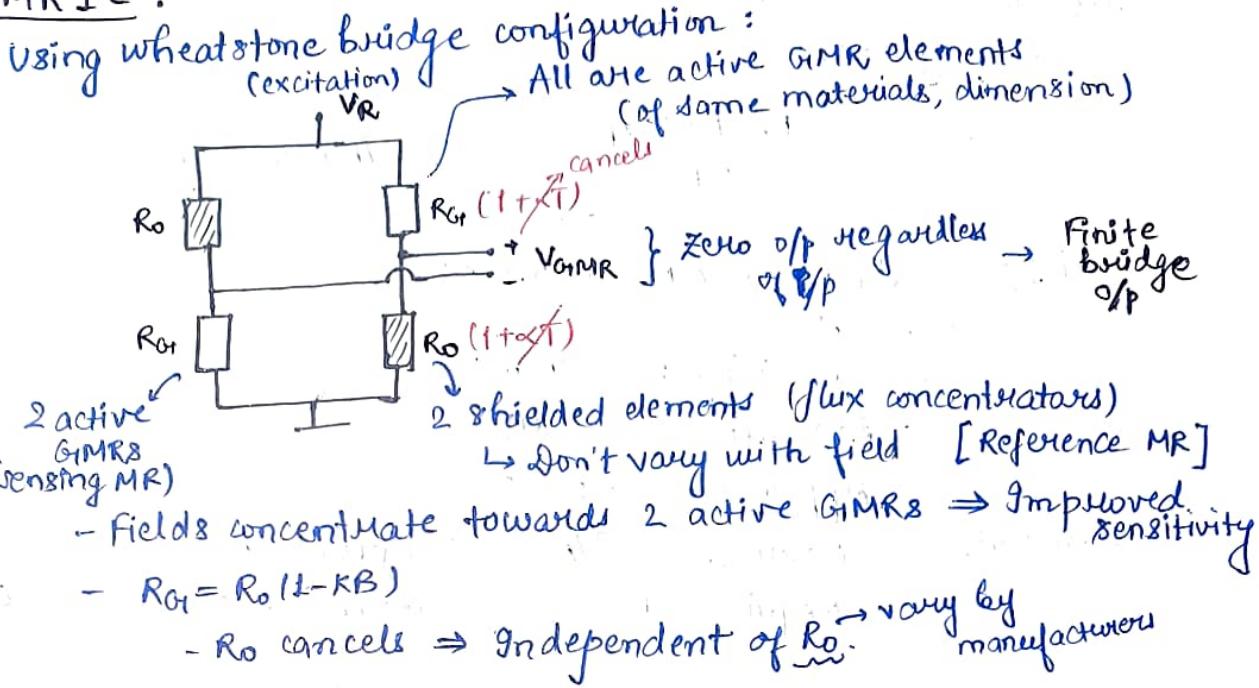


Large sensitivity to mag. field

- Carrier tunnel through insulator.
- Higher sensitivity than GMR.

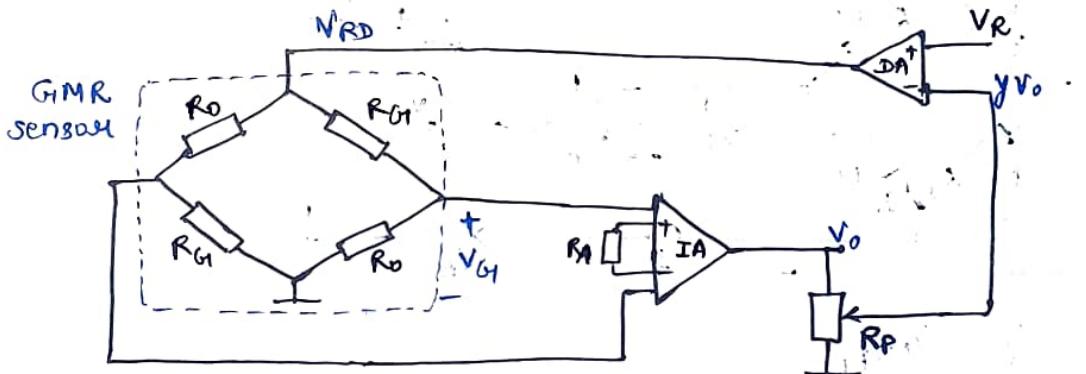
# CMR (Colossal Magneto-Resistance)

## GMR IC :



$$V_{GMR} = \left( \frac{R_o - R_{G1}}{R_o + R_{G1}} \right) V_R \rightarrow \text{Non-linearity} \quad (V_{GMR} \text{ vs. } R_{G1})$$

## Linearizer Circuit:



$$V_o = G V_{G1} = G \left( \frac{R_o - R_{G1}}{R_o + R_{G1}} \right) V_{RD} \quad \dots \textcircled{1}$$

$$V_{RD} = V_R - yV_o \quad \dots \textcircled{2}$$

$$\therefore V_o = G \left( \frac{R_o - R_{G1}}{R_o + R_{G1}} \right) (V_R - yV_o)$$

$$\Rightarrow V_o = \frac{G \left( \frac{R_o - R_{G1}}{R_o + R_{G1}} \right) V_R}{1 + yG \left( \frac{R_o - R_{G1}}{R_o + R_{G1}} \right)}$$

$$= \frac{G (R_o - R_{G1}) V_R}{R_o + R_{G1} + yG (R_o - R_{G1})} \quad \dots \textcircled{3}$$

- Get linear  $V_o$  vs.  $R_{G1}$ .

Take  $y G_1 = 1$ .

$$\Rightarrow V_o = \frac{G_1 (R_o - R_{G1}) V_R}{2 R_o} : \text{feedback compensation}$$

Merits: - Impenetrated NL ( $< 0.7\%$ )

- Simple

- sensitivity:  $0.7V/mT$

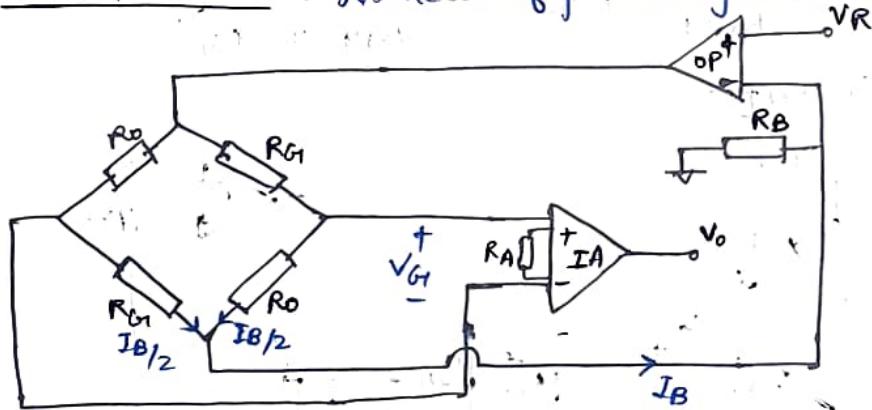
- Resolution:  $0.2\mu T$

- Approx. cost: \$7

Demerits: - Requires 2 I/A's (DA using IA)

- Requires precise potentiometer to ensure  $G_1 y = 1$ .

Improved circuit: No need of precise potentiometer.

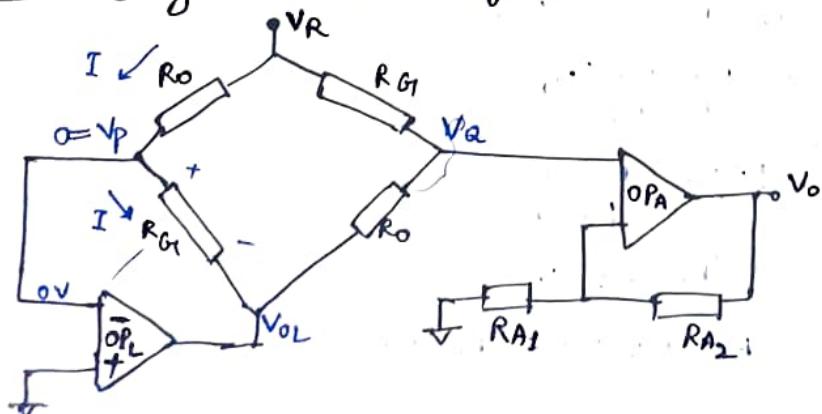


$$I_B = V_R / R_B$$

$$V_G1 = \frac{I_B}{2} (R_o - R_{G1})$$

$$V_o = G_1 V_G1 = \frac{G_1 I_B}{2} (R_o - R_{G1})$$

Linearizing front-end for GMR-sensor (LFG)



$V_p = 0$  (virtual ground)

$$I = V_R / R_o$$

$$\therefore V_{OL} = -IR_{G_1} = -\frac{V_R}{R_o} R_{G_1}$$

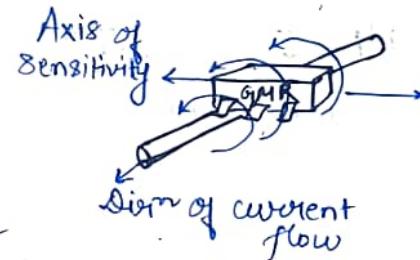
$$\begin{aligned} V_Q &= V_R \frac{R_o}{R_o + R_{G_1}} + \frac{V_{OL} R_{G_1}}{R_o + R_{G_1}} \quad (\text{By superposition}) \\ &= V_R \frac{R_o}{R_o + R_{G_1}} - \frac{\frac{V_R}{R_o} R_{G_1}^2}{R_o + R_{G_1}} \\ &= \frac{V_R}{R_o + R_{G_1}} \left( R_o - \frac{R_{G_1}^2}{R_o} \right) \\ \therefore V_Q &= \frac{V_R (R_o - R_{G_1})}{R_o} \end{aligned}$$

- 2nd opamp for further amplification.

$$V_o = \left( 1 + \frac{R_{A2}}{R_{A1}} \right) V_Q$$

### Current Sensing using GMR

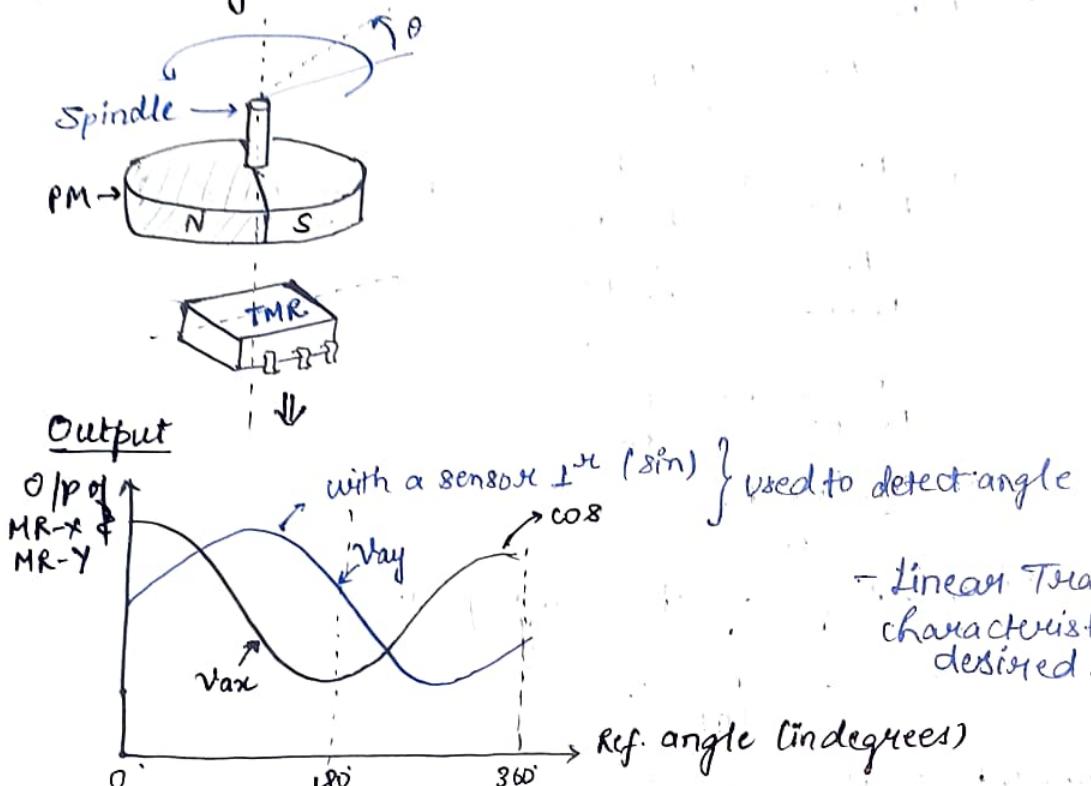
- Non-intrusive measurement (no loading).
- current probes.
- Industrial process control
- PCB mounted current detection
- well-suited for High-current applications.



### Angle sensors

- Steering wheel
- Robotic arm
- Motor-positioning

## GMR/TMR Angle Sensors

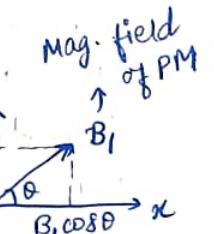


## A TMR Angle Sensor with Full-Circle Range:

TMR IC  $\rightarrow$  AAT001

Two half bridges: X Y

aligned along +ve x  $R_{X_1}, R_{X_2}$  aligned along x-dirn  
aligned along -ve x  $R_{Y_1}, R_{Y_2}$  aligned along y-dirn



$$R_{X_2} \rightarrow B_1 \cos \theta$$

$$R_{X_2} = R_0 [1 + K_T \cos \theta], \quad R_0: \text{Nominal Resistance}$$

aligned along -ve x  $R_{X_1} \rightarrow -B_1 \cos \theta$   $K_T: \text{Transformation constant / sensitivity of half-bridges}$

$$R_{X_1} = R_0 [1 - K_T \cos \theta]$$

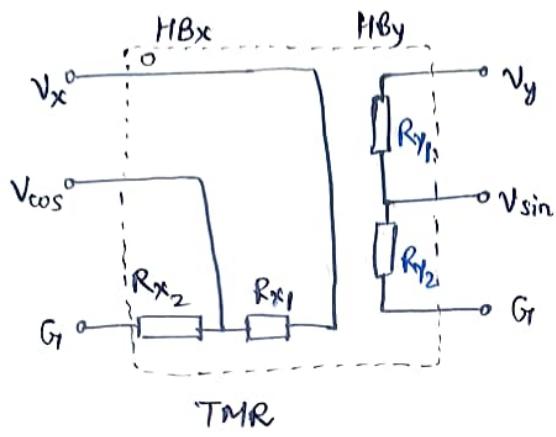
offset can be removed (using DA)

$$V_{\cos} = \frac{R_{X_2} V_x}{R_{X_1} + R_{X_2}} = \left( \frac{1 + K_T \cos \theta}{2} \right) V_x = 0.5 K_T V_x \cos \theta$$

$$V_{\sin} = \frac{R_{Y_1} V_y}{R_{Y_1} + R_{Y_2}} = \left( \frac{1 + K_T \sin \theta}{2} \right) V_y = 0.5 K_T V_y \sin \theta$$

- Needs only one IC.

- Output should depend only on the angle.



We can choose  $V_x, V_y$ .

Choose  $V_x = V_m \cos \omega t$ ,  $V_y = V_m \sin \omega t$ .

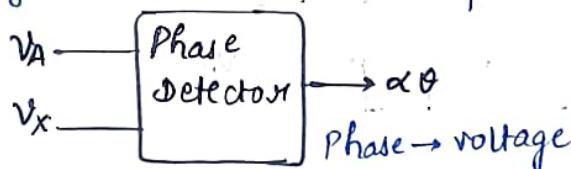
$$\therefore V_{\text{cos}} = 0.5 K_T V_m \cos \omega t \cdot \cos \theta$$

$$V_{\text{sin}} = 0.5 K_T V_m \sin \omega t \cdot \sin \theta.$$

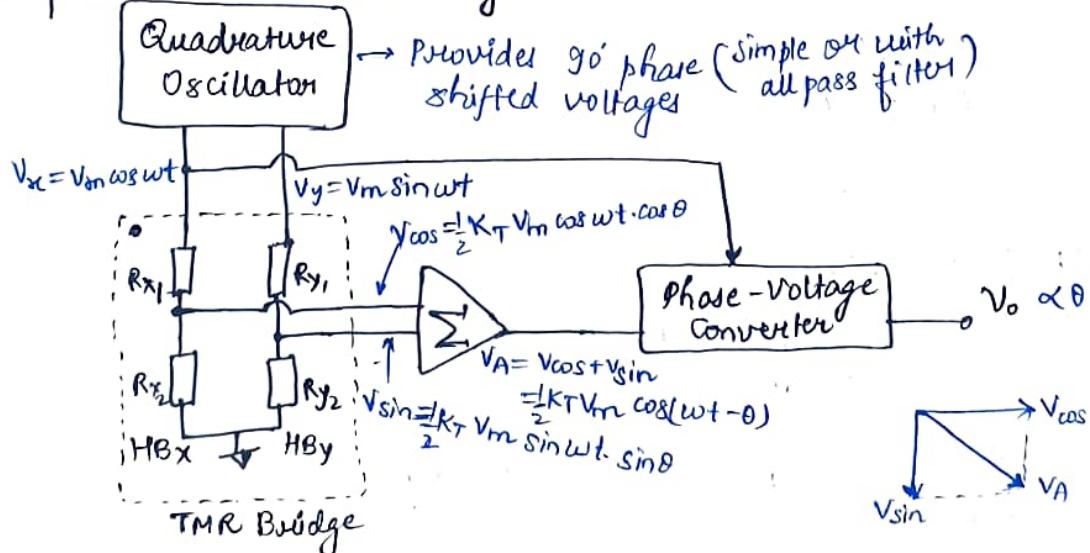
Using summing amplifier,

$$V_A = V_{\text{cos}} + V_{\text{sin}} = 0.5 K_T \cos(\omega t - \theta)$$

Angle is converted to the phase angle b/w  $V_A$  and  $V_x$ .



### Proposed Signal Conditioning Scheme:

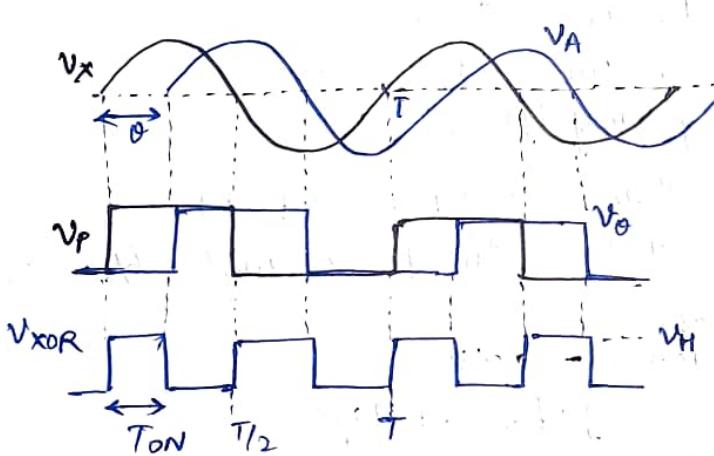
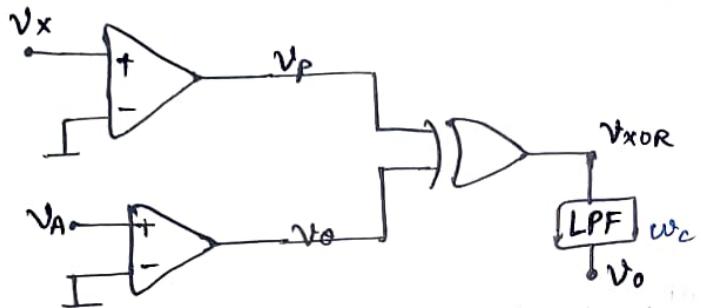


## Phase Detector - Basic Circuit

$$V_X = V_m \cos \omega t$$

$$V_A = 0.5 K_T V_m \cos(\omega t - \theta)$$

We would want to detect '0' regardless of the amplitudes.



$$T = 2\pi/w$$

$$T_{ON} \propto \theta$$

$$T_{ON} = \theta/w$$

$$\frac{T_{ON}}{T} = \frac{\theta}{2\pi}$$

LPF:  $w_c \ll w$ ,

$$V_0 = \text{avg}(V_{XOR})$$

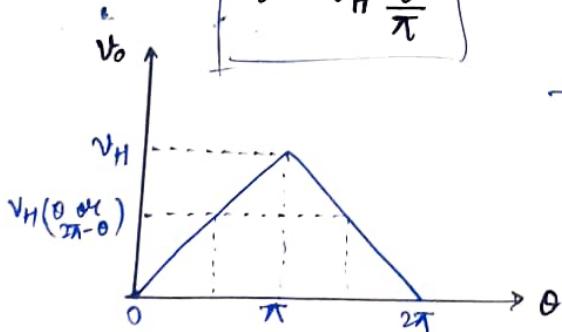
$$= V_H \frac{T_{ON}}{T/2}$$

$$\therefore V_0 = V_H \frac{\theta}{\pi}$$

→  $V_H$ -dependent.

→ 180° phase-detector

[90° & 270° give the same obs.]

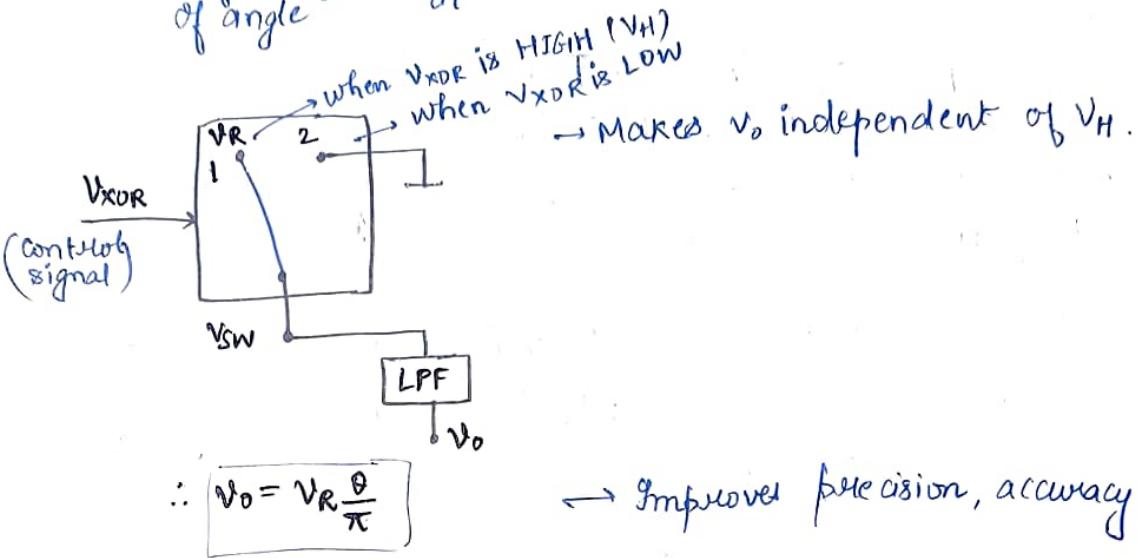


$$\text{Q. } \omega = 2000\pi$$

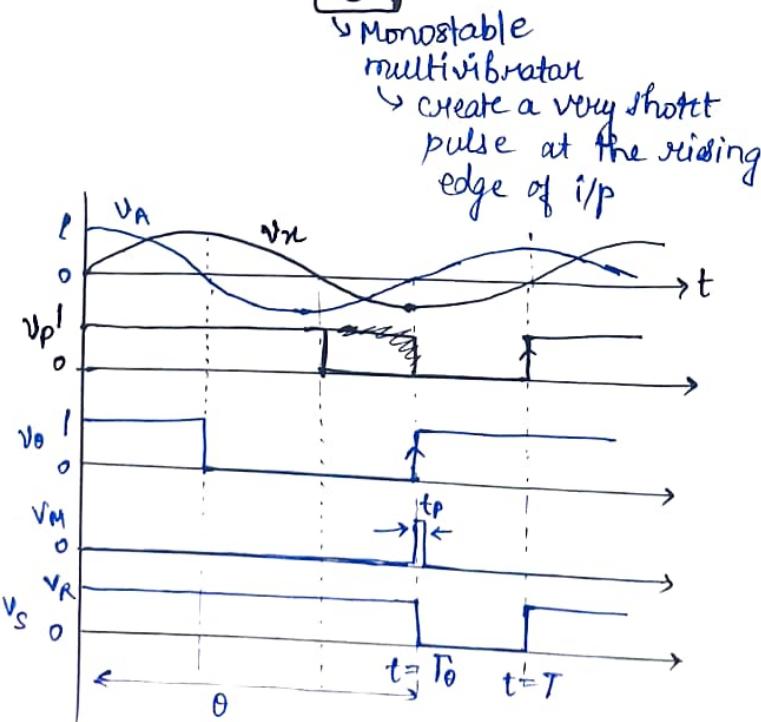
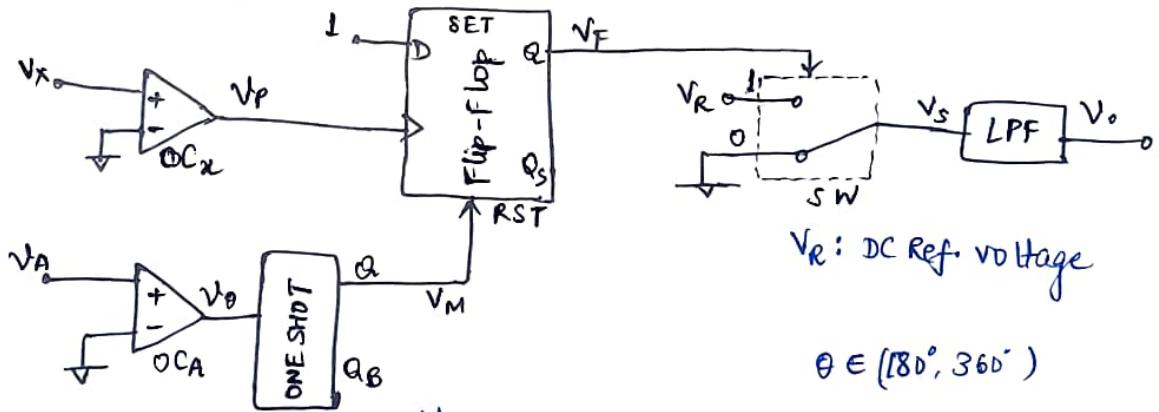
$$W_C = 20\pi$$

Output should not contain any component of  $2000\pi$ .

Rate of change,  $\frac{d\theta}{dt} \ll \omega$ .  
of angle



### Phase-to-Voltage converter (360° phase detector)



$$V_x = V_m \cos \omega t$$

$$v_A = K_T V_m \cos(\omega t - \theta)$$

$$T_{ON} \propto \theta$$

$$\Rightarrow T_{ON} = \theta/\omega$$

$$\text{Switch o/p, } v_s = \begin{cases} V_R, & t \in T_{ON} \\ 0, & t \in T_{OFF} \end{cases}$$

$$\text{Avg. value, } v_o = \frac{V_R T_{ON}}{T} = \frac{V_R \theta}{\omega \frac{2\pi}{\omega}} = \frac{V_R \theta}{2\pi}$$

We get different  $T_{ON}$  for  $90^\circ$  and  $270^\circ$  phase diff. [for 1st-2nd and 3rd-4th quadrant], thus can be used for full  $360^\circ$  range phase-detection.

Dominant  
Error Sources:

① we assumed to get  $90^\circ$  phase-shifted sinusoidal wave.  
But there may be some phase error (phasor) propagating to the output.

Oscillator signals:  $V_x = V_m \cos \omega t$   
 $V_y = V_m \sin(\omega t + \Psi)$ ,  $\Psi$ : phase error of  $QD (^\circ)$

TMR sensor outputs:

$$V_{\cos} = V_x K_s \cos \theta = V_m K_s \cos \omega t \cdot \cos \theta$$

$$V_{\sin} = V_y K_s \sin \theta = V_m K_s \sin(\omega t + \Psi) \cdot \sin \theta$$

Summation:  $V_{S1} = V_m K_s \cos \omega t \cos \theta + V_m K_s \sin(\omega t + \Psi) \cdot \sin \theta$

$$V_{S1} = V_m K_s \cdot \cos(\omega t - \phi_1)$$

$$\phi_1 = \tan^{-1} \left[ \frac{\sin \theta \cos \Psi}{\cos \theta + \sin \theta \sin \Psi} \right] \rightarrow \text{phase-shift w.r.t. } V_x$$

$$= \tan^{-1} \left[ \frac{\tan \theta \cos \Psi}{1 + \tan \theta \sin \Psi} \right]$$

$$\% \text{ error} = \frac{\phi_1 - \theta}{360^\circ} \times 100\% \quad [\text{w.r.t. full scale}]$$

Maxm value of error occurs at

$$\theta = 90^\circ, 270^\circ$$

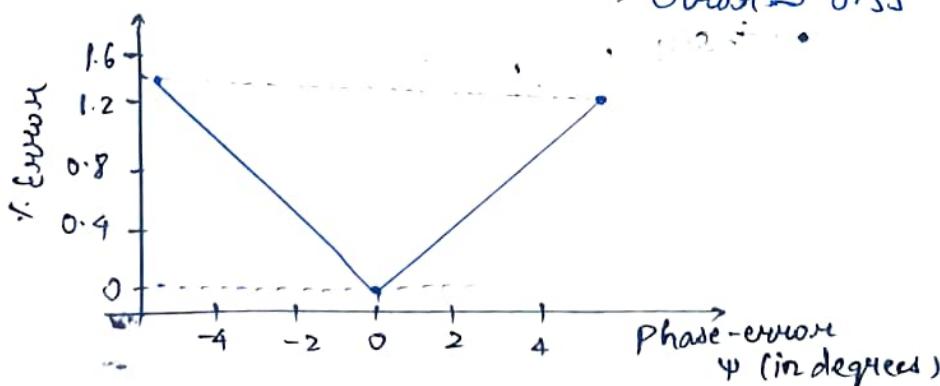
$$\theta = 90^\circ \Rightarrow \phi_1 = \tan^{-1} [\cot \Psi] = 90^\circ - \Psi$$

$$\% \text{ error} = \frac{\pm \Psi}{360^\circ} \times 100\% \quad (+ \text{ for } \theta = 270^\circ)$$

$$\text{Maxm error (worst-case)} = \frac{|\Psi|}{360^\circ} \times 100\%$$

For phase-mismatch of  $\Psi = 2^\circ$

$$\text{error} \approx 0.55\%$$



## Enhanced Methodology:

Difference :  $V_{S_3} = V_m K_B \cos \omega t \cdot \cos \theta - V_m K_S \sin(\omega t + \Psi) \sin \theta$   
 $= V_m K_B \cos(\omega t + \phi_2)$

$$\phi_2 = \tan^{-1} \left[ \frac{\tan \theta \cos \Psi}{1 - \tan \theta \sin \Psi} \right] \rightarrow \text{phase-shift wrt } V_x.$$

$$\begin{aligned} \text{Define } D_\theta &= \frac{\phi_1 + \phi_2}{2} \\ &= \frac{1}{2} \left[ \tan^{-1} \left( \frac{\tan \theta \cos \Psi}{1 + \tan \theta \sin \Psi} \right) + \tan^{-1} \left( \frac{\tan \theta \cos \Psi}{1 - \tan \theta \sin \Psi} \right) \right] \\ &= \frac{1}{2} \tan^{-1} (\tan 2\theta \cos \Psi) \end{aligned}$$

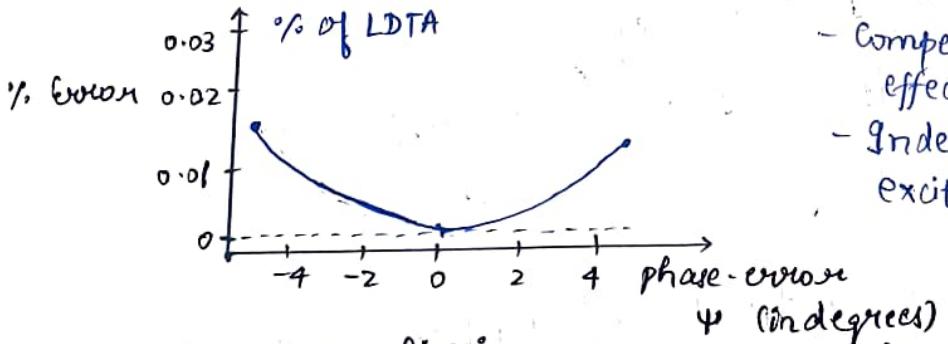
$\Psi$ : small  $\Rightarrow \cos \Psi \rightarrow 1$

$$\Rightarrow D_\theta = \frac{1}{2} \tan^{-1} (\tan 2\theta) \approx \theta \text{ for } \theta \in (0^\circ, 360^\circ)$$

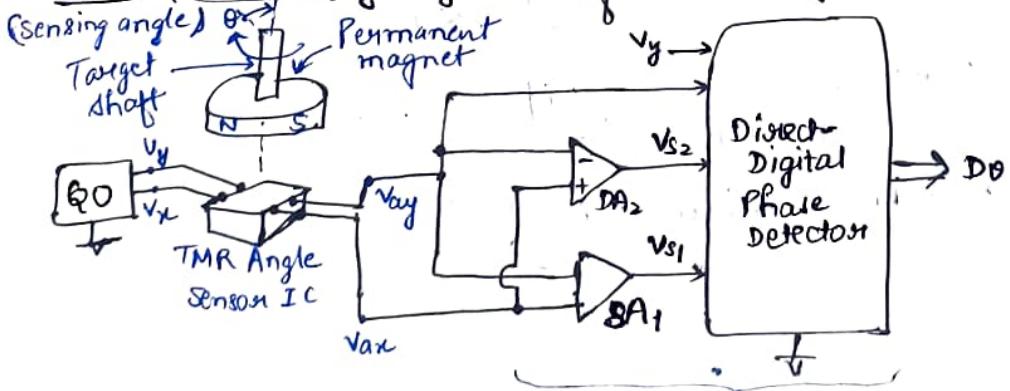
$$\% \text{ error} = \frac{D_\theta - \theta}{360^\circ} \times 100 \%$$

$\rightarrow$  Drastically reduced from the prev. approach

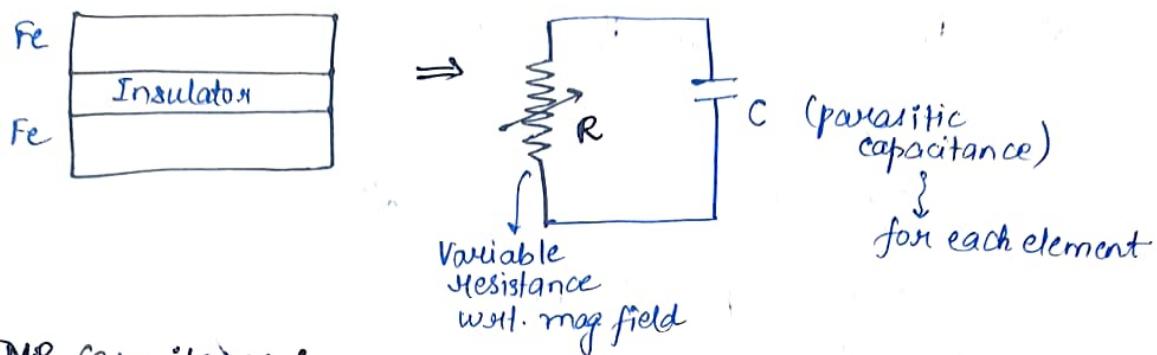
- Compensates the adverse effect of QO phase-error ( $\Psi$ ).
- Indep. of  $K_T$  and excitation voltage.



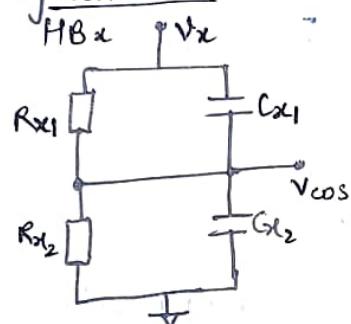
## LDTA (Linearizing Digitizer for TMR Angle Sensor)



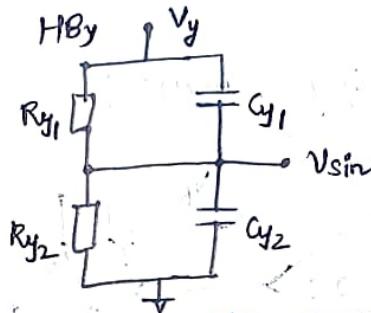
## TMR element:



## TMR Capacitance:



$$V_{cos} = K_T V_M \cos(\omega t - \delta \cos) \cos \theta$$



$$V_{sin} = K_T V_M \sin(\omega t - \delta \sin) \sin \theta$$

→ TMR capacitances do not affect the o/p.

→ Phase error of QD (Quadrature Oscillator)

→ Parasitic capacitances of TMR elements

↳ Mitigation:

Excitation using DC (open-circuited cap.)

$$\cos \theta \rightarrow 0$$

$\mathcal{M}$

Mitigation:  
If QD is avoided  
by using a single  
sine-wave.

## Linear MR Angle Transducers using DC Excitation

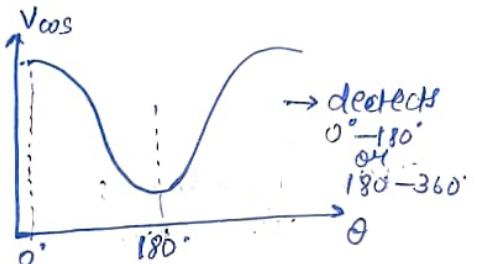
$$V_{\cos} = K_T V_x \cos \theta, \quad V_{\sin} = K_T V_y \cos \theta$$

↪ constant/dc for  
a given  $\theta$

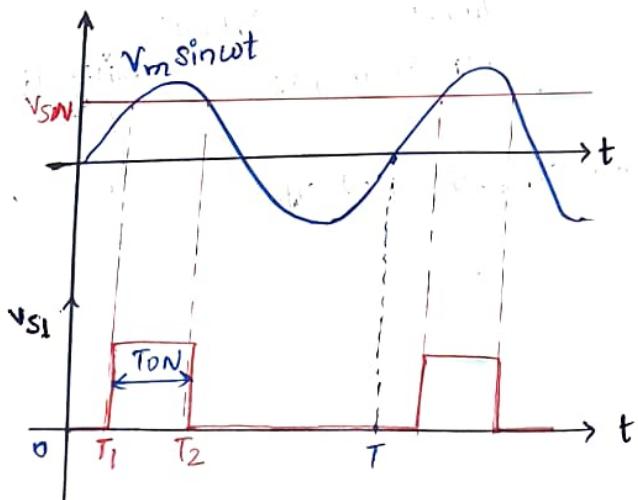
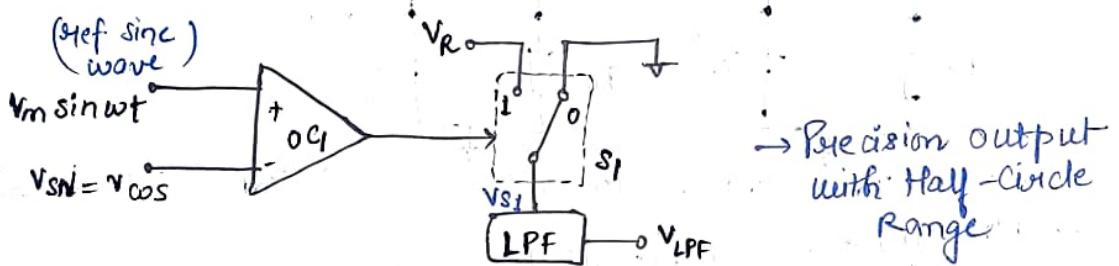
$$V_x = V_y = V_{DC}$$

$$V_{\cos} = V_{SN} \rightarrow O/P \text{ for sensor}$$

$$V_{SN} = V_{SN_0} \cos \theta$$



### Single conditioning Scheme:



$$\begin{aligned} V_m \sin \omega t &= V_{SN} \\ &= V_m \cos \theta \\ \Rightarrow t &= \frac{1}{\omega} \left( \frac{\pi}{2} \pm \theta \right) \end{aligned}$$

$$T_1 = \frac{1}{\omega} \left( \frac{\pi}{2} - \theta \right), \quad T_2 = \frac{1}{\omega} \left( \frac{\pi}{2} + \theta \right)$$

$$\begin{aligned} T_{ON} &= T_2 - T_1 \\ &= \frac{2\theta}{2\pi} \cdot T \end{aligned}$$

$$\Rightarrow \frac{T_{ON}}{T} = \frac{\theta}{\pi}$$

$$V_{SN} = V_{SN_0} \cos \theta$$

$$\text{choose } V_m = V_{SN_0}$$

↪ may not match exactly

↓ error will be significant near  $0^\circ$  &  $180^\circ$ .

(low sensitivity regions of sensor O/P)  
(where rate of change is small)

$V_{LPF} = \text{average } (V_{st})$

$$= V_R \frac{T_{DN}}{\pi}$$

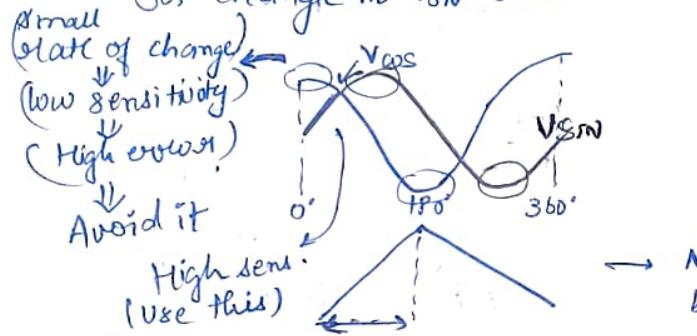
$$\boxed{V_{LPF} = V_R \frac{\theta}{\pi}}$$

$V_R$ : DC Ref. voltage  
 $(0 < \theta < \pi)$

$$\left[ \frac{d\theta}{dt} \ll \omega \right]$$

We have assumed that  $V_{SN}$  is constant for atleast few cycles.

So, change in  $V_{SN} \ll \omega$ .



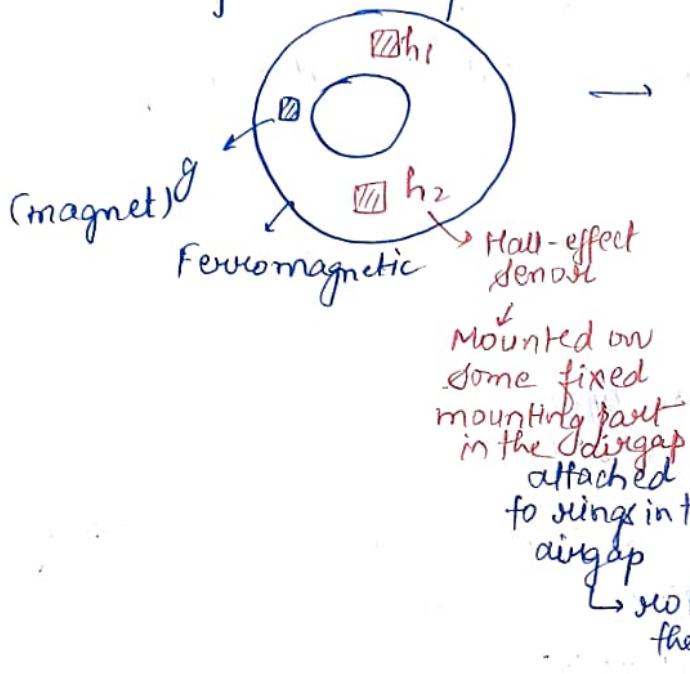
Avoid low sensitivity regions and use only high sensitivity regions  $\rightarrow$  by switching between sin and cos.

$\hookrightarrow$  Difficult to use in through shaft

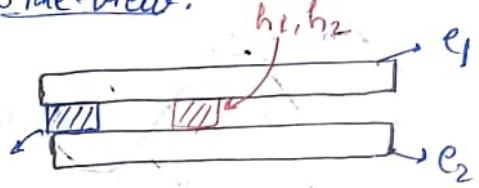
$\hookrightarrow$  ~~Hall~~ Use hall-effect sensor.

# A linear Reluctance - Hall Effect Based Angle Sensor

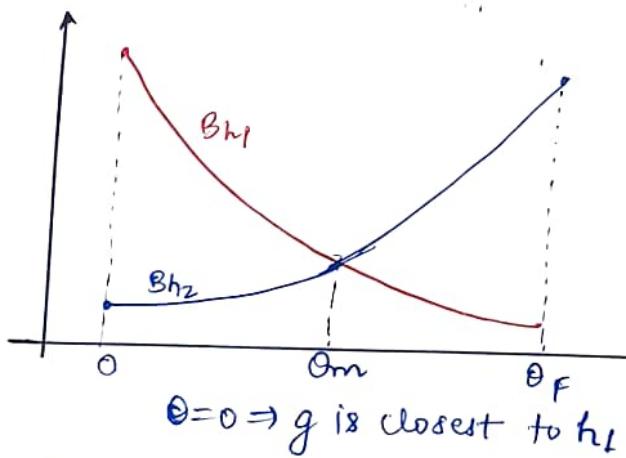
When the shaft is inaccessible, attach the sensor as a ring at a particular position.



( $e_1, e_2$ )  
Use two such rings in proximity with a small gap:  
Side-view:



$e_1, e_2, g \rightarrow$  rotating parts  
 $h_1, h_2 \rightarrow$  fixed



Mag. flux {  $B_{h_1}$  : seen by  $h_1$ ,  
 $B_{h_2}$  : seen by  $h_2$

OF: full angle-scale angle  
Om: mid-scale angle

Ideal angle range =  $180^\circ$

Characteristic of the sensor is cubic in nature.

$$B_{h_1} \approx a_1 \theta^3 + a_2 \theta^2 + a_3 \theta + a_4$$

$$B_{h_2} \approx b_1 \theta^3 + b_2 \theta^2 + b_3 \theta + b_4$$

Hall-effect sensor is linear.

$$\left. \begin{array}{l} V_{H_1} = V_B [1 + K B_{H_1}] \\ V_{H_2} = V_B [1 + K B_{H_2}] \end{array} \right\} \text{Hall IC } \text{O/P}$$

$$\Rightarrow V_{H_1}(\theta) = c_1 \theta^3 + c_2 \theta^2 + c_3 \theta + c_4$$

$$V_{H_2}(\theta) = d_1 \theta^3 + d_2 \theta^2 + d_3 \theta + d_4$$

## Linearization Methodology

$$\text{Hall IC outputs, } V_{H_1}(\theta) = V_B (1 + K B_{H_1}(\theta))$$

$$V_{H_2}(\theta) = V_B (1 + K B_{H_2}(\theta))$$

$$\Rightarrow V_{H_1}(\theta) = c_1 \theta^3 + c_2 \theta^2 + c_3 \theta + c_4$$

$$V_{H_2}(\theta) = d_1 \theta^3 + d_2 \theta^2 + d_3 \theta + d_4.$$

$B_{H_2}$  can be represented as mirrored and shifted version of  $B_{H_1}$ .

$$B_{H_2}(\theta) = B_{H_1}(-\theta + \theta_F)$$

$$V_{H_2}(\theta) = V_{H_1}(-\theta + \theta_F)$$

$$\Rightarrow V_{H_2}(\theta) = c_1 [-\theta + \theta_F]^3 + c_2 [-\theta + \theta_F]^2 + c_3 (-\theta + \theta_F) + c_4$$

$$\text{coeff. of } \theta^3 = -c_1 = d_1$$

$$\therefore V_{H_2}(\theta) = -c_1 \theta^3 + d_2 \theta^2 + d_3 \theta + d_4.$$

$$V_D = V_{H_1} - V_{H_2}$$

↓  
cubic

(crosses zero at  $\theta_m$ ;

also symmetric

about  $\theta_m$ : Real root:  $\theta_m$

Roots:  $\theta = \theta_m, \theta_m \pm \alpha j$

$$V_A = V_{H_1} + V_{H_2}$$

↓  
quadratic

never crosses zero: complex roots

↓  
symmetric about  $\theta_m$ : Roots =  $\theta_m \pm \beta j$   
(real part of roots =  $\theta_m$ )

$$V_D = K_N (\theta - \theta_m) (\theta - (\theta_m - \alpha j)) \\ (\theta - (\theta_m + \alpha j))$$

$$| \begin{array}{l} K_N = 2c_1 \\ K_D = c_1 + d_1 \end{array}$$

$$= K (\theta - \theta_m) [\theta^2 - 2\theta_m \theta + \theta_m^2 + \alpha^2],$$

$$V_A = K_D [\theta^2 - 2\theta_m \theta + \theta_m^2 + \beta^2]$$

$$\text{Define } V_0(\theta) = \frac{V_{H_1}(\theta) - V_{H_2}(\theta)}{V_{H_1}(\theta) + V_{H_2}(\theta) + V_K} = \frac{V_D(\theta)}{V_A(\theta) + V_K}, \quad V_K: \text{constant for a sensor unit.}$$

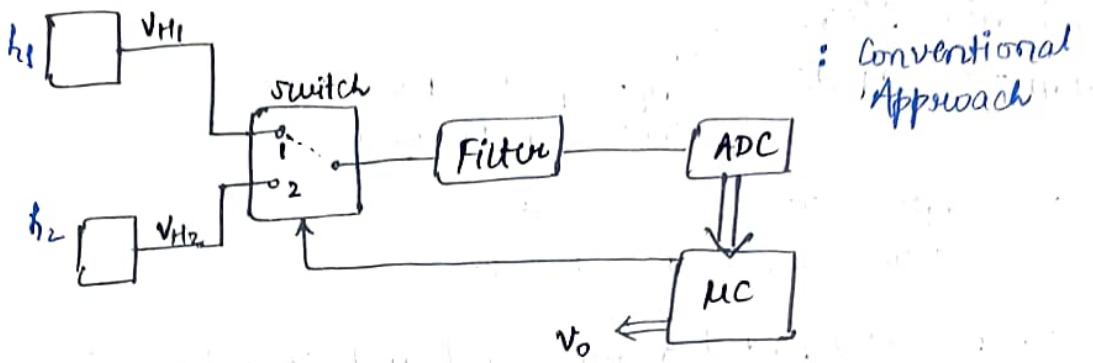
$$= \frac{K_N (\theta - \theta_m) [\theta^2 - 2\theta_m \theta + \theta_m^2 + \alpha^2]}{K_D [\theta^2 - 2\theta_m \theta + \theta_m^2 + \beta^2] + V_K}$$

$$= \frac{K_N (\theta - \theta_m) [\theta^2 - 2\theta_m \theta + \theta_m^2 + \alpha^2]}{[\theta^2 - 2\theta_m \theta + \theta_m^2 + \beta^2] + V_K/K_D}$$

choose  $V_K = K_D (\alpha^2 - \beta^2)$

[pole-zero cancellation idea]

$$\Rightarrow V_0(\theta) = \frac{K_N}{K_D} (\theta - \theta_m).$$



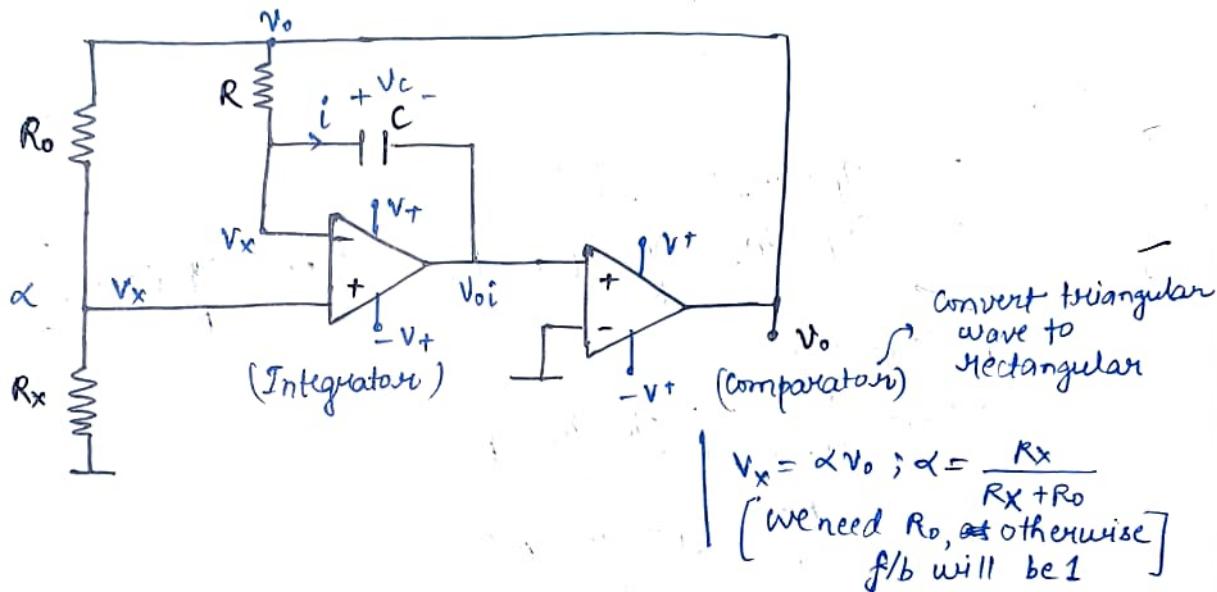
First keep the switch (multiplexer) to pos. 1, then to 2. Give the control signal back to the switch from a microcontroller which configured to calculate  $v_o$ , then gives  $v_o$ .

- Better dedicated circuit in the research paper.
- Cannot have a dedicated ADC for each sensor.

## Resistive Sensors

Eg: GMR, LDR

- Digitizers to digitize resistive sensor without ADC.
- Relaxation - Oscillator  $\rightarrow$  2 o/p's  $\rightarrow$  Triangular  
Rectangular.



$V_o$ :

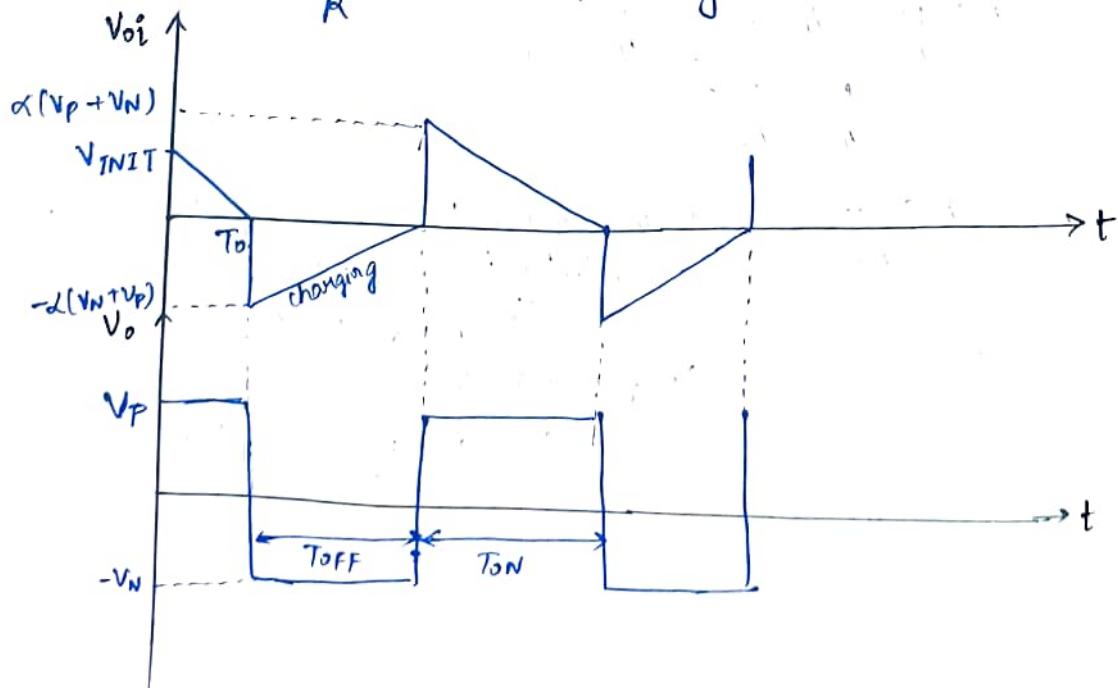
$v_p \approx V_p$  (drop due to C & E drop on o/p side transistor of comparator)

$-v_N \approx -V_N$

$$i = \frac{V_o - V_x}{R}$$

$$i = \frac{V_o}{R} (1 - \alpha)$$

$$i = \frac{V_p}{R} (1 - \alpha) \quad [\text{During } T_{ON}]$$



At  $T_0^-$ ,

$$V_{oi} \approx 0, V_x = \alpha V_p$$

$$V_{oi} + V_c = V_x$$

$$\Rightarrow V_c = V_x - V_{oi}$$

$$\Rightarrow V_c = \alpha V_p \rightarrow \text{storing voltage}$$

At  $T_0^+$ ,

$$V_c = \alpha V_p$$

$$V_x = -\alpha V_N$$

$$V_{oi} = V_x - V_c$$

$$V_{oi} = -\alpha(V_N + V_p)$$

$$i = \frac{V_o}{R} (1-\alpha) \rightarrow \text{Negative after } T_0.$$

$T_{ON}$ :

31-10-2025

$$V_{oi} = \alpha [V_p + V_N] - \frac{1}{C} \int i dt$$

$$= \alpha [V_p + V_N] - \frac{V_p}{RC} (1-\alpha) t \quad \left[ \therefore i = \frac{V_p}{R} (1-\alpha) \right]$$

$$V_{oi}(T_{ON}) = 0$$

$$\Rightarrow T_{ON} = \left( \frac{\alpha}{1-\alpha} \right) \left( \frac{V_p + V_N}{V_p} \right) RC$$

$$= \frac{R_x}{R_o} \left( \frac{V_p + V_N}{V_p} \right) RC$$

↳  $R_x$  can be estimated from  $T_{ON}$  (timer)

↳  $T_{ON}$  also depends on  $V_p, V_N$ .

$$T_{OFF} = \frac{R_x}{R_o} \left( \frac{V_N + V_p}{V_N} \right) RC \quad [\text{Interchange } V_N \text{ & } V_p \text{ in } T_{ON}]$$

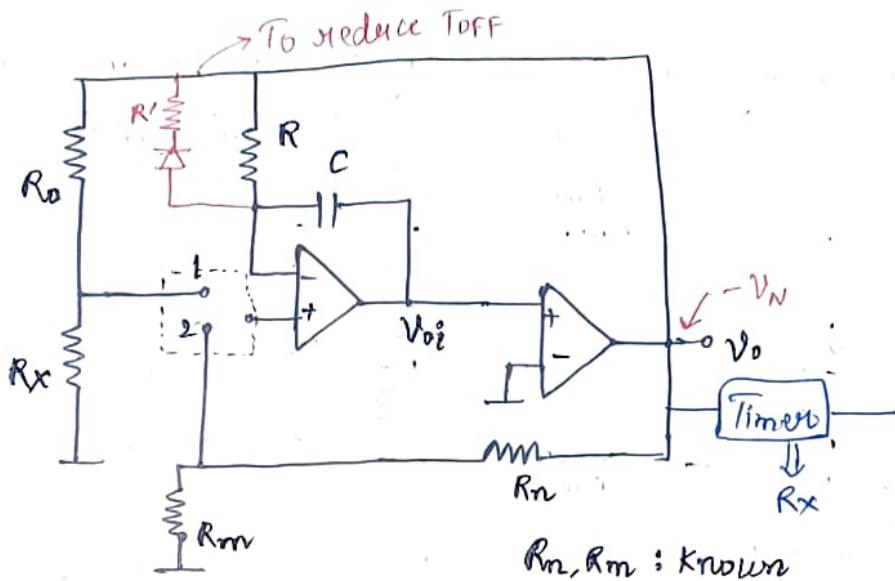
Define  $F = \frac{T_{ON}}{T_{OFF}}$

$$= \frac{\frac{T_{ON}}{T_{OFF}}}{\left[ \frac{R_x}{R_o} \left( \frac{V_p + V_N}{V_p} \right) RC \right]} \left[ \frac{1}{V_p} \cdot \frac{1}{V_N} \right]$$
$$= \frac{\left[ \frac{1}{V_p} + \frac{1}{V_N} \right]}{\frac{R_x}{R_o} \cdot RC}$$

=  $\frac{RC R_x}{R_o}$ . → if we find  $F$ , we can get correct estimation of  $R_x$   
(indep. of  $V_p, V_N$ )

↳ Depends on  $C$  (having high drifts).

↳ Replace by 2 resistors.



Mode -1:  $T_{ON_1}, T_{OFF_1}$

$$T_{ON_1} = \frac{R_x}{R_o} \left( \frac{V_p + V_N}{V_p} \right) R C$$

Mode -2:  $T_{ON_2}, T_{OFF_2}$

$$T_{ON_2} = \left( \frac{R_m}{R_n} \right) \left( \frac{V_p + V_N}{V_p} \right) R C$$

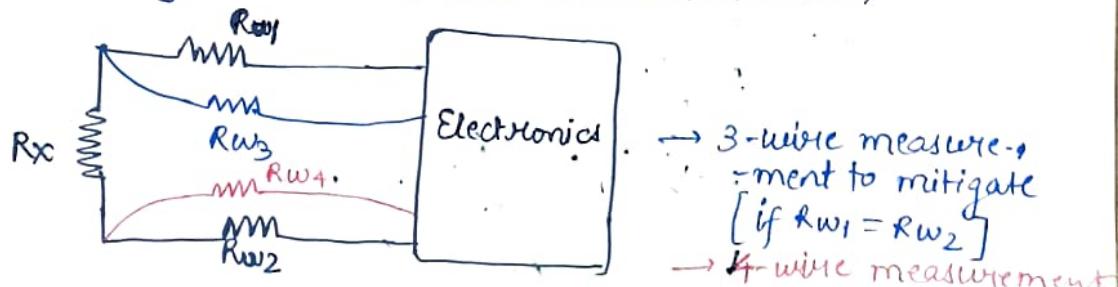
$$F = \frac{T_{ON_1}}{T_{OFF_2}} = \frac{R_x}{R_o} \cdot \frac{R_n}{R_m} \quad \text{(Digital quantity)}$$

$$\begin{aligned} \text{Conversion time} &= T_{ON_1} + T_{OFF_1} + T_{ON_2} + T_{OFF_2} \\ &= \cancel{\left( \frac{R_x}{R_o} \right)} \left( \cancel{\frac{V_p + V_N}{V_p}} \right) / R C \end{aligned}$$

We want only  $T_{ON_1}, T_{ON_2} \Rightarrow$  Reduce  $T_{OFF_1}, T_{OFF_2}$ .

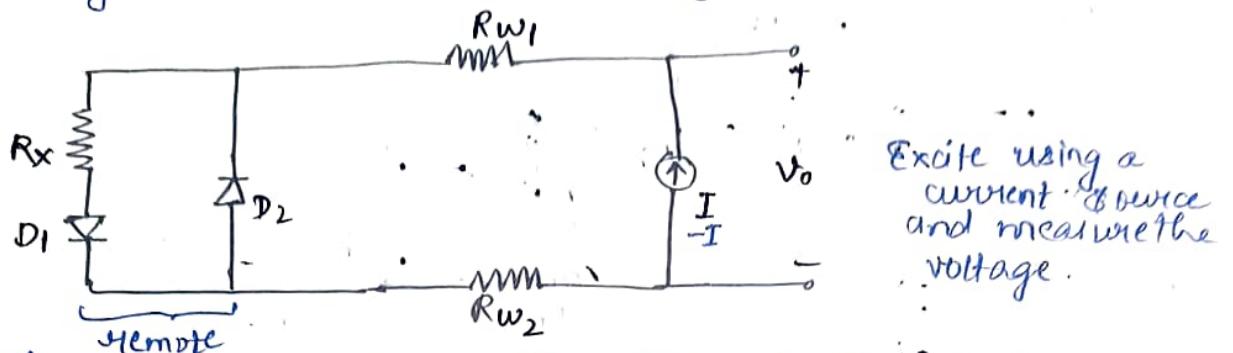
$$T_{OFF} = \frac{R_x}{R_o} \left( \frac{V_N + V_p}{V_N} \right) (R' || R) C$$

Usually, sensors are at remote locations connected by long connecting wires (with lead wire resistances).



$$R_x' = R_x + R_{w1} + R_{w2}$$

We may have many sensors. So, try to reduce the wires connecting sensors and electronics by two-wire measurement.



When  $I \rightarrow +ve$ : Current flows through  $R_{W1}$ ,  $R_x$ ,  $D_1$ ,  $R_{W2}$ .

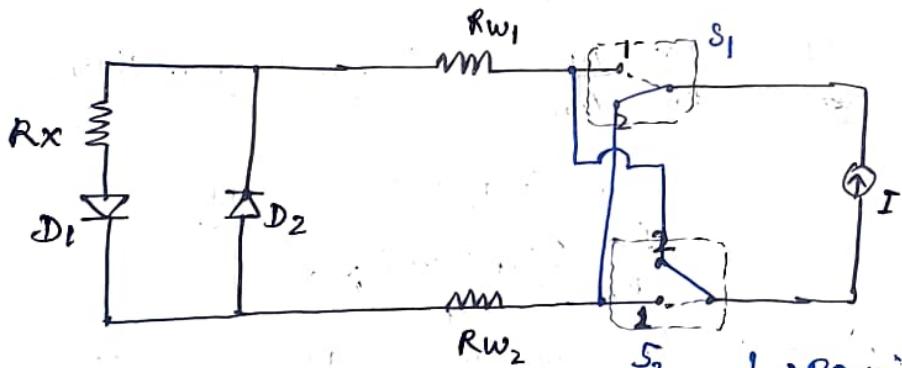
$$V_{O1} = I (R_{DN} + R_x + R_D + R_{W2}) \quad [\text{Across current source}]$$

When  $I \rightarrow -ve$ :

$$V_{O2} = -I (R_{W1} + R_D + R_{W2})$$

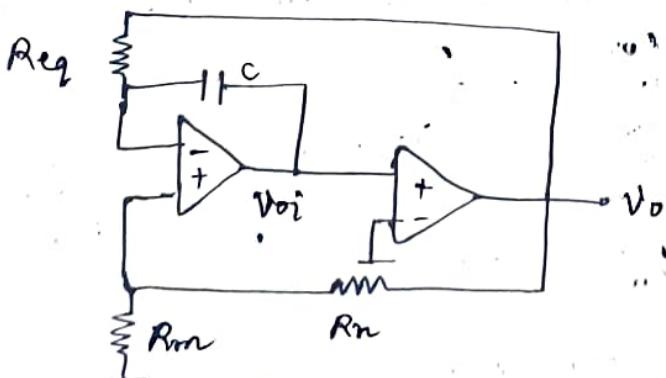
$$\Rightarrow V_{O1} + V_{O2} = IR_x \quad [\text{Non-idealities cancel}]$$

Demerit: Require ~~two~~ two matched diodes with same  $R_D$ .

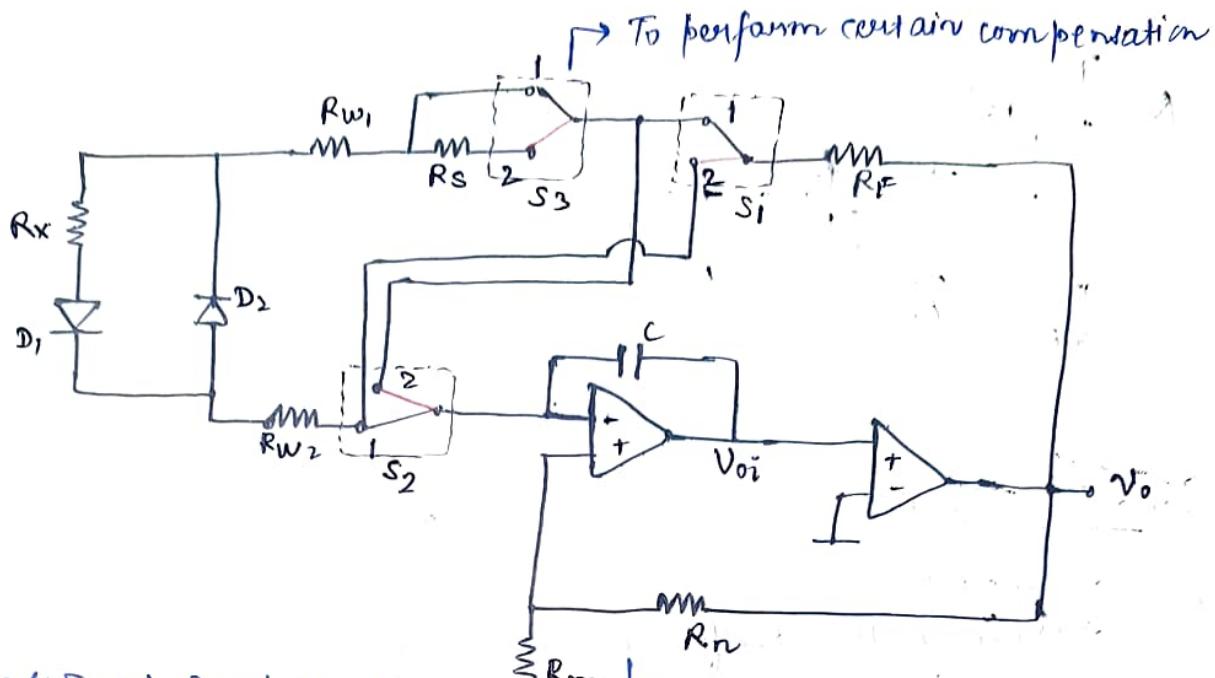


→ Requires only one current source.

Bring the sensor in the resistive feedback part of the electronics.



$$T_{ON} = \frac{R_m}{R_n} \left( \frac{V_p + V_N}{V_p} \right) R_{eq} C = k R_{eq}$$



Mode-1:  $S_1 \rightarrow 1, S_2 \rightarrow 1, S_3 \rightarrow 1$

$$\hookrightarrow R_{eq1} = R_F + R_S + R_{S3} + R_{W1} + R_X + R_D + R_{W2} + R_{S2}$$

$$\Rightarrow R_{eq1} = R_X + R_{com.}$$

all other common resistance

Mode-2:  $S_1 \rightarrow 2, S_2 \rightarrow 2, S_3 \rightarrow 2$

diode resistance

switch resistance

03-11-2025

$$T_{ON1} = R_{eq1} C \underbrace{\left( \frac{V_p + V_N}{V_p} \right)}_K \frac{R_m}{R_n} = K R_{eq1}$$

Mode-2:

$$S_1 \rightarrow 2, S_2 \rightarrow 2, S_3 \rightarrow 2$$

$$R_{eq2} = R_F + R_S + R_{W2} + R_D + R_{W1} + R_S + R_{S3} + R_{S2}$$

$$\Rightarrow R_{eq2} = R_S + R_{com.}$$

$$T_{ON2} = K R_{eq2}$$

Mode-3:

$$S_1, S_2 \rightarrow 2, S_3 \rightarrow 1$$

$$R_{eq3} = R_{com.} \quad (\text{same as mode-2 but } R_S \text{ is bypassed})$$

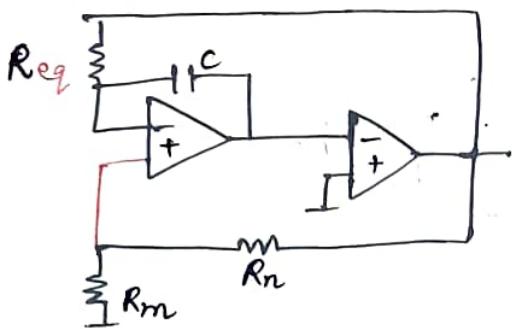
$$T_{ON3} = K R_{eq3}$$

$$F_2 = \frac{T_{ON1} - T_{ON3}}{T_{ON2} + T_{ON3}}$$

$$= \frac{R_{eq1} - R_{eq3}}{R_{eq2} - R_{eq3}}$$

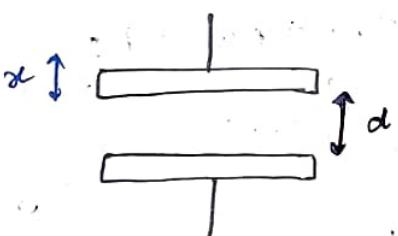
$$= \frac{R_X + R_{com} - R_{com}}{R_S + R_{com} - R_{com}} = \boxed{\frac{R_X}{R_S}}$$

→ indep. of  
lead wires  
( $R_{W1,2}$ )



## Capacitive Sensors

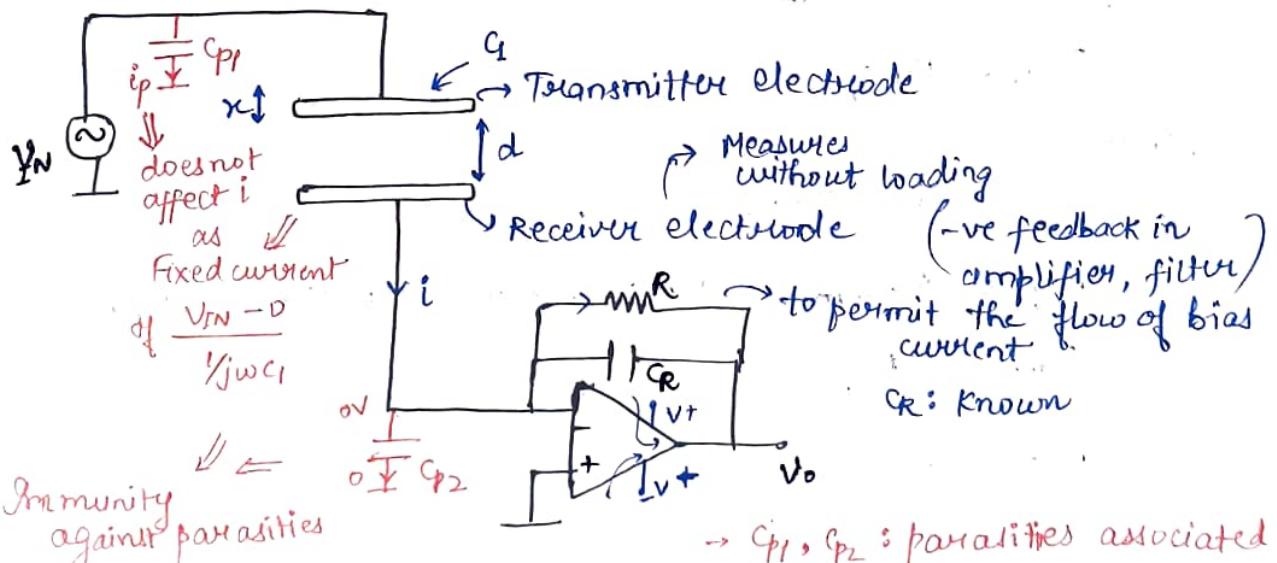
- ↳ compact
- ↳ no magnetic shielding, only electrical shielding needed
- ↳ low cost, low power



$$\text{Nominal capacitance, } C_0 = \frac{\epsilon A}{d}$$

when displacement b/w the plates change,

$$C_1 = \frac{\epsilon A}{d+x} = \frac{C_0}{1+x/d}$$

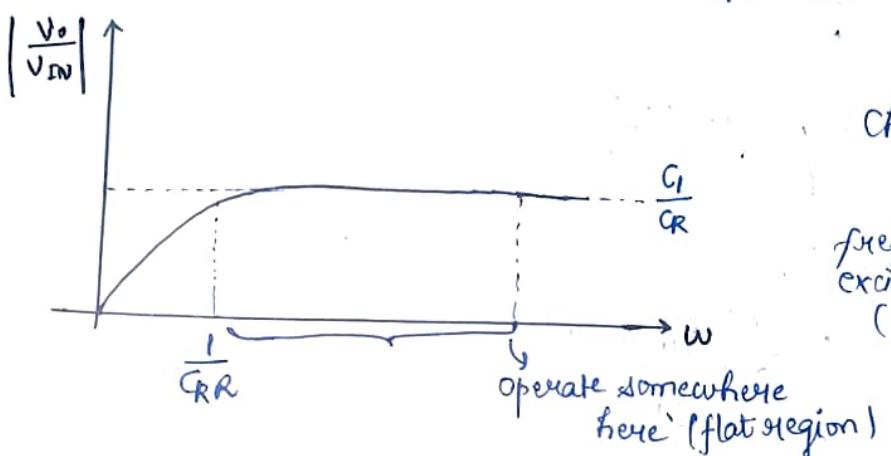


→  $C_1, C_2$ : parallel associated with tx & rx.

$C_1$  → Practical cap.; made of actual plates

$C_R$  → package.

$$\frac{V_o}{V_{IN}} = -\frac{j\omega C_1 R}{j\omega C_R R + 1} \Rightarrow \left| \frac{V_o}{V_{IN}} \right| = \frac{\omega C_1 R}{\sqrt{\omega^2 \cdot C_R^2 R^2 + 1}}$$



$$\frac{V_o}{V_{IN}} = -\frac{C_1}{C_R} \quad \left[ \text{at high freq., } \frac{1}{R} \rightarrow 0 \Rightarrow \frac{V_o}{V_{IN}} = -\frac{C_1}{j\omega C_R} \right]$$

$$V_o = -\frac{C_1 V_{IN}}{C_R} \quad [C_1 V_{IN} = q_{IN}]$$

$C_R \ll 1F$

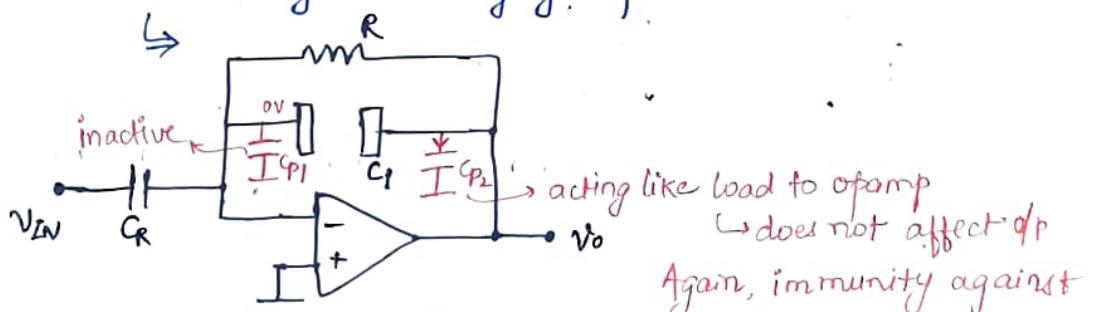
$V_o = -\frac{q_{IN}}{C_R}$  → charge amplifier;  
 charge is always conserved;  
 draws charge from power supply.

$$Q = \frac{C_0}{1 + x/d}$$

$$\frac{V_o}{V_{IN}} = -\frac{C_0}{C_R (1 + x/d)}$$

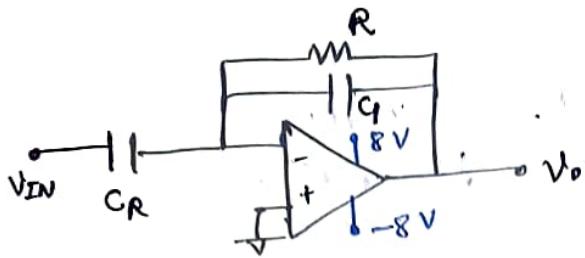
$$\boxed{\frac{V_o}{V_{IN}} = -\frac{C_R}{C_0} = -\frac{C_R}{C_0} (1 + x/d)} \quad [\text{To get } V_o \propto x]$$

Obtain this by interchanging capacitances.



$$\omega \gg \frac{1}{C_R R}$$

$x=0 \Rightarrow$  we have an offset  $(-\frac{C_R}{C_0}, -\frac{C_0}{C_R}) \Rightarrow$  limits sensor operating range  
 change in  $x$  is very minimal ⇒ larger change in voltage.  
 ⇒ limits the ~~span~~ span of  $x$  (limited by power supply)



$$\frac{V_o}{V_m} = -\frac{C_R}{C_0} = -\frac{C_R}{C_0} [1 + x/d]$$

For  $V_m = V_m \sin \omega t$ ,

$$V_o = -\frac{C_R}{C_0} \left[ 1 + \frac{x}{d} \right] V_m \sin \omega t$$

$\underbrace{\phantom{-\frac{C_R}{C_0} \left[ 1 + \frac{x}{d} \right] V_m \sin \omega t}}$   
 $V_{out}$

$$V_{out} = \frac{C_R}{C_0} [1 + x/d] V_m < 8V$$

$$x=0 \Rightarrow V_{out} = \frac{C_R}{C_0} V_m \\ = 7.5V$$

for  $V_m = 5V$

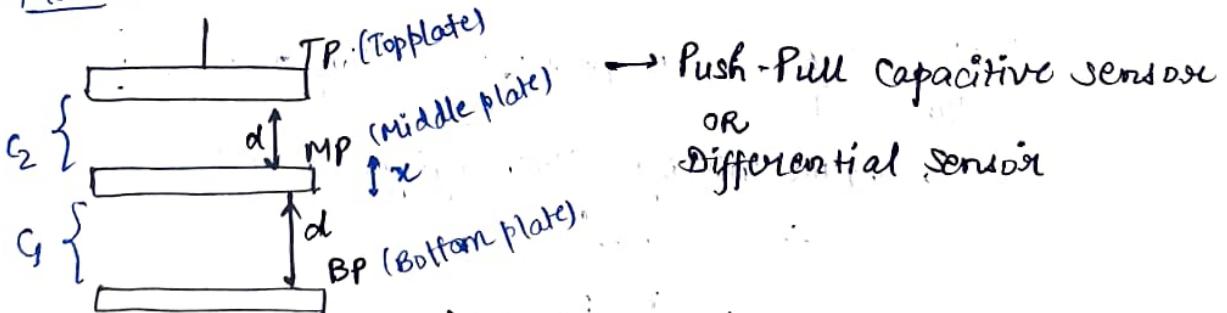
$$C_0 = 10nF$$

$$C_R = 15nF$$

$$7.5 \left[ 1 + \frac{x}{d} \right] < 8V$$

$\Rightarrow x < 0.067d$  → Limited by power supply offset voltage

Plates:



$x=0 \Rightarrow MP$  equidistant from TP & BP.

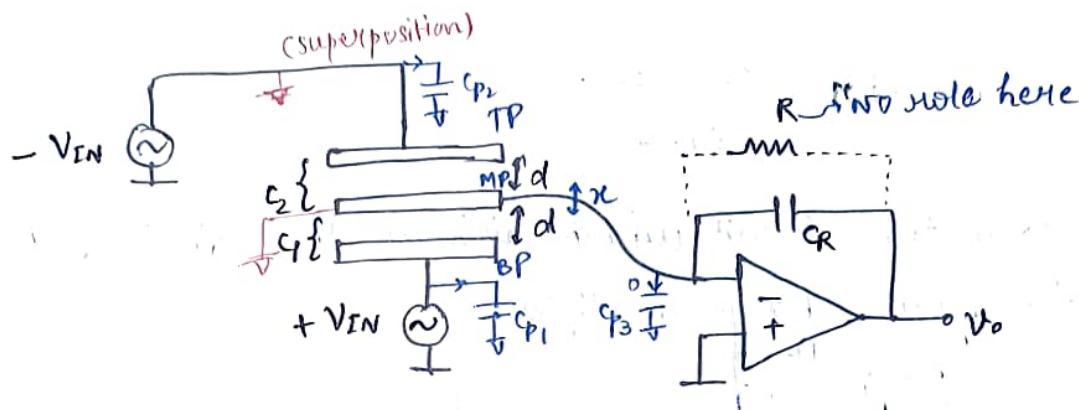
At  $x=0$ ,  $C_1 = C_2 = C_0$

$$C_1 = \frac{C_0}{1 + x/d}$$

$$C_2 = \frac{C_0}{1 - x/d}$$

$$C_2 - C_1 = \frac{2[C_0] \pi d}{1 - \alpha^2/d^2}$$

$$\alpha = 0 \Rightarrow C_2 - C_1 = 0$$



By superposition,

$$V_o = -\frac{G}{C_R} V_{IN} + \frac{C_2}{C_R} V_{IN}$$

$$\Rightarrow V_o = \frac{(C_2 - C_1)}{C_R} V_{IN}$$

→ No offset.

→ Non-linear w.r.t.  $\alpha$

→ Immunity against parasitics

↳ depends on  $(C_2 - C_1) \rightarrow$  depends on  $C_0 (= \frac{E_0 A}{d})$

↳ depends on capacitor dimension

Mitigation:

$$\begin{aligned} Z_2 \{ C_2 \} & \frac{V_{IN}}{\frac{1}{j\omega C_2}} \\ Z_1 \{ C_1 \} & \frac{-V_{IN}}{\frac{1}{j\omega C_1}} \end{aligned} \quad V_o = \frac{Z_1 V_{IN}}{Z_1 + Z_2} - \frac{Z_2 V_{IN}}{Z_1 + Z_2} = \left( \frac{Z_1 - Z_2}{Z_1 + Z_2} \right) V_{IN} = \left( \frac{x}{d} \right) V_{IN}$$

$$Z_1 = \frac{1}{j\omega C_1} = \underbrace{\frac{1}{j\omega C_0}}_{\text{Nominal impedance}} [1 + \alpha/d] = Z_0 [1 + \alpha/d]$$

$$Z_2 = Z_0 [1 - \alpha/d]$$

$$\Rightarrow V_o = \left( \frac{x}{d} \right) V_{IN} \quad \begin{aligned} &\rightarrow \text{Linear} \\ &\rightarrow \text{No offset} \\ &\rightarrow \text{Indep. from } C_0 \end{aligned}$$

## Parasitic effect (cp):

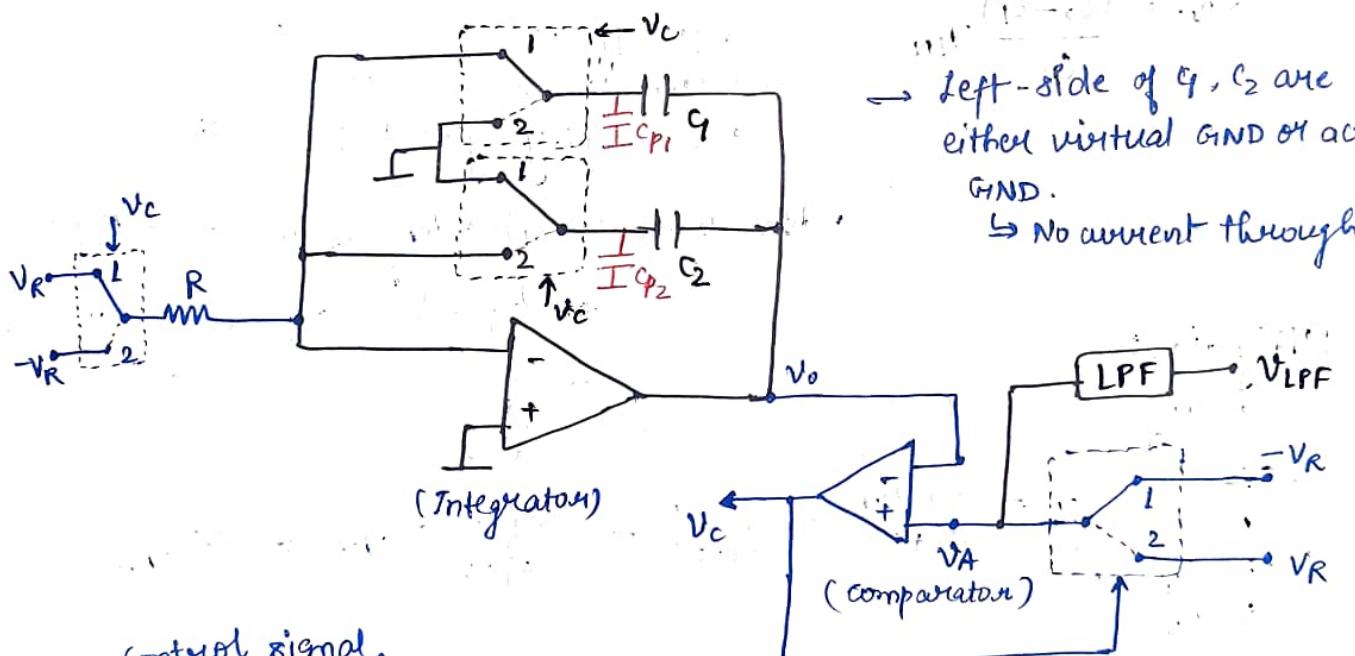
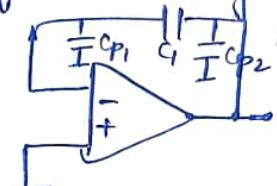
$C_{P1}, C_{P2} \rightarrow$  only draws some current  $\Rightarrow$  No effect on op voltage

$\varphi_3 \rightarrow$  affects  $V_0$

Ratiometric operation :  $\left( \frac{Z_1 - Z_2}{Z_1 + Z_2} \right)$

Make a statometeric circuit which without the effect of  $G$ .

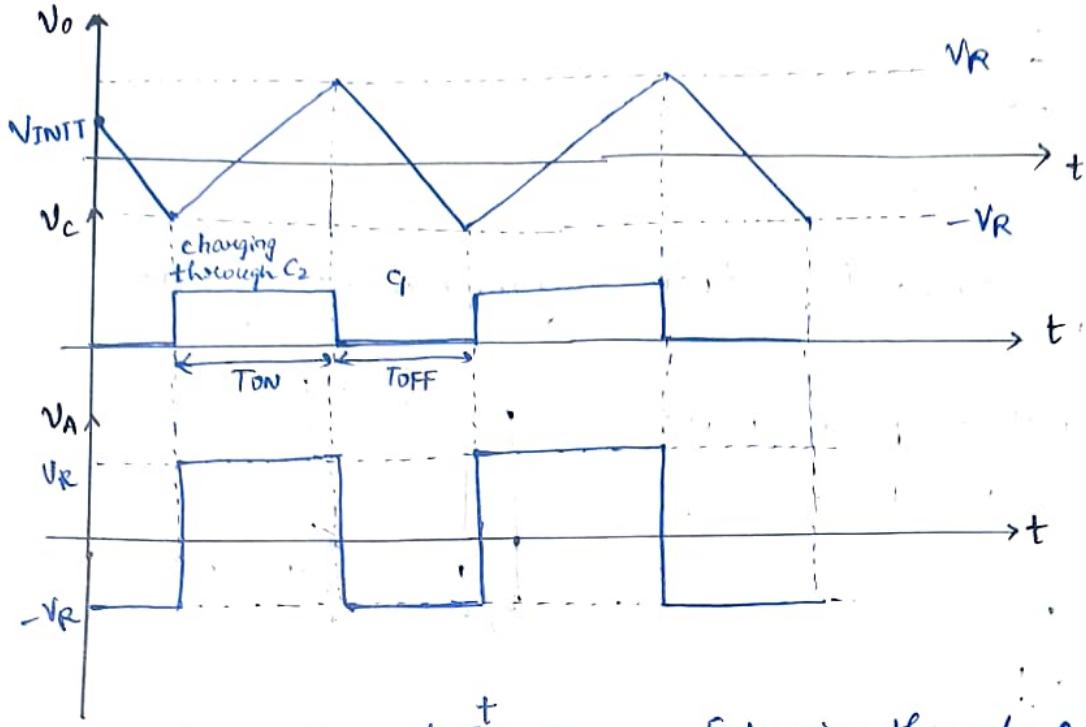
Inspiration from charge amplifiers:



control signal,

$$V_C = \text{Logic-low} \Rightarrow SW \rightarrow 1$$

Logic-high  $\Rightarrow$  SW-2



$$V_o = -V_R = \frac{1}{C_2} \int_{T_0}^t i dt \quad [\text{charging through } C_2]$$

$$= -V_R + \frac{1}{C_2} \int_{T_0}^t \frac{V_o}{R} dt$$

$$\Rightarrow V_o = -V_R + \frac{V_R}{RC_2} (t - T_0)$$

$\uparrow T_0 + T_{ON}$

$$\text{and, } V_o (T_0 + T_{ON}) = V_R$$

$$\Rightarrow \begin{cases} T_{ON} = 2RC_2 \\ T_{OFF} = 2RC_1 \end{cases}$$

$$\left( \frac{T_{ON} - T_{OFF}}{T_{ON} + T_{OFF}} \right) = \frac{C_2 - C_1}{C_2 + C_1} = \frac{Z_1 - Z_2}{Z_1 + Z_2} = \frac{x}{d}$$

$$\text{avg}(V_A) = \frac{V_R T_{ON} - V_R T_{OFF}}{T_{ON} + T_{OFF}} \rightarrow \text{to get } T_{ON}, T_{OFF} \text{ ratiometric}$$

$$\Rightarrow \text{avg}(V_A) = V_R \frac{\frac{T_{ON} - T_{OFF}}{T_{ON} + T_{OFF}}}{\frac{1}{d}} = V_R \frac{x}{d}$$

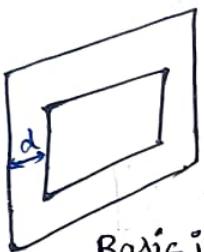
$$= V_{LPF}$$

$\rightarrow$  constant o/p for any given  $x$ , along with all other benefits.

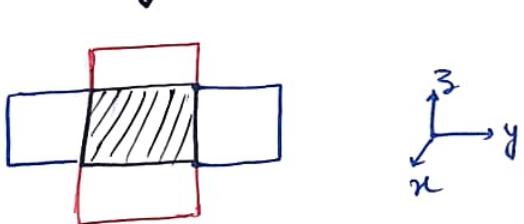
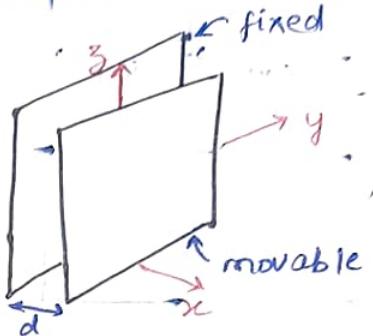


$$C = \frac{EA}{d}, V_0 = F(C_0)$$

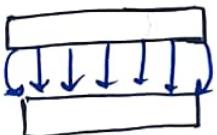
- If our axis of interest is  $z$ , then any movement in  $z$  is undesired.
- To mitigate that, keep one plate smaller than the other.



Basic idea



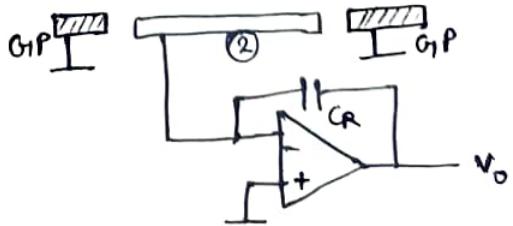
- Any movement in  $x$  and  $y$  axis won't change effective overlap area.
- Fringing effect:



$$C_0 = \frac{AE}{d}$$

$$C_{actual} \neq \frac{AE}{d}$$

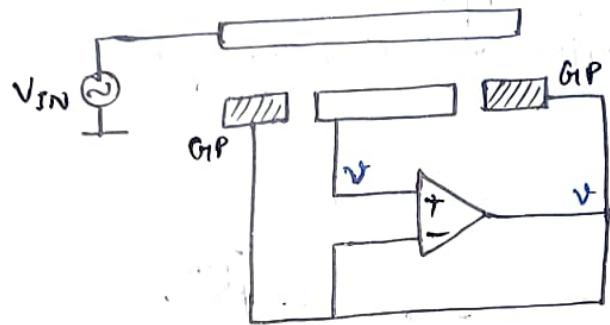
- To mitigate, use, guard plate (GIP):



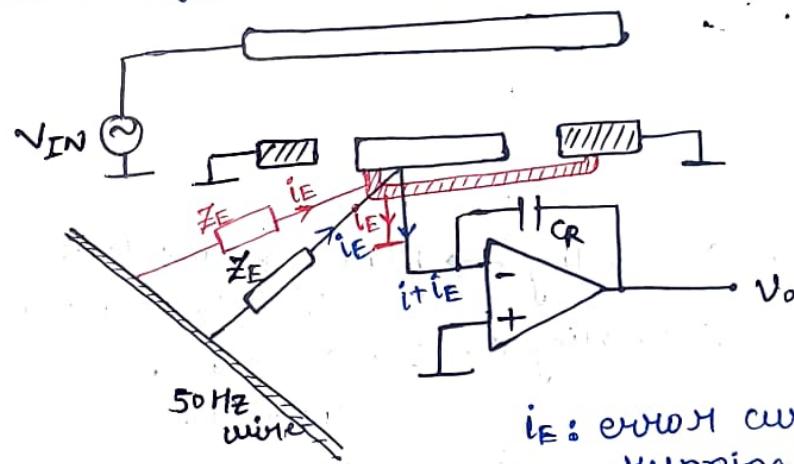
- Now, plate ② and guard plate should be at the same potential.
- Current due to fringing grounded to GIP, hence won't contribute to the actual current.

How to use the concept of guarding for voltage measurement of results?

→ connect GIP to the output of the opamp.



- Power-line interference:

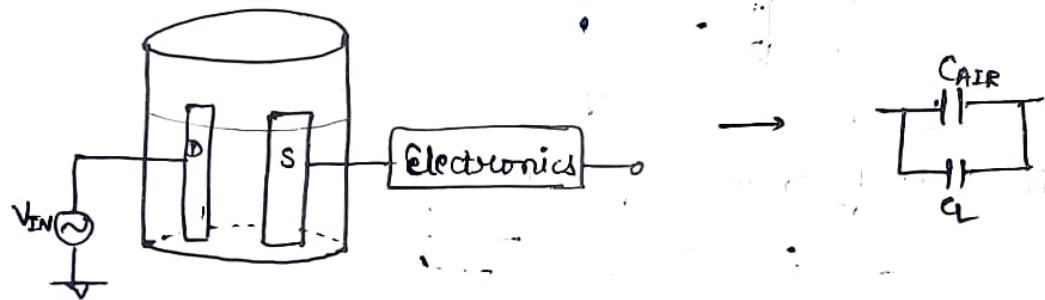


$i_E$ : error current to 50 Hz running power supply.

- To mitigate this, guard is suitably extended.
- Now, interference current is passed to ground through guard plate shield.

## Liquid Level Monitoring Sensor

- Fuel level, coolant level.
- Capacitive system  $\rightarrow$  volumetric property.
- Optical system  $\rightarrow$  surface property.
- Capacitive system have no sloshing system.
- Interference between two liquids.
- Independent of conductivity and viscosity of liquids.
- Dirty liquids.



### Real Issues:

Tank can be Conducting  $\rightarrow$  Place D & S inside the tank  
( $E$ -field cannot penetrate)

Insulating  $\rightarrow$  D & S can be placed inside or outside  
the tank.

Liquid can be conducting  $\rightarrow$  Electrodes should be insulated  
in case they are placed inside the  
tank.

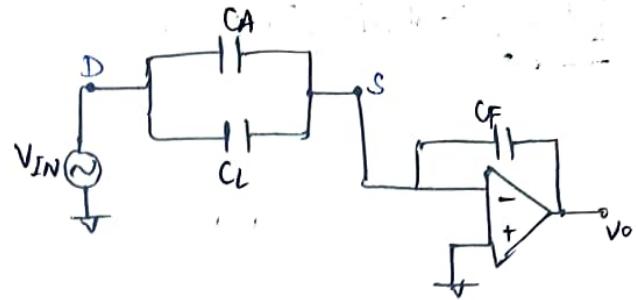
Dielectric  $\rightarrow$  works fine in either case.

## Dielectric liquid

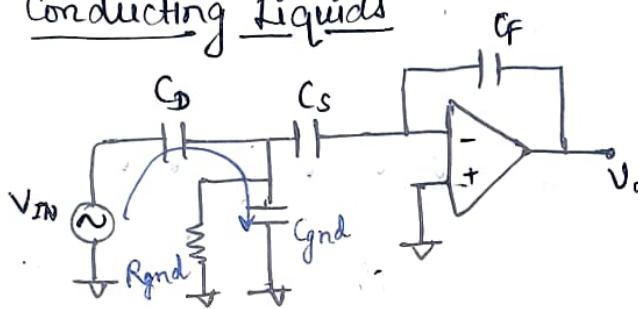
$$C_L \gg C_A$$

$$\frac{V_o}{V_{IN}} = -\frac{C_L}{C_F}$$

$H \uparrow, C_L \uparrow, V_o \uparrow$



## Conducting Liquids



$$C_{gnd} \gg C_D / C_S$$

$\frac{1}{SC_{gnd}}$  will be very small, hence provide a ground to  $V_{IN}$ .

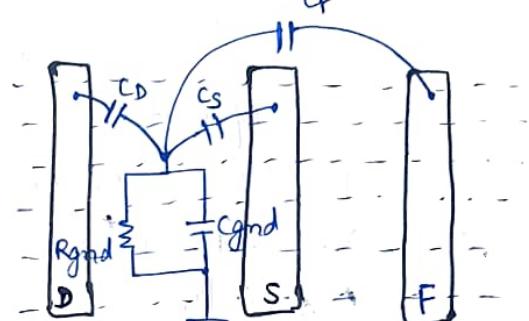
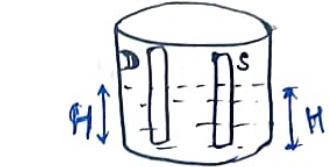
$$V_o \rightarrow 0$$

To mitigate this, bring one more electrode.

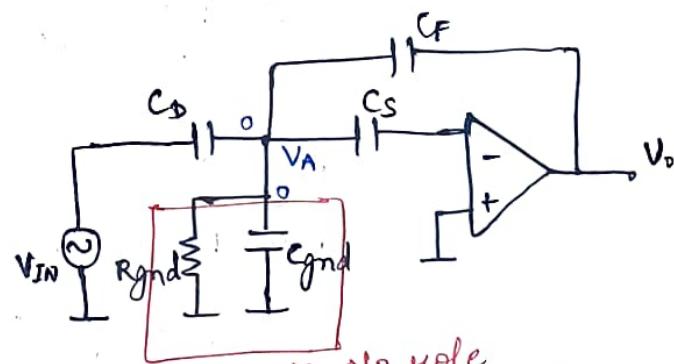
C\_F is now a feedback capacitor.

$$V_A = 0 \text{ (virtual ground)}$$

$$\frac{V_o}{V_{IN}} = -\frac{C_D}{C_F}$$

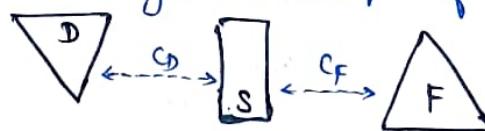


(extra electrode  
for feedback)



But now  $C_D = C_F$ , it will be a constant output. [cannot get  $V_o \propto \text{height}$ ]

To mitigate, change the shape of the electrode.

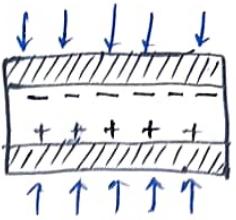


- Push-pull mechanism
- A good sensitivity.
- $\hookrightarrow \frac{C_D}{C_F} \uparrow \text{with height}$

Books: Larey K.  
Bacter-Capacitive  
Sensors (For more  
detail about capacitive  
sensors)

# Piezoelectric Sensors

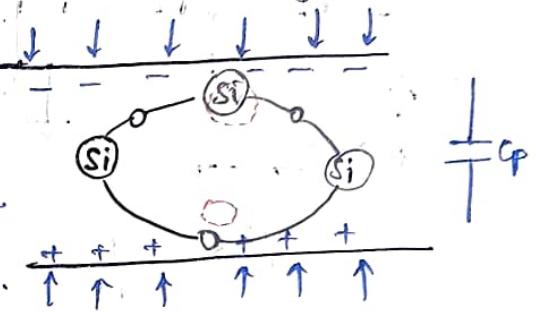
Material stress  $\xrightarrow{\text{Piezoelectric}}$  Electric potential  
 (sensitivity of force, acceleration,  
 pressure, ultrasonic receiver)



Electric potential  $\xrightarrow{\text{inverse-piezo-}} \text{electric}$  Material stress  
 (activation or development of)  
 ultrasonic transmitter

- Piezo or inverse piezo-effect can be observed in asymmetrical crystal lattice ( $\text{SiO}_2$ ).

- If we apply stress, Si-atom will suffer less movement than O-atom.
- $\hookrightarrow$  Leads to relative displacement of +ve and -ve charge carriers.
- $\hookrightarrow$  Leads to potential difference.



$$q \propto F$$

↑  
charge force

$$\Rightarrow q = df,$$

where d: charge sensitivity of  
piezo-material.

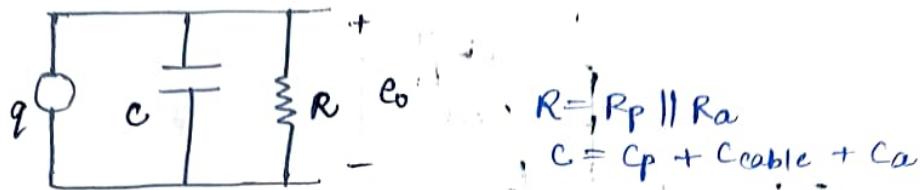
$$\text{For } \text{SiO}_2, d = 2.3 \text{ PC/N}$$

$$\text{For } \text{BaTi}_2\text{O}_3, d = 140 \text{ PC/N}$$

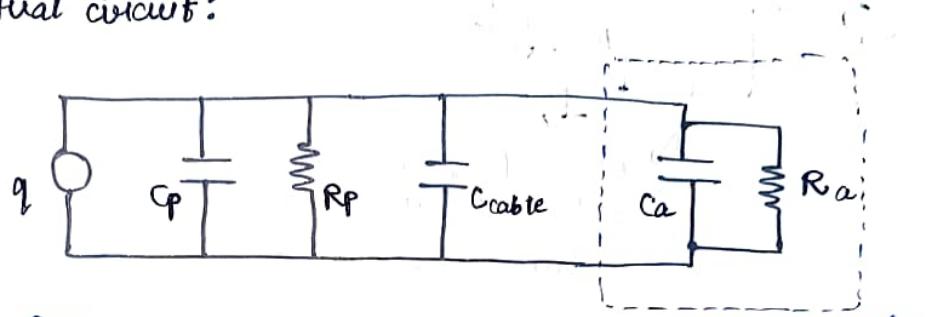
$C_p \rightarrow$  capacitance of the crystal.

$$V = \frac{q}{C_p} = \underbrace{\left(\frac{d}{C_p}\right)}_{\text{crystal voltage sensitivity}} f$$

## Equivalent circuit :



Actual circuit:



Feed: cable capacitance

C<sub>a</sub>: amplifier capacitance

R<sub>a</sub>: amplifier resistance

Apply KCL,

$$\frac{dq}{dt} = C \frac{de_0}{dt} + \frac{e_0}{R}$$

$$\Rightarrow R \frac{dq}{dt} = RC \frac{de_0}{dt} + e_0$$

Apply Laplace,

~~R<sub>s</sub>Q~~

$$R_s Q(s) = RC s E_0(s) + E_0(s)$$

$$\Rightarrow E_0(s) = \frac{R_s Q}{1 + SRC}$$

$$\Rightarrow \frac{E_0(s)}{Q} = \frac{R_s}{1 + SRC}$$

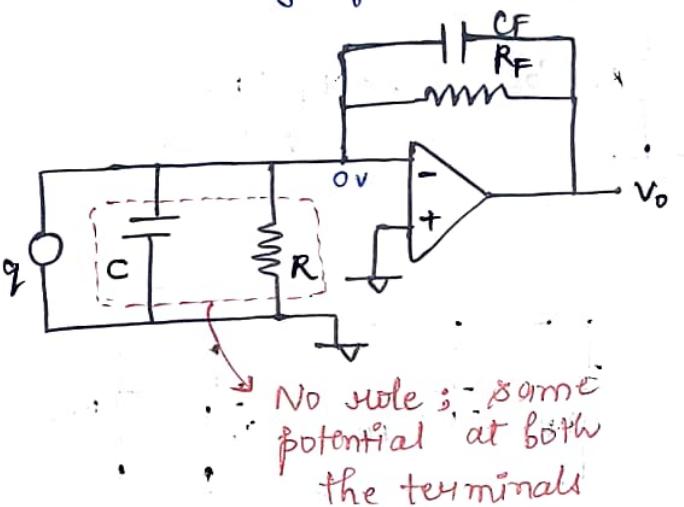
Also,  $Q(s) = dF(s)$ .

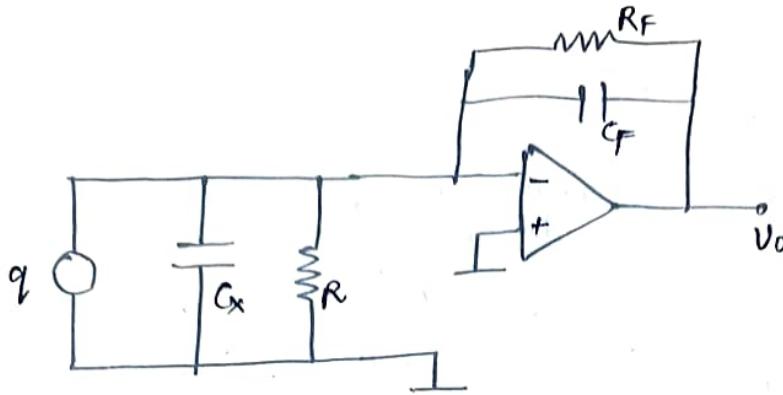
$$\Rightarrow \frac{E_0(s)}{F(s)} = \frac{R ds}{1 + SRC}$$

$$\therefore T = RC$$

$$\therefore \frac{E_0(s)}{F(s)} = \frac{T \frac{d}{C} s}{Ts + 1} \rightarrow \text{High-pass Response}$$

→ Piezo-electric can only sense varying (dynamic) forces  
but not steady forces.





$$\frac{V_o}{F}(s) = - \frac{T \left( \frac{d}{C_F} \right) s}{Ts + 1},$$

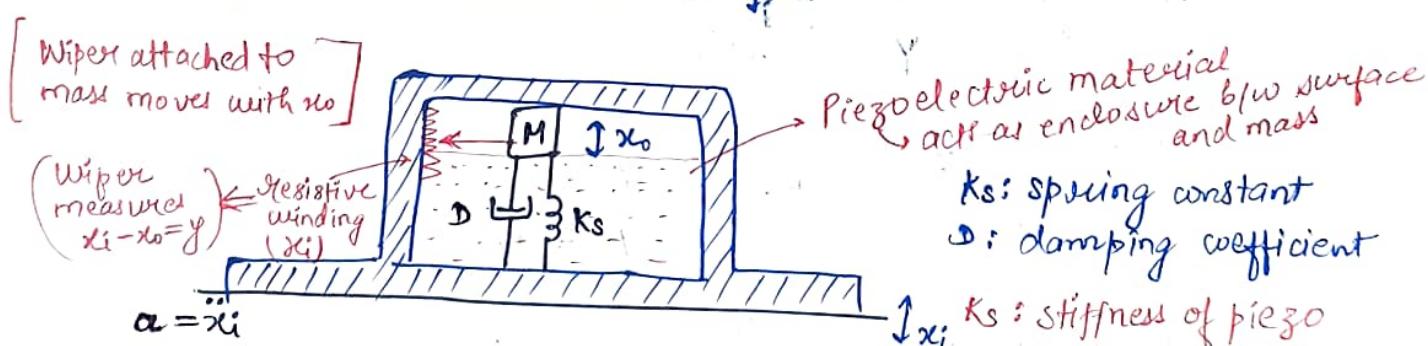
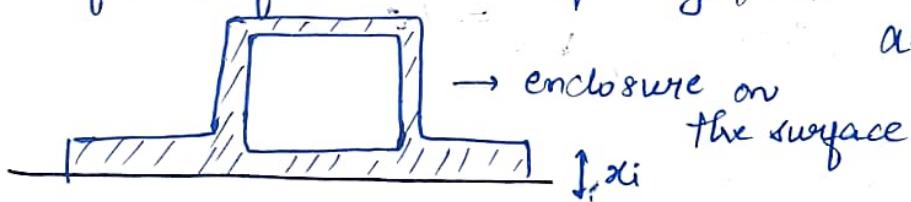
$$T = R_F C_F$$

$$\frac{dq}{dt} + \frac{V_o}{RF} + C_F \frac{dV_o}{dt} = 0$$

$$RF C_F \ddot{V}_o + V_o = -R \ddot{q}$$

### Piezoelectric Acceleration Accelerometer :-

↳ No reference frame (cannot fix any part)  $x_i$  : I/p displacement  
 $a = \ddot{x}_i \rightarrow$  to measure



$$k_s(x_i - x_0) + D \frac{dy}{dt} (x_i - x_0) = M \frac{d^2 x_0}{dt^2}$$

Define  $y = x_i - x_0 \rightarrow$  relative displacement of  $x_i$  wrt.  $x_0$ .

$$\Rightarrow k_s y + D \frac{dy}{dt} = M \frac{d^2 y}{dt^2} (x_i - y)$$

$$\Rightarrow M \frac{d^2 y}{dt^2} + D \frac{dy}{dt} + k_s y = M \frac{d^2 x_0}{dt^2}$$

$$\Rightarrow \frac{d^2y}{dt^2} + \frac{D}{M} \frac{dy}{dt} + \frac{K_s}{M} y = a$$

$\Rightarrow \ddot{y} + \frac{D}{M} \dot{y} + \frac{K_s}{M} y = a \rightarrow$  In inertial accel', 'a' can be found by determining 'y'.

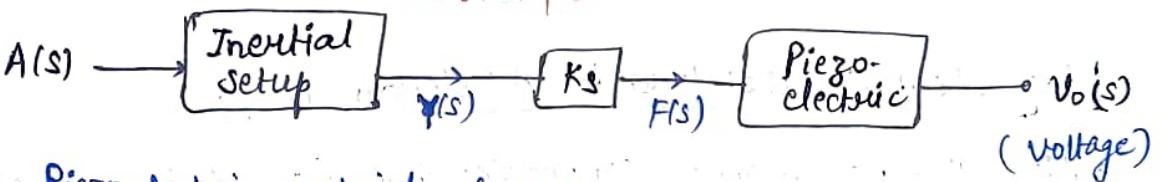
$$\begin{aligned} \Rightarrow \frac{Y(s)}{A(s)} &= \frac{1}{s^2 + \frac{D}{M}s + \frac{K_s}{M}} \quad \rightarrow \text{2nd-order behaviour} \\ &= \frac{1}{s^2 + 2\xi\omega_n s + \omega_n^2} \quad \hookrightarrow \text{use } \xi \text{ (damping ratio), } \omega_n \text{ (natural freq.)} \end{aligned}$$

where,

$$\omega_n = \sqrt{\frac{K_s}{M}}$$

$$\downarrow \xi = \frac{D}{2\sqrt{K_s M}} \quad \begin{matrix} \rightarrow \text{contributed due} \\ \text{to friction} (\downarrow) \end{matrix}$$

Underdamped



Piezoelectric material experiences 'y' & then a force

$$\left\{ \begin{array}{l} F(s) \\ Y(s) \end{array} \right. = K_s$$

$$\frac{V_o(s)}{A} = \frac{V_o(s)}{F} \cdot \frac{F}{Y} \cdot \frac{Y}{A(s)}$$

$$\frac{V_o(s)}{A} = \frac{T \frac{d}{c} s}{Ts + 1} \cdot K_s \cdot \frac{1}{s^2 + 2\xi\omega_n s + \omega_n^2} \quad \rightarrow \text{3rd-order instrument}$$

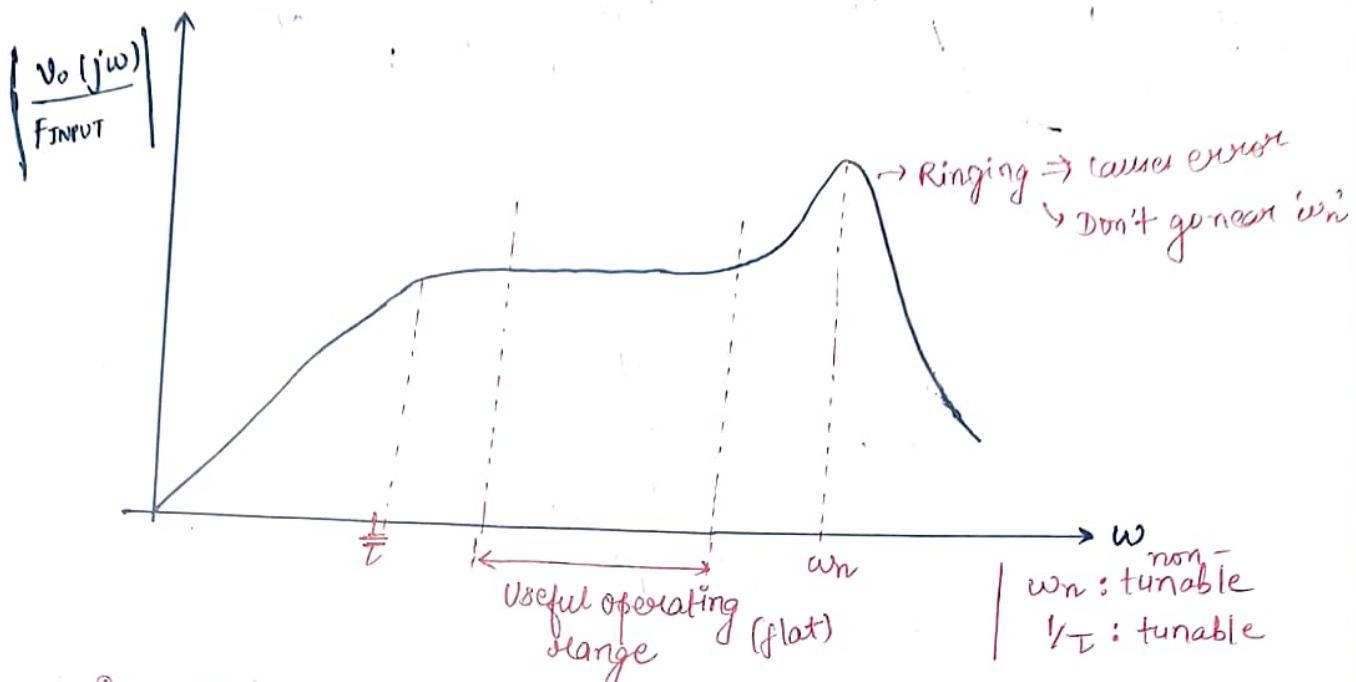
Total dynamic force in the system,

$$F_{\text{INPUT}}(s) \approx M A(s) \quad [\text{Total mass } \approx A(s)]$$

$$\therefore \frac{V_o}{F_{\text{INPUT}}} (s) = \frac{T \frac{d}{c} s}{Ts + 1} \cdot \frac{K_s / M}{s^2 + 2\xi\omega_n s + \omega_n^2}$$

$$\begin{aligned} \text{O/p wrt.} \\ \text{I/p} \end{aligned} \quad = \frac{T d/c s}{Ts + 1} \cdot \frac{\omega_n^2}{s^2 + 2\xi\omega_n s + \omega_n^2}$$

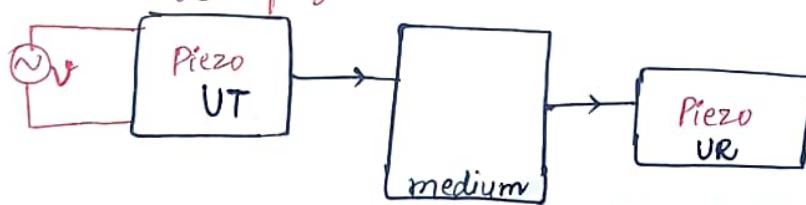
Take  $s=j\omega$ .



Piezoelectric accelerometer: Gives direct voltage output without requiring any batteries.

### Ultrasonic Measurement System

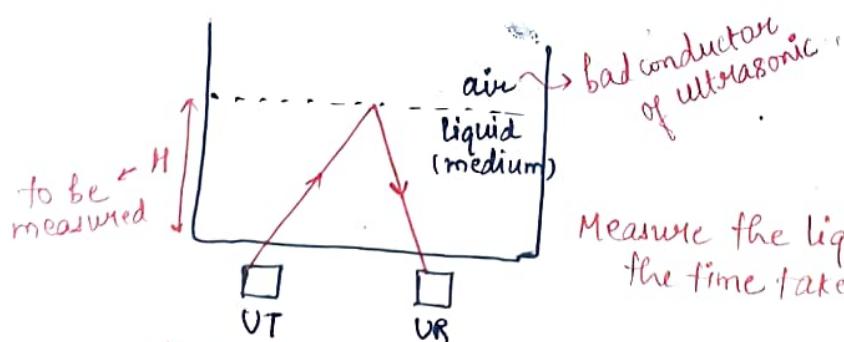
↳ Uses piezo



↳ contains info. about the physical quantity to measure

UT: Ultrasonic Transmitter

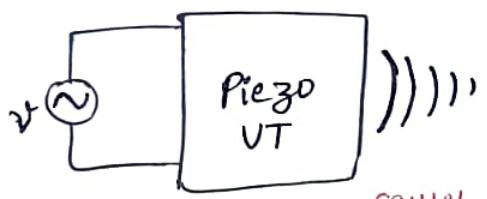
VR: Ultrasonic Receiver



Measure the liquid level by measuring the time taken by wave to reach VR.

### Applications:

- Level
  - Flow-rate
  - Crack detection
  - Blood flow rate
- } measurement



Inverse  
Piezo-  
electric  
effect  
causes  
vibration  
coupled  
through the  
medium  
(mechanical  
deformation)



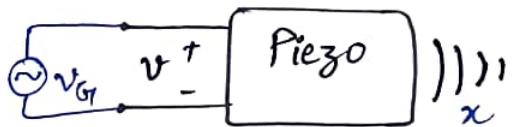
Piezo-  
electric

Charge developed in piezo,  $q = df$ ,  $d$ : charge sensitivity [VR]

$$\text{UT : } x q = df x \\ x = \frac{df x}{q} \rightarrow \text{work done per unit charge} = \text{voltage} \\ x = dv$$

14-11-2025

## Ultrasonic Transmitter

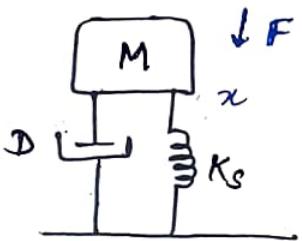


$$x = dv$$

$K_s \rightarrow$  Stiffness

$$F = K_s x = (d K_s) v$$

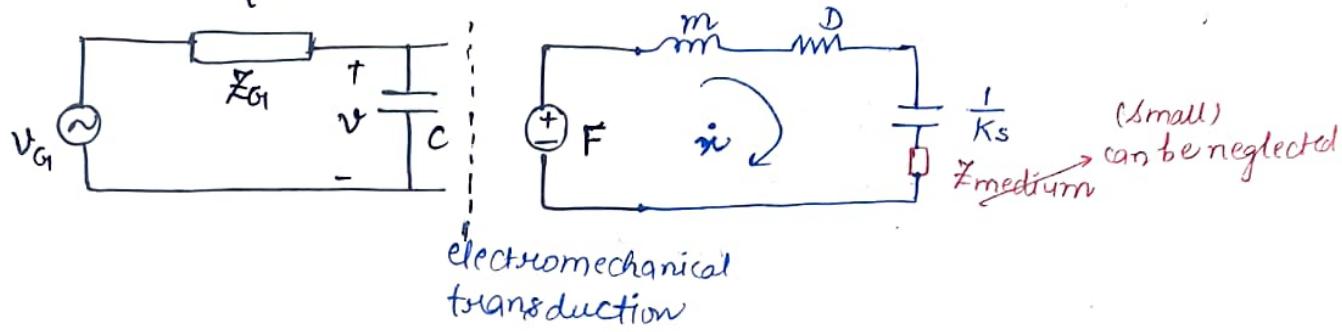
Equivalent Circuit:



$$Z_{\text{medium}} \approx 0$$

$$F = m \ddot{x} + D \dot{x} + K_s x$$

## Electrical Equivalent:

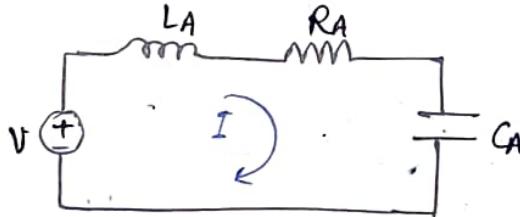


$$F = (d K_s) v$$

Turn's ratio =  $d K_s$

## Electrical model:

$$F = m \ddot{x} + D \dot{x} + K_s x$$



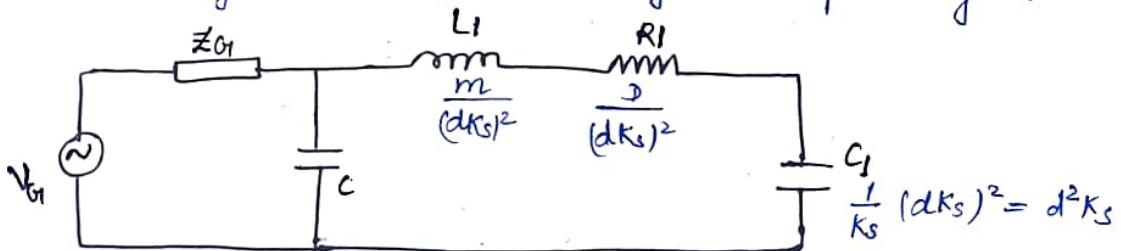
$$v = L_A \dot{I} + R_A I + \frac{1}{C_A} \int I dt$$

$$F \leftrightarrow v \quad m \leftrightarrow L_A$$

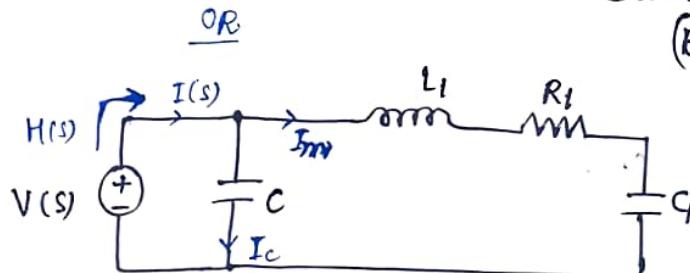
$$\dot{x} \leftrightarrow I \quad D \leftrightarrow R_A$$

$$K_s \leftrightarrow \frac{1}{C_A}$$

For easier analysis, move the secondary to the primary side.



↳ Butterworth Van Dyke model  
(BVD model)



$$H(s) = \frac{V(s)}{I(s)}$$

$$I(s) = I_C(s) + I_m(s)$$

$$I(s) = sC V(s) + \frac{V(s)}{sL_1 + R_1 + \frac{1}{sC_1}}$$

Put  $s=j\omega$ .

$$H(j\omega) = \frac{j(\omega^2 L_1 C_1 - 1) + \omega Q R_1}{j\omega^2 C_1 R_1 + \omega(C + C_1) - \omega^3 L_1 C_1}$$

Series Resonance @  $\omega_s$  [due to  $L_1, C_1$ ]

Numerator  $\rightarrow$  minimum [impedance,  $H(j\omega) \rightarrow \min$ ]

$$\Rightarrow \omega_s^2 L_1 C_1 - 1 = 0$$

$$\Rightarrow \omega_s = \frac{1}{\sqrt{L_1 C_1}} = \sqrt{\frac{k_s}{M}} = \omega_n$$

$\frac{m}{(dk_s)^2} \quad d^2 k_s$

[Series resonance appears at natural frequency]

Parallel Resonance @  $\omega_p$

Denominator  $\rightarrow$  minimum [ $\omega(C + C_1) - \omega^3 L_1 C_1 = 0$ ]

$$\omega_p(C + C_1) = \omega_p^3 L_1 C_1 \quad [g_{mp}, H(j\omega) \rightarrow \max]$$

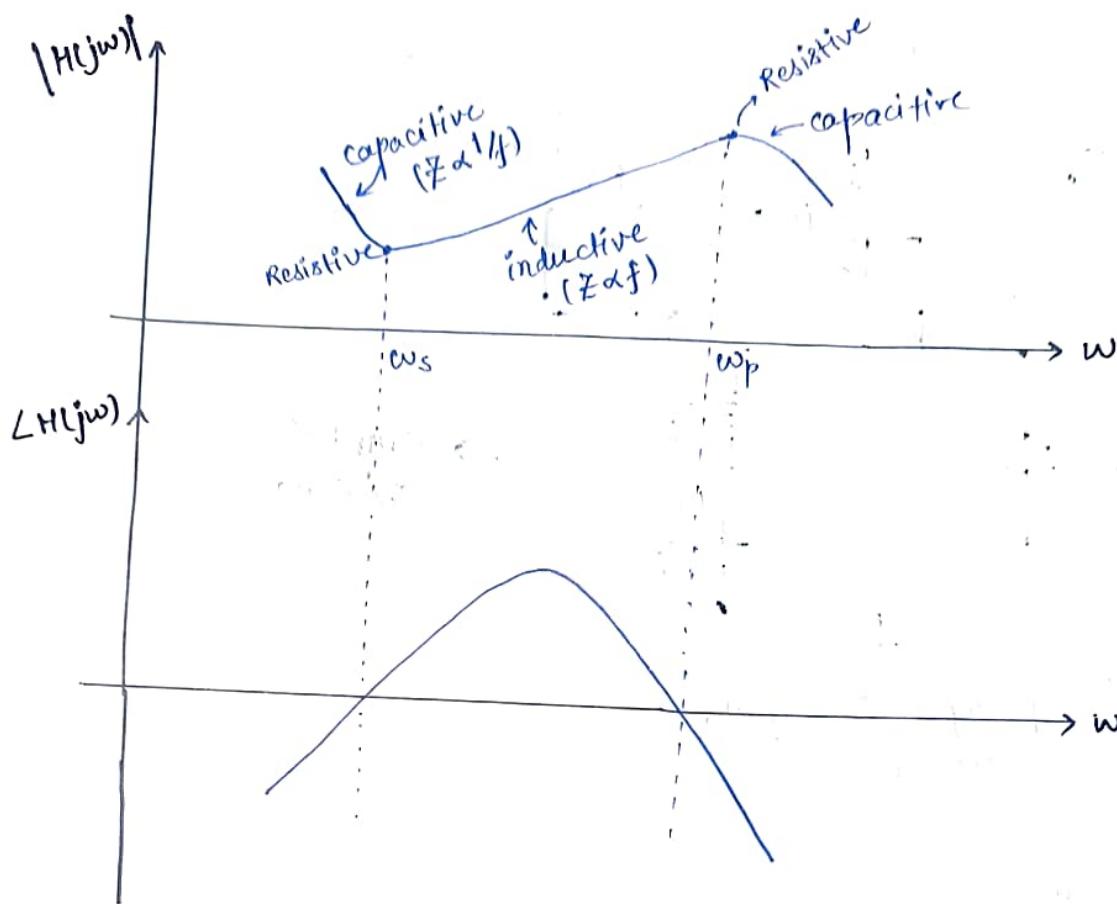
$$\Rightarrow \omega_p^2 = \frac{C + C_1}{L_1 C_1} = \frac{1}{L_1 C_1} \left[ 1 + \frac{C_1}{C} \right]$$

$$\Rightarrow \omega_p^2 = \omega_s^2 \left[ 1 + \frac{C_1}{C} \right]$$

$$\therefore \omega_p = \omega_s \sqrt{1 + \frac{C_1}{C}}$$

mechanical  
electrical  
side cap.  $C_1 \ll C$  electrical  
mechanical  
side cap.

$$\Rightarrow \omega_p \approx \omega_s$$



@  $\omega_s$ :

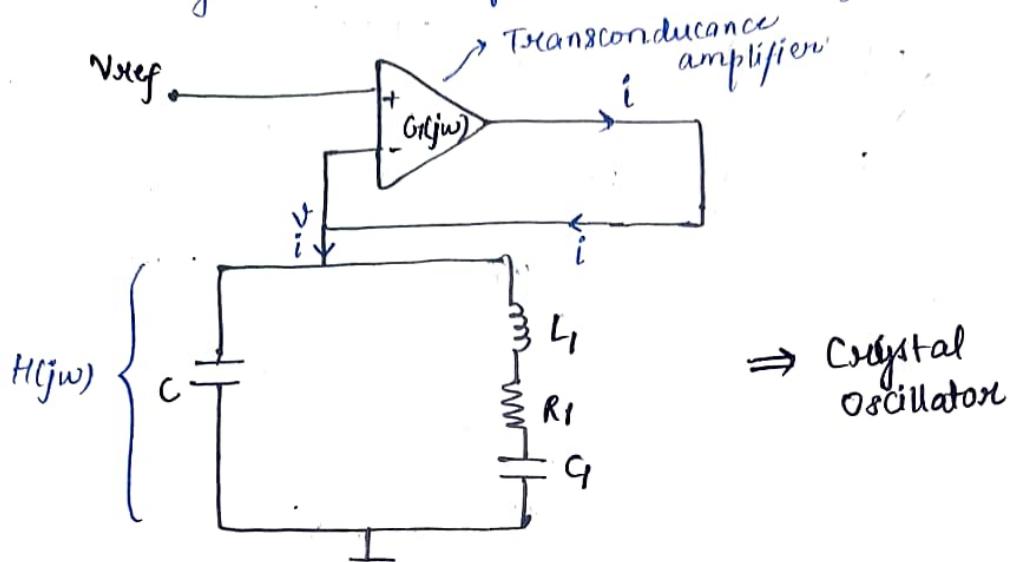
- $|H(j\omega)|$  is minimum.
- $\dot{x}$  is high
- Mechanical power  $[F\dot{x}]$  is high.  
 $\Rightarrow$  Operate at  $\omega = \omega_s$  for maximum power output.  
 "Ultrasonic cleaning"  $\rightarrow$  Application

$$\begin{bmatrix} \dot{x} \leftrightarrow I \\ F \leftrightarrow V \end{bmatrix}$$

@  $\omega_p$ :

- $|H(j\omega)|$  is maximum.
- $\dot{x}$  is low.
- $F\dot{x}$  is low.  
 $\Rightarrow$   $Z_{\text{medium}}$  will be very low  
 $\Rightarrow$  Precise low power.
- Bio-medical application.

Operate the crystal at one of the resonance frequencies:



$$i = [V_{ref} - v] G_1(j\omega),$$

$$v = i H(j\omega)$$

$$\Rightarrow \frac{i}{V_{ref}} = \frac{G_1(j\omega)}{1 + G_1 H(j\omega)}$$

For resonance,  $G_1 H(j\omega) = -1$

$$\Rightarrow |G_1(j\omega_s)| = \frac{1}{|H(j\omega_s)|},$$

$$\angle G_1(j\omega) + \angle H(j\omega) = 180^\circ$$

$$\Rightarrow \angle G_1(j\omega_s) = 180^\circ - \angle H(j\omega_s)$$

$$\text{If } @ \omega_s \rightarrow |H(j\omega)| = 1/5 \Rightarrow |G_1(j\omega)| = 5$$

$$\angle H(j\omega) = 20^\circ \Rightarrow \angle G_1(j\omega) = 160^\circ$$

Eg.  $m = 0.05 \text{ kg}$   
 $k_s = 2 \times 10^9 \text{ N/m}$   
 $D = 200 \text{ Ns/m}$   
 $d = 2 \times 10^{-10} \text{ C/N}$   
 $C = 1.6 \mu\text{F}$ .

(a) Series resonant frequency ( $\omega_s$ )

$$\omega_s = \sqrt{\frac{k_s}{M}} = \sqrt{\frac{2 \times 10^9}{0.05}} = 2 \times 10^5 \text{ rad/s.}$$

$$f_s = \frac{\omega_s}{2\pi} = 31.83 \text{ kHz.}$$

(b) Estimate parameters of BVD model.

$$L_1 = \frac{m}{(dk_s)^2} = \frac{0.05}{0.16} = 312.5 \text{ mH}$$

$$R_1 = \frac{D}{(dk_s)^2} = \frac{200}{0.16} = 1250 \Omega$$

$$C_1 = d \cdot dk_s = 2 \times 10^{-10} \times 0.4 = 80 \text{ pF.}$$

$$dk_s = 0.4$$

$$\therefore C_1 \ll C, \text{ so } \omega_p \approx \omega_s.$$

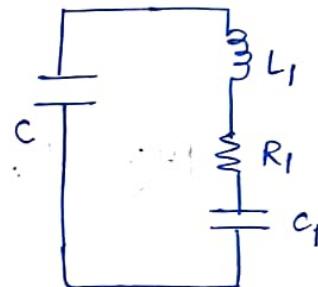
(c) Parallel resonant frequency.

$$\omega_p = \omega_s \sqrt{1 + \frac{C_1}{C}}$$

$$= 2 \times 10^5 \sqrt{1 + \frac{80}{1600}}$$

$$f_p = \frac{\omega_p}{2\pi} = 32.6 \text{ kHz}$$

$$\therefore f_s \approx f_p.$$



⑦ Design an amplifier such that crystal operates at series resonance.

$$H(j\omega_n) = \frac{j[\omega_n^2 L_1 C_1 - 1] + \omega_n^2 R_1 C_1}{j\omega_n R_1 C_1 + j\omega_n (L_1 + C_1) - \omega_n^2 R_1 C_1}$$

$$\left[ \omega_n = \omega_s = \frac{1}{\sqrt{L_1 C_1}} \right]$$

$$\Rightarrow H(j\omega_n) = \frac{\frac{R_1 C_1}{j\omega_n R_1 C_1 + L_1}}{j\omega_n R_1 C_1 + L_1} = \frac{R_1}{j\omega R_1 C + j} \\ = \frac{1250}{j2 \times 10^5 \times 1250 \times 1.6 \times 10^{-9} + j} \\ = \frac{1250}{0.4j + j}$$

$$|H(j\omega_n)| = \frac{1250}{\sqrt{0.16 + 1}} = 1160$$

$$\angle H(j\omega_n) = -\tan^{-1}(0.4) = -22^\circ$$

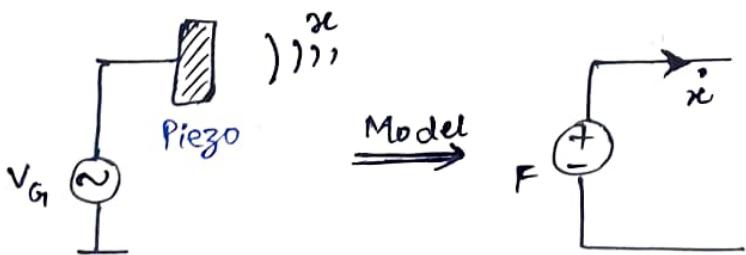
$$|G(j\omega_n)| = \frac{1}{|H(j\omega_n)|} = \frac{1}{1160}$$

$$\angle G(j\omega_n) = 180^\circ - \angle H(j\omega_n) = 202^\circ$$

$$-158^\circ$$

} Specifications of amplifier.

### Applications of Ultrasonic Transmission:

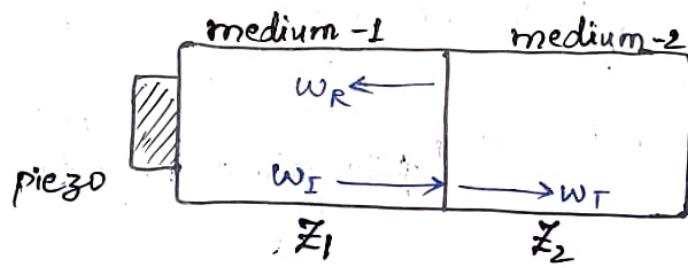
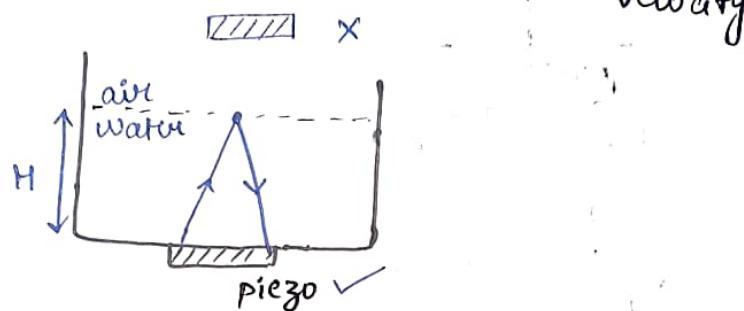


$$\left. \begin{array}{l} \text{Mechanical power} = Fic \\ \text{Mechanical impedance} = \frac{F}{ic} \end{array} \right\} \text{From equivalent circuit}$$

Mechanical terms:

Mechanical power intensity ( $W$ ) = stress  $\times$  velocity

Mechanical impedance ( $Z$ ) =  $\frac{\text{stress}}{\text{velocity}}$



Z-values:

air :  $430$

quartz :  $1.5 \times 10^7$

water :  $0.15 \times 10^7$

steel :  $4.7 \times 10^7$

Al :  $1.7 \times 10^7$

$w_I$ : mechanical power intensity incident on the medium at the interface.

$$\text{Reflection coefficient } (\alpha_R) = \frac{w_R}{w_I} = \frac{(Z_2 - Z_1)^2}{(Z_2 + Z_1)^2}$$

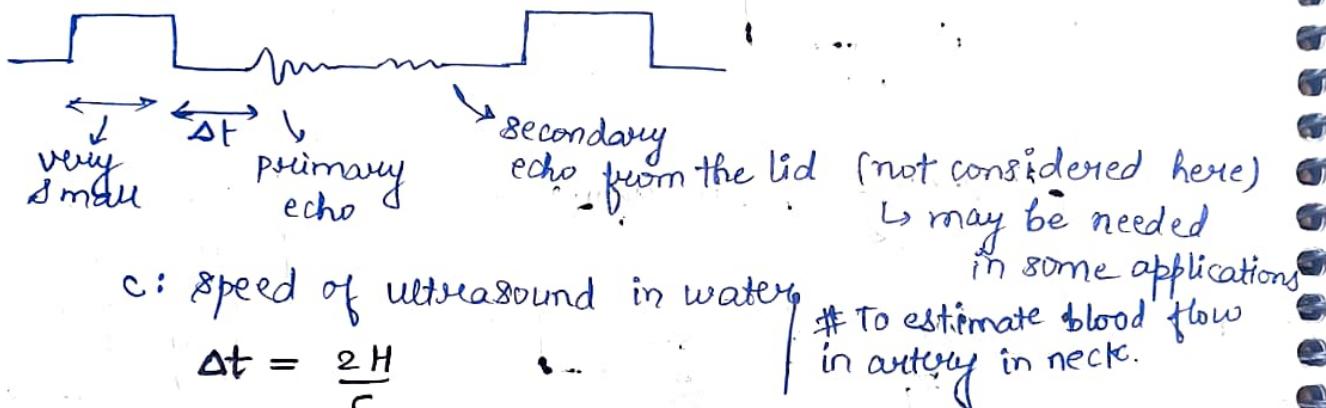
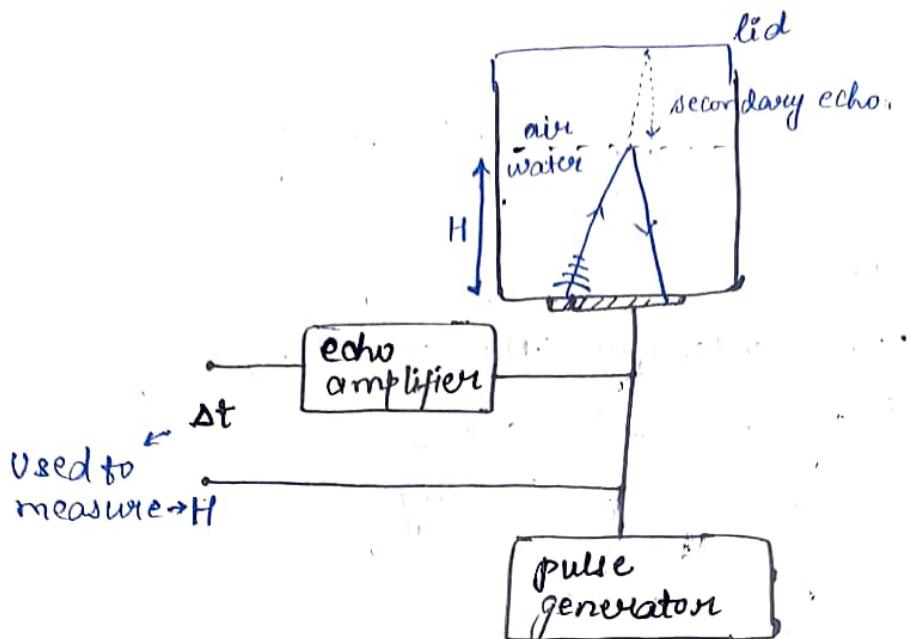
$$\text{Transmission Coefficient } (\alpha_T) = \frac{w_T}{w_I} = \frac{4Z_2 Z_1}{(Z_2 + Z_1)^2}$$

$\alpha_R, \alpha_T$  : Known

$$\boxed{\alpha_R + \alpha_T = 1}$$

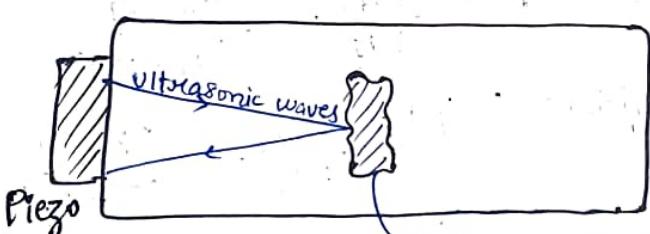
$Z_2 \ll Z_1 \Rightarrow \alpha_R \rightarrow 1, \alpha_T \rightarrow 0 \Rightarrow$  no effective transmission

-  $Z_{\text{air}}$  is less than many  $Z_{\text{medium}}$ , so most of the power gets reflected.

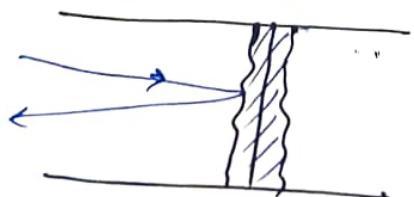


## Non-Destructive Evaluation / Testing

→ Access the quality of material.

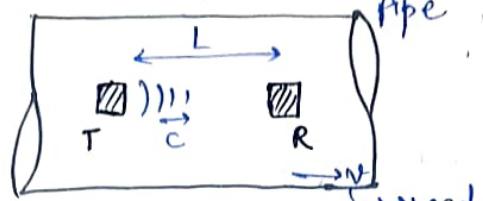


- can also detect sub-surface cracks [Principle: low Z of air]
- Access quality of welding: of crack from received echo



→ Welding → Access its quality by quantity of air

→ In a pipe: [Ultrasonic Flow Meters]



$$\text{Transit time, } t_1 = \frac{L}{c+v}$$

$$\text{static fluid } (v=0) : t_2 = \frac{L}{c}$$

speed of fluid in pipe:  $v$

speed of ultrasound:  $c$

transit times:  $t_1, t_2$

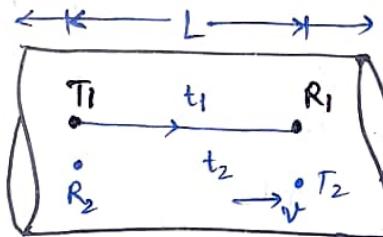
[calibration phase]

$$v = ?$$

$$t_2 - t_1 = \frac{Lv}{c(c+v)} \approx \frac{Lv}{c^2} \rightarrow \text{estimate } v \text{ from } (t_2 - t_1).$$

( $\because c \gg v$ )

18-11-2025



$t_2$ -measurement in static fluid  
is difficult, so add another RT pair,  
to avoid calibration phase.

$$t_1 = \frac{L}{c+v}$$

$$t_2 = \frac{L}{c-v}$$

$$\Delta t = t_2 - t_1 = \frac{L^2 v}{c^2 - v^2} \approx \frac{2Lv}{c^2}, c^2 \gg v^2$$

$$\therefore \boxed{\Delta t \propto v}$$

To get independence from  $c$ ,

$$\frac{1}{t_1} - \frac{1}{t_2} = \frac{2v}{L}$$

discussed

### Ultrasonic Flowmeter

↓  
Transmit time

wetted  
clamp on

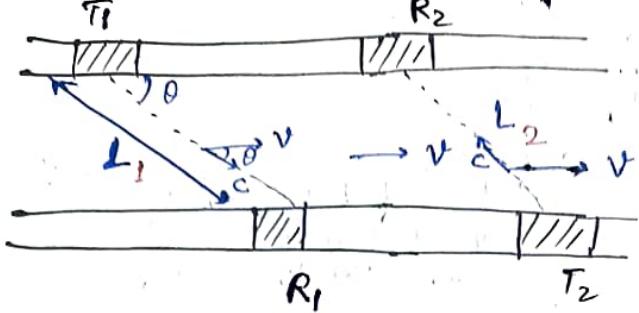
clean fluids

Doppler effect

vs probe embedded  
on wall/thickness  
of pipe

dirty fluids

Clamp-on: No direct contact with the liquid.



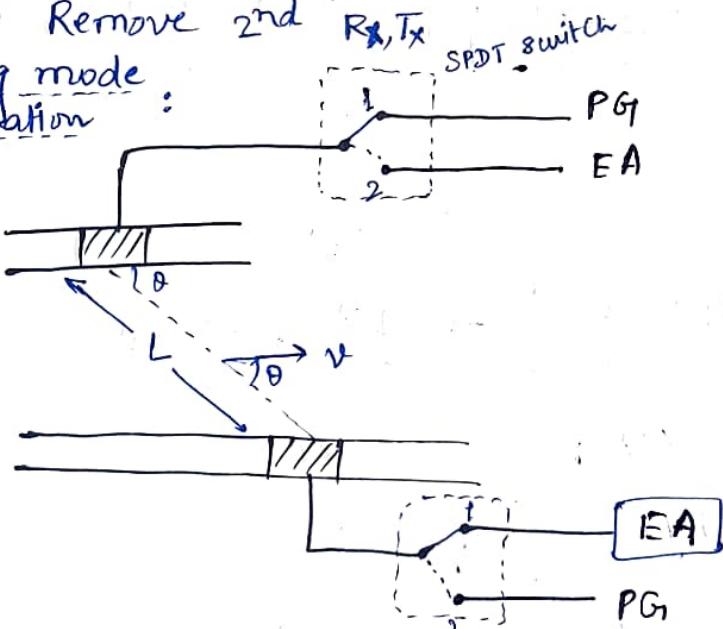
$$t_1 = \frac{L}{c + v \cos \theta}$$

$$t_2 = \frac{L}{c - v \cos \theta}$$

$$\frac{1}{t_1} - \frac{1}{t_2} = \frac{2v \cos \theta}{L}$$

In reality,  $L_1$  may not be same as  $L_2$  (slight mismatch), making it dependent on 'c'  $\Rightarrow \left(\frac{1}{t_1} - \frac{1}{t_2}\right)$  is no longer linear.

Solution: Remove 2nd switching mode configuration:



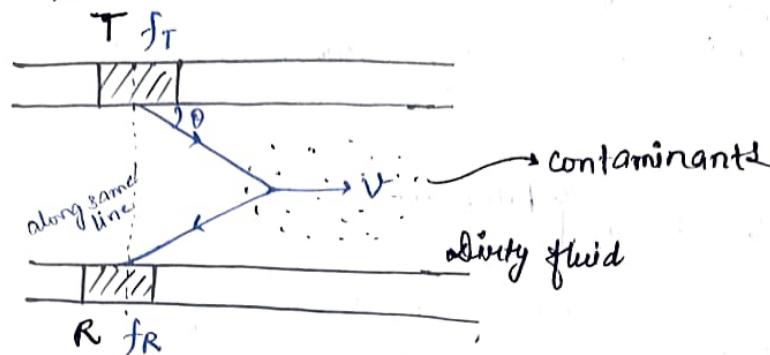
PG: Pulse generator ( $T_x$ )

EA: Echo amplifier ( $R_x$ )

Mode-1 :  $t_1$

Mode-2 :  $t_2$

## Doppler Effect:



$f_T$ : transmitted ultrasonic frequency

$$f' = f_T \frac{c - v \cos \theta}{c}$$

$$f_R = f' \frac{c}{c + v \cos \theta}$$

$$\Rightarrow f_R = f_T \left( \frac{c - v \cos \theta}{c + v \cos \theta} \right)$$

$$= f_T \left[ \frac{1 - \frac{v}{c} \cos \theta}{1 + \frac{v}{c} \cos \theta} \right], \quad v \ll c$$

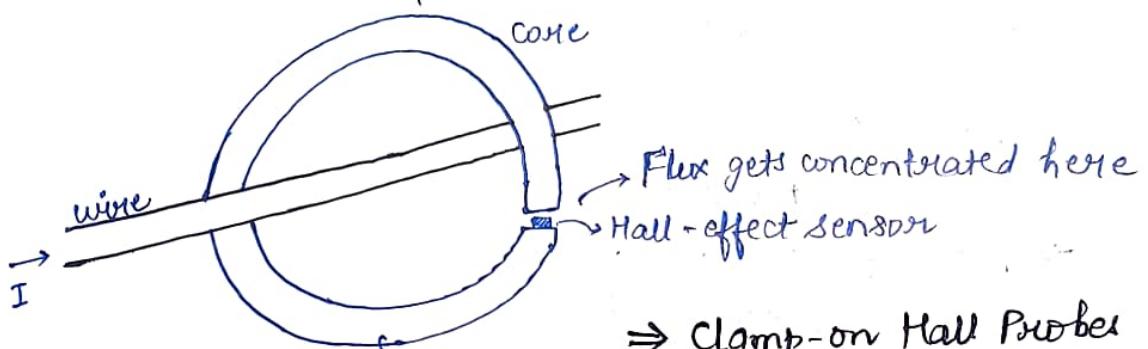
$$f_R \approx f_T \left[ 1 - \frac{2v}{c} \cos \theta \right]$$

$$\therefore f_T - f_R = \frac{2v}{c} \cos \theta. f_T \propto v$$

- There may be many  $f_R$ 's  $\Rightarrow$  Take the dominant one (from the Fourier analysis)
- Calculating proportionality constant by exposing to known few 'v' values.

## I and V Measurement

- ↳  $I_n$  → smart grids
- ↳ condition monitoring equipment
- ↳ power systems
- ↳ Heavy wires      } Problems
- ↳ congested locations      }
- ↳ Option: current transformer      } bulky  
                        Potential transformer }

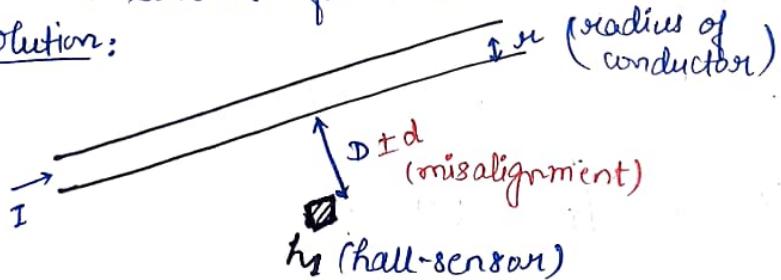


⇒ Clamp-on Hall Probe

- Requires full 360° access around the conductor
- Not suitable for PCB mounted circuit

↳ 360° measurement

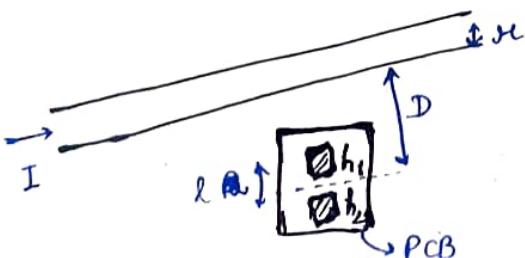
Solution:



$$\text{Mag. field seen by } h_1, B_1 = \frac{\mu_0 I}{2\pi(D \pm d + r)}$$

↳ Depends on  $D$ ,  $d$ ,  $r$

Solution: Use two hall sensors.



- Hall-sensors  $h_1, h_2$  soldered on the PCB

Fields seen by sensors,

$$B_1 = \frac{\mu_0 I}{2\pi [D + H - l/2]}$$

$$B_2 = \frac{\mu_0 I}{2\pi [D + H + l/2]}$$

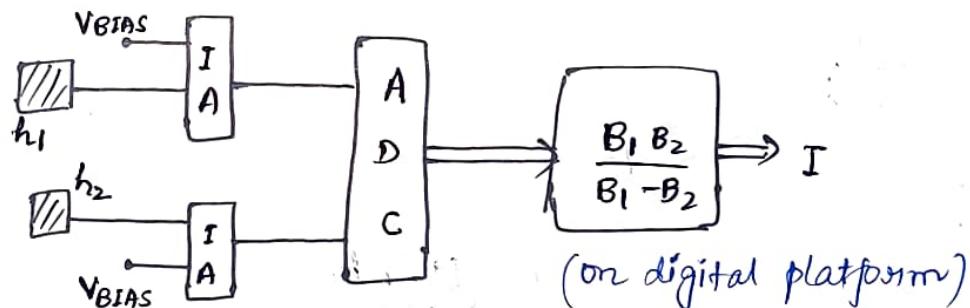
$$\frac{1}{B_2} - \frac{1}{B_1} = \frac{2\pi}{\mu_0 I} l$$

$$\therefore \frac{B_1 B_2}{B_1 - B_2} = \frac{\mu_0 I}{2\pi l} \rightarrow \text{free of } D, H$$

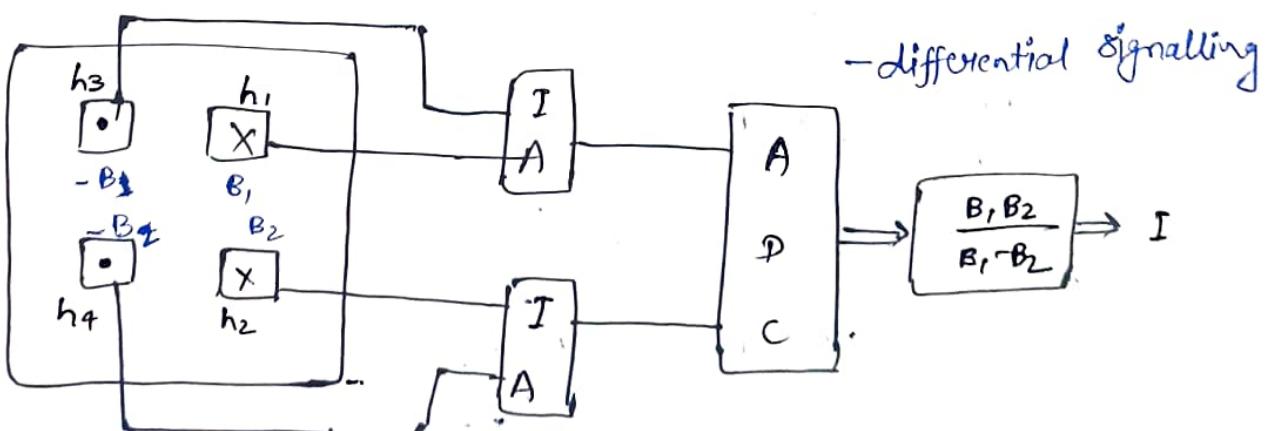
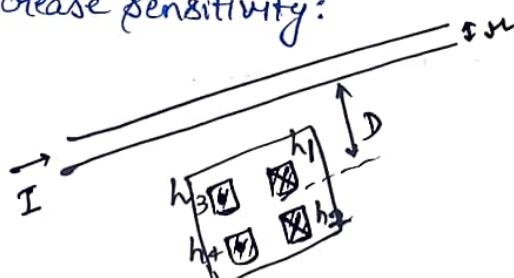
↳ depends on  $l \Rightarrow$  decided by us.

$$V_{H_1} = V_{BIAS} [1 + KB_1]$$

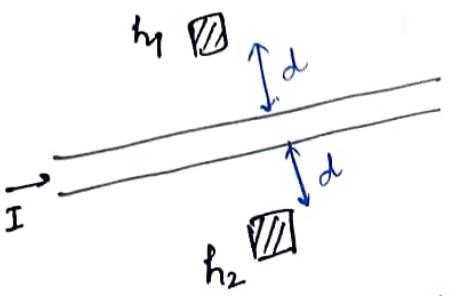
$$V_{H_2} = V_{BIAS} [1 + KB_2]$$



To increase sensitivity:

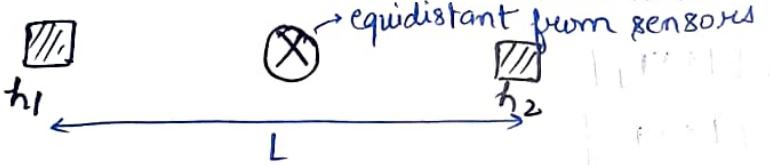


## Anti-differential Current Probe

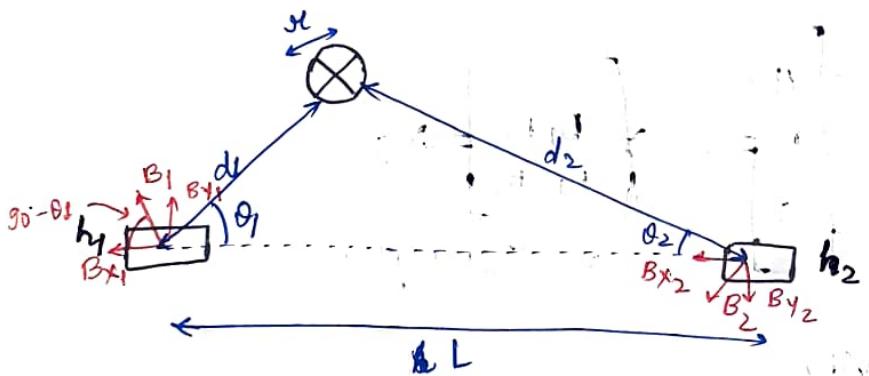


Current-carrying conductor should be equidistant from the sensors, which is difficult to achieve  $\Rightarrow$  Misalignment.

⊗ Suppose the conductor is misaligned and is here



21-11-2025



$$(d_1 + h) \cos \theta_1 + (d_2 + h) \cos \theta_2 = L \quad \dots (1)$$

$$B_1 = \frac{\mu_0 I}{2\pi(d_1 + h)}$$

$$B_2 = \frac{\mu_0 I}{2\pi(d_2 + h)}$$

$$(1) \Rightarrow \frac{\mu_0 I}{2\pi B_1} \cos \theta_1 + \frac{\mu_0 I}{2\pi B_2} \cos \theta_2 = L$$

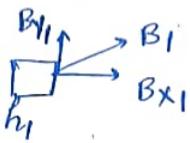
$$\left[ \cos \theta_1 = \frac{B_{y1}}{B_1}; \quad \cos \theta_2 = \frac{B_{y2}}{B_2} \right]$$

$$\Rightarrow \frac{\mu_0 I}{2\pi B_1^2} B_{y1} + \frac{\mu_0 I}{2\pi B_2^2} B_{y2} = L$$

$$\Rightarrow I = \frac{2\pi L}{\mu_0 \left[ \frac{B_{Y2}}{B_{Z2}^2} + \frac{B_{Y1}}{B_{Z2}} \right]}$$

→ Independent of  $\mu$ ,  $d_1$ ,  $d_2$

↳ Dual axis Hall sensors to measure  $B_{Y1}$ ,  $B_{Y2}$  (at  $h_1$ ,  $h_2$ )



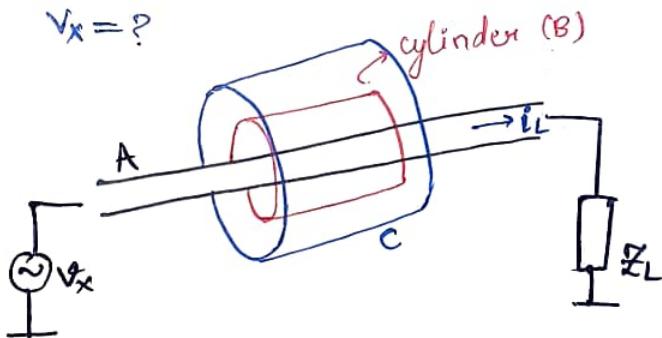
Measure

### Non-contact Voltage Measurement

↳ Measure the voltage (RMS) (typically high) in the insulated conductor without touching it.

$$V_x = \sqrt{2} V_x \sin(\omega_x t)$$

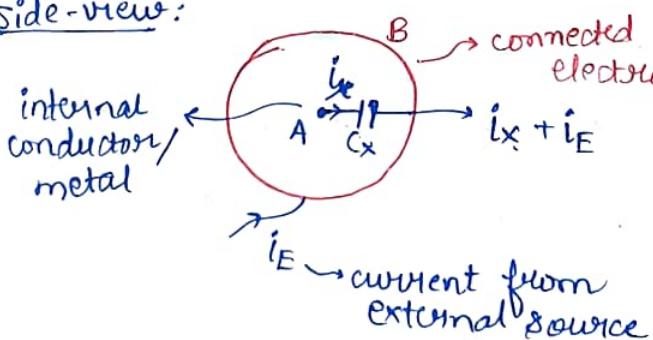
$$V_x = ?$$



→ very large current  
↳ Magnetic principle not applicable possible

- Measure using capacitive principle. [  $i_x$ : displacement current ]

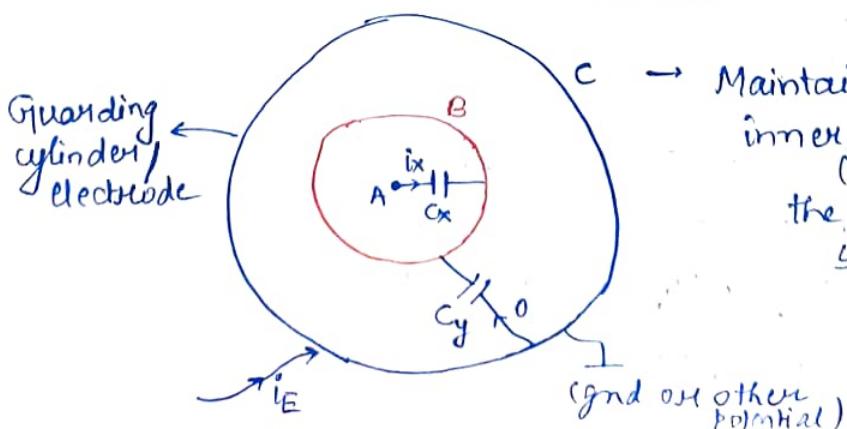
Side-view:



connected to some node of electronic circuit (Gnd/Ref)

Cx: cap. b/w main conductor (A) & cylinder B

↳ depends on conductor (wire) thickness, wire insulating material, gap b/w wire & B.  
↳ Not in our control (get indep. from it)



→ Maintain the guard and inner electrode at (B & C) the same potential

↳ Zero current flow b/w them

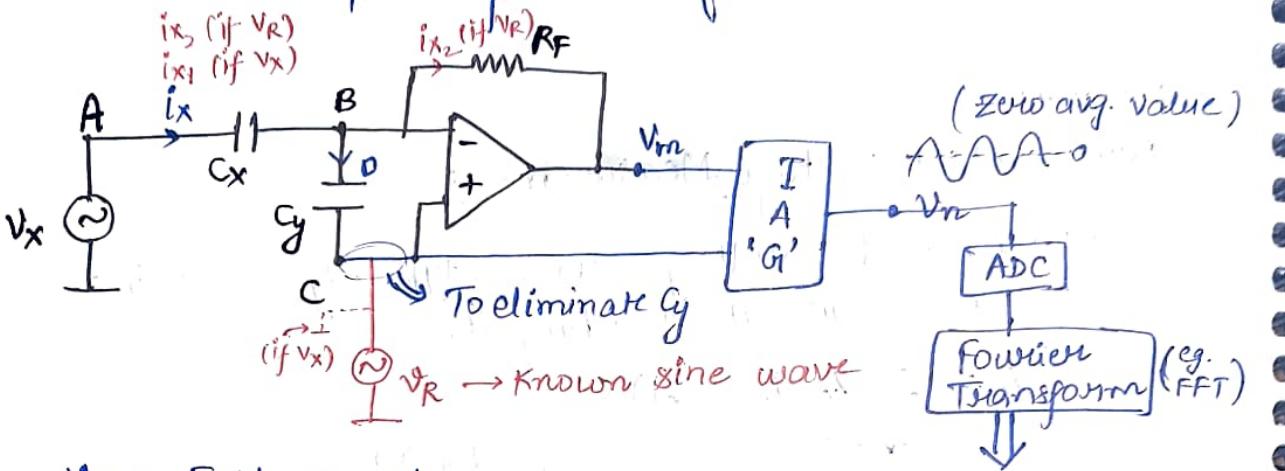
↳ Inner electrode protected

$i_x \xrightarrow{\text{depends on}} C_x$

↳ Dependence :-  
 - thickness of wire  
 - insulating material of wire  
 - gap b/w wire & B

↳ Not in our control

↳ Get independence from it



$$V_R = \sqrt{2} V_r \sin \omega_r t$$

$$V_x = \sqrt{2} V_x \sin \omega_x t$$

Using superposition:

$$\underline{V_x} : i_{x_1} = C_x \dot{V}_x$$

$$V_{m_1} = -i_{x_1} R_F$$

$$V_{n_1} = G_1 [V_{m_1} - 0]$$

$$\Rightarrow V_{n_1} = -G_1 i_{x_1} R_F$$

$$= -G_1 R_F C_x \dot{V}_x$$

$$\Rightarrow \underline{V_{n_1}} = -\underbrace{G_1 R_F C_x \sqrt{2} V_x \omega_x \sin(\omega_x t + 90^\circ)}$$

$$\Rightarrow \underline{V_{n_1}} = -V_{N_1} \sin(\omega_x t + 90^\circ)$$

$V_R$

$$i_{x_2} = -C_x \dot{V}_R$$

$$V_{m_2} = V_R - i_{x_2} R_F$$

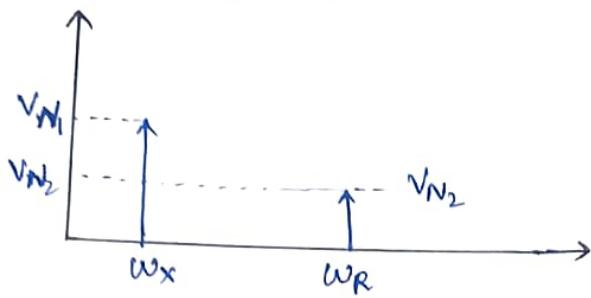
$$V_{n_2} = G_1 [V_{m_2} - V_R] = -G_1 i_{x_2} R_F$$

$$\Rightarrow V_{n_2} = G_1 C_x R_F \dot{V}_R$$

$$\Rightarrow V_{n_2} = \underbrace{G_1 C_x R_F \sqrt{2} V_R \omega_R}_{\text{if } V_R} \sin(\omega_R t + 90^\circ)$$

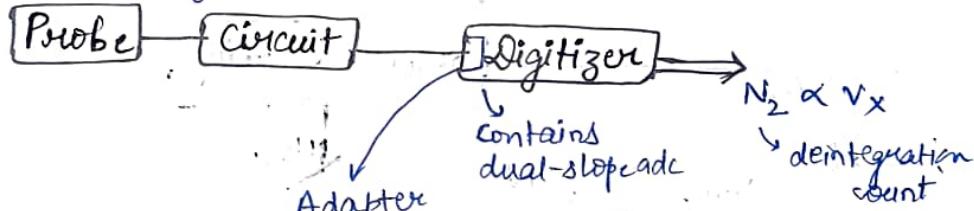
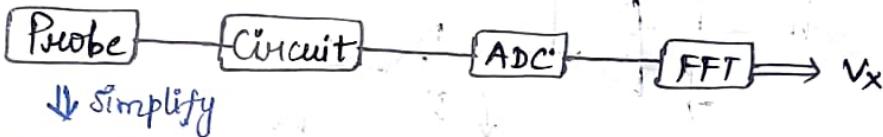
$$\Rightarrow \underline{V_{n_2}} = V_{N_2} \sin(\omega_R t + 90^\circ)$$

$$\therefore V_n = V_{n_1} + V_{n_2}$$

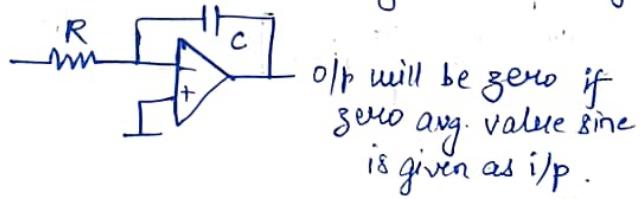


$$\frac{V_{N_1}}{V_{N_2}} = \frac{V_x w_x}{V_R w_R} \Rightarrow V_x = \left( \frac{V_{N_1}}{V_{N_2}} \right) \frac{V_R w_R}{w_x}$$

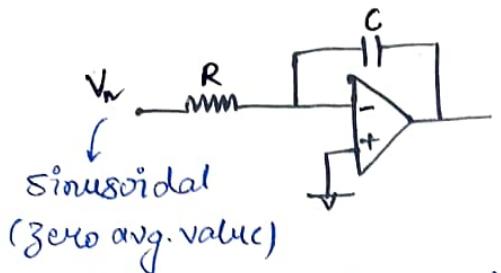
→ indep. of thickness,  
separation of conductors  
 $w_x$  : may correspond to  
power supply.



↳ converts output sine (of zero avg. value) (from IA o/p)  
to a signal having certain avg. value

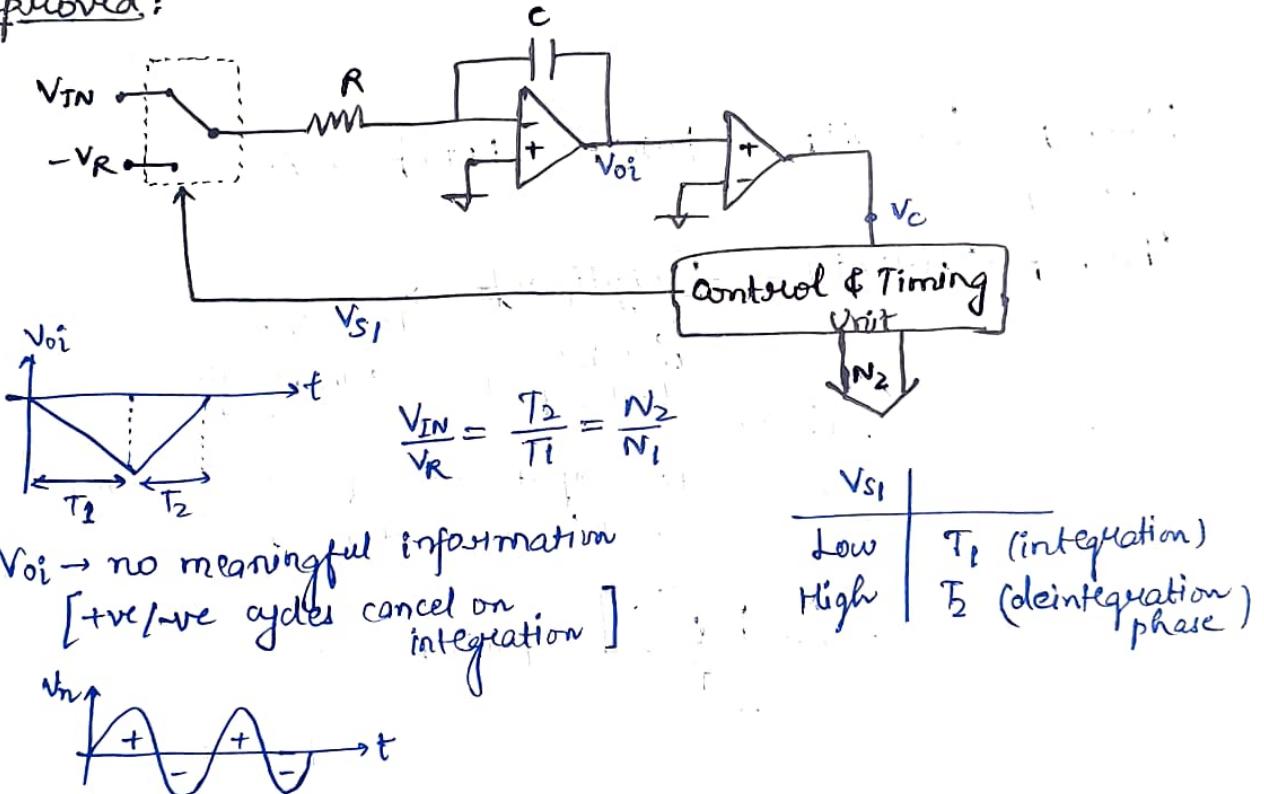


# Dual Slope ADC



↳ Digitizer should have an adaptation block that produces a finite average value.

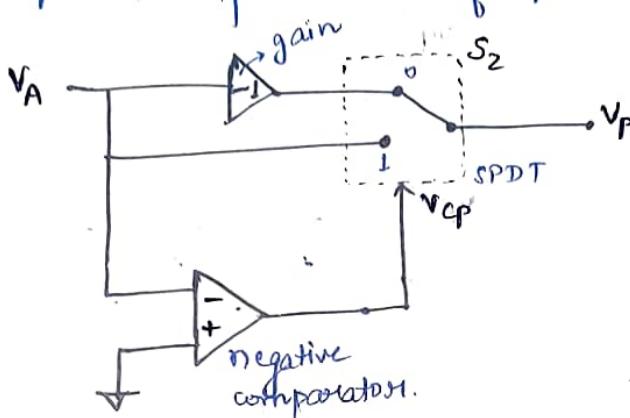
Improved:



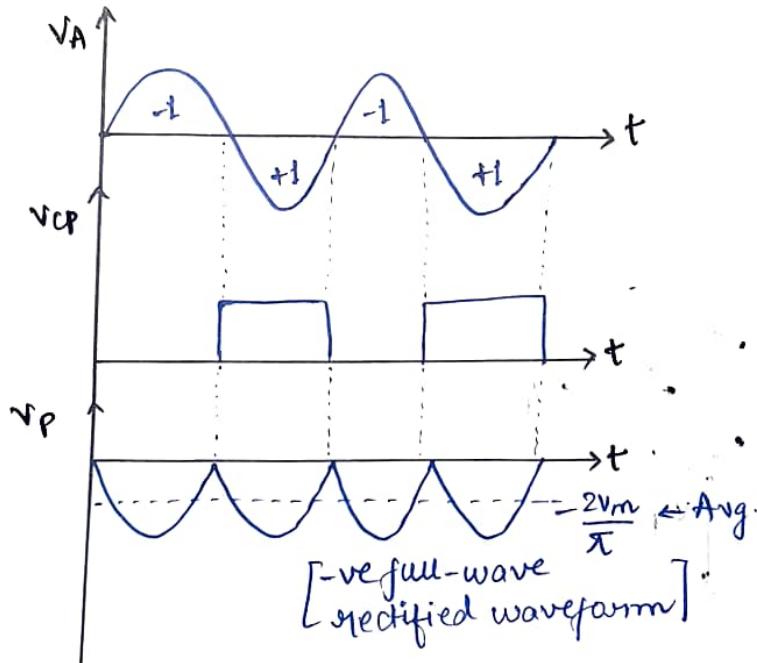
Instead of: Capacitive sensor + circuit + ADC + FFT  
 ↓  
 Capacitive sensor + circuit + Digitizer + Adapter  $\Rightarrow N_2$   
 ↓  
 $V_{in}$        $N_2 \propto V_x$   
 We need adapter block  $\rightarrow$  PSD

## Phase Sensitive Demodulator (PSD)

- Phase of control signal determines the transformation from i/p to o/p.
- O/p is transformation of i/p.



$V_A$	$V_{CP}$	$S_2$	$V_P$
$> 0$	Low	0	$-V_A$
$< 0$	High	1	$V_A$



→ signal with finite average value can be processed by dual slope ADC.

Case-1: -ve comparator → Negative Full Wave Rectifier (FWR)

$$V_P = -|V_A|$$

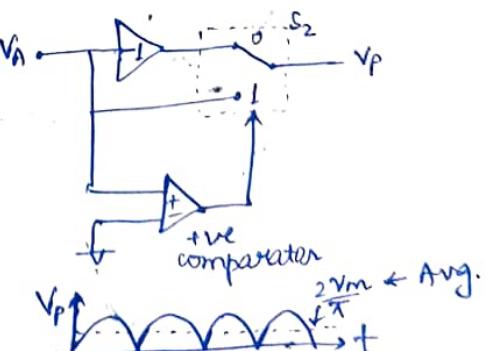
$$\text{Avg. } (V_P) = -\frac{2V_m}{\pi}$$

→ 90° phase shift  
↳ All pass filter.

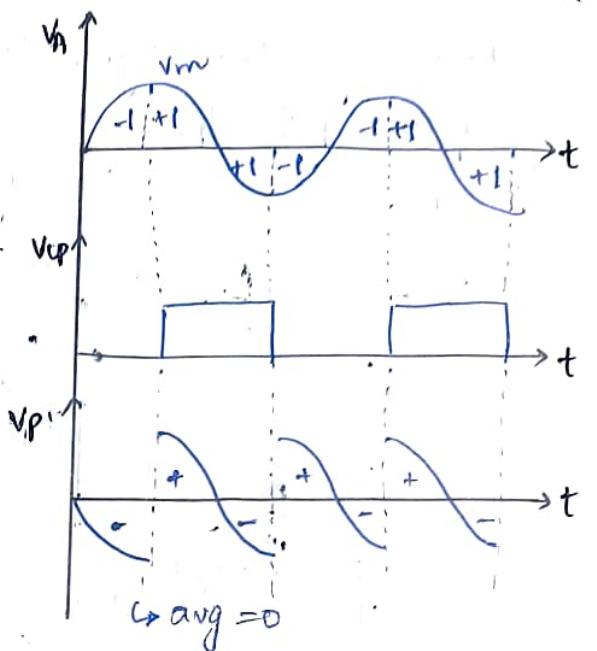
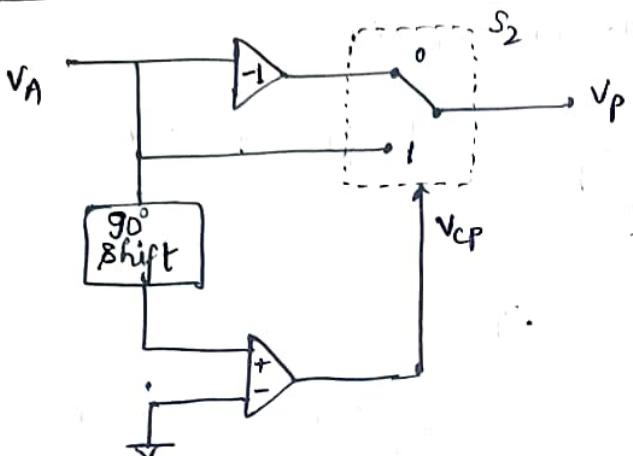
Case-2: +ve comparator → +ve FWR:

$$V_P = |V_A|$$

$$\text{Avg. } (V_P) = \frac{2V_m}{\pi}$$



### Case-3:

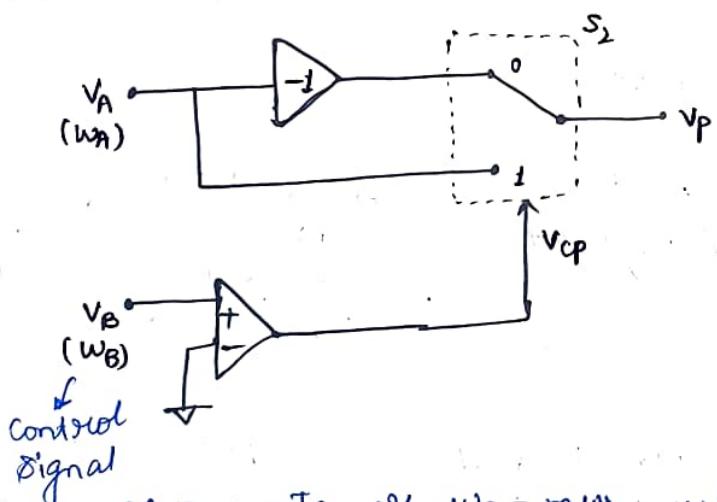


$$\text{avg}(V_p) = 0$$

### Case-4: $\theta$ -shift

$$\text{avg}(V_p) = \frac{2 V_m}{\pi} \cos \theta$$

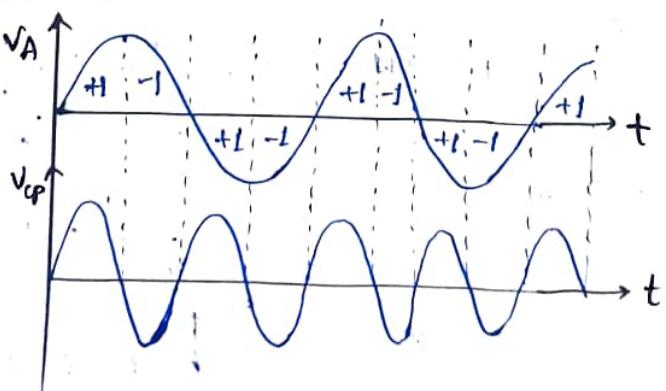
### Case-5: $\omega_B = 2\omega_A$



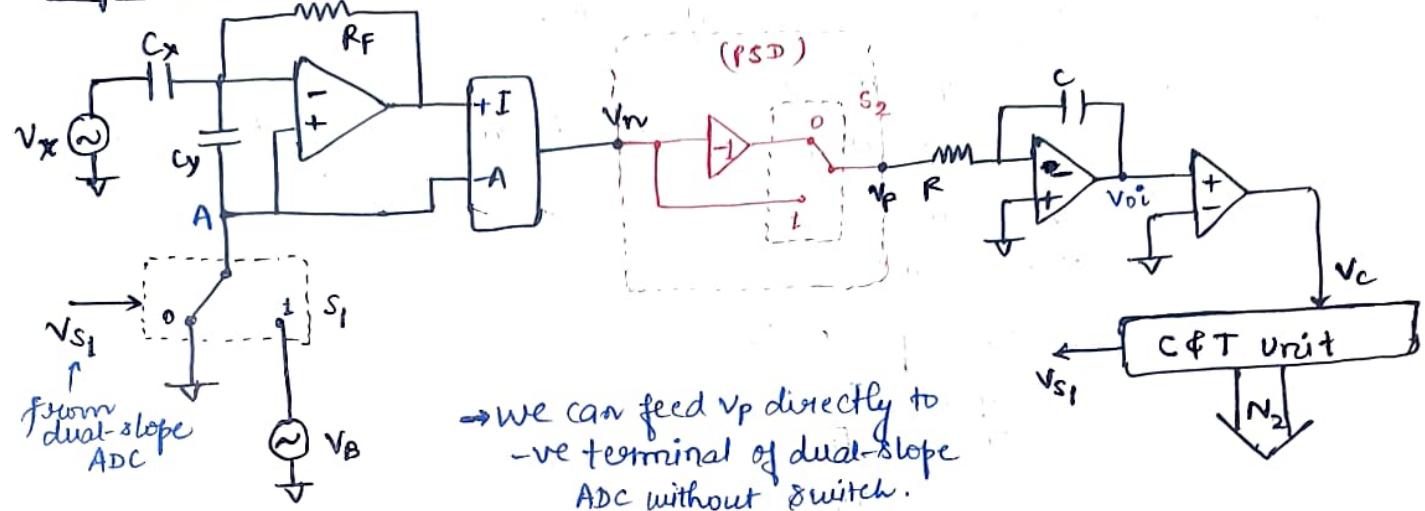
g.f.  $T_A = m T_B$  or  $\omega_B = m \omega_A$ , where  $m$  is an integer.

$$\Rightarrow \text{avg}(V_p) = 0.$$

$$\omega_B = 2\omega_A$$



## Capacitive Probe:



$v_{s_1}$	$s_1$	$v_n$	$s_3$	avg ( $N_P$ )
Low	$T_1$	0	$v_{n1}$	$0 + \frac{2v_{n1}}{\pi}$
High	$T_2$	1	$v_{ns}$	$+ \frac{2v_{n2}}{\pi}$

$$v_{n1} = \sqrt{2} G_1 R_F C_x v_x \omega_x$$

$$v_{n2} = \sqrt{2} G_2 R_F C_x$$

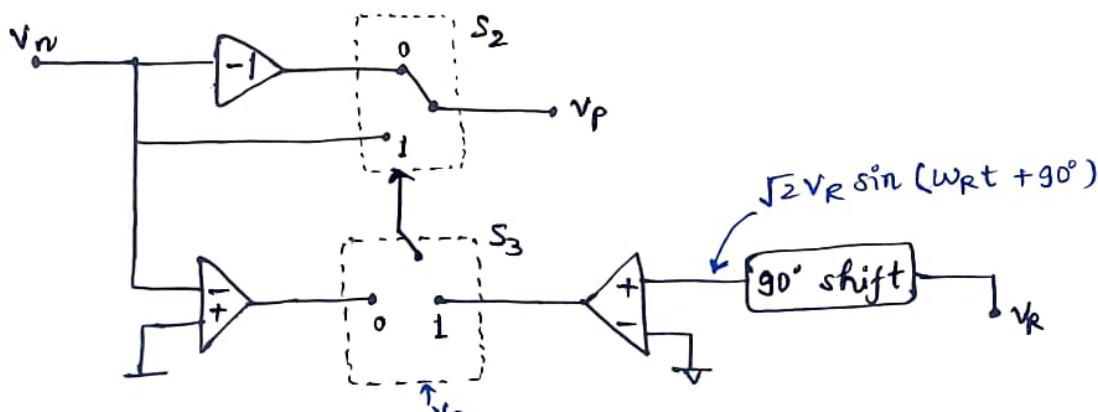
$T_1$ :  $s_1 \rightarrow 0$

$$v_n = v_{n1} = -v_{N_1} \sin(\omega_x t + 90^\circ)$$

$T_2$ :  $s_1 \rightarrow 1$

$$v_n = v_{n2} = v_{N_2} \sin(\omega_R t + 90^\circ) - v_{N_1} \sin(\omega_x t + 90^\circ) = v_{ns}$$

## PSD:



$T_1$ :  $v_n = v_{n1} = -v_{N_1} \sin(\omega_x t + 90^\circ)$

$$\text{avg}(v_p) = -\frac{2v_{n1}}{\pi}$$

$T_2$ :  $v_n = v_{n2} = +v_{N_2} \sin(\omega_R t + 90^\circ) - v_{N_1} \sin(\omega_x t + 90^\circ)$

$$\text{avg}(v_p) = \frac{2v_{n2}}{\pi}$$

→ To avoid dependence on  $V_{N_1}$  term,

choose,  $W_R = m W_X$

or,  $T_X = m T_R \Rightarrow$  2nd term averages to zero.

Eg.  $T_X = 20 \text{ ms}$   
 $T_R = 0.2 \text{ ms}$

From dual-slope ADC,

$$\frac{V_1}{V_2} = \frac{T_2}{T_1}$$

$$\Rightarrow \frac{\frac{2V_{N_1}}{\pi}}{\frac{2V_{N_2}}{\pi}} = \frac{T_2}{T_1} \Rightarrow \frac{V_{N_1}}{V_{N_2}} = \frac{T_2}{T_1} = \frac{W_X W_X}{W_R W_R}$$

can be calculated  $\Rightarrow \boxed{\frac{W_X}{W_R} = \frac{T_2}{T_1} \times \frac{T_X}{T_R}}$

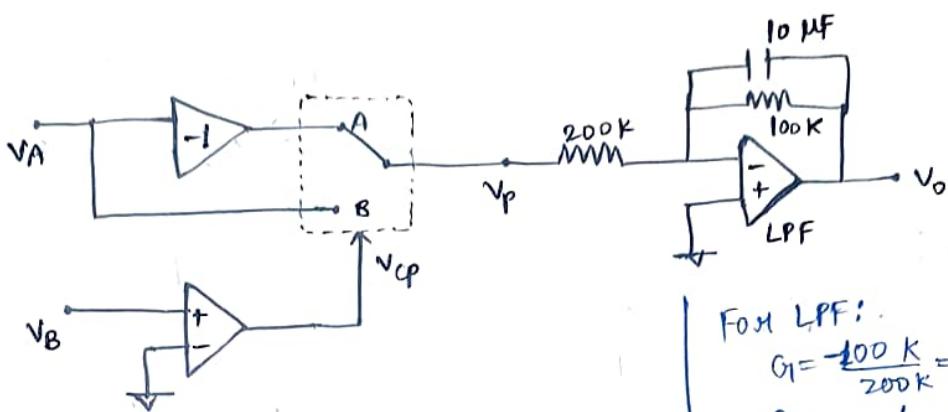
$T_2$ : measured by CFT unit

$T_1$ : present integration time

$T_X, T_R$ : known

$T_1, W_R$ : known

Eg.



Find  $V_O$  for these cases:

①  $V_A = V_B = \sin(100\pi t)$

$$\begin{aligned} V_O &= \text{avg}(V_P) \times G \\ &= -\frac{2}{\pi} \left(-\frac{1}{2}\right) = \frac{1}{\pi} V \end{aligned}$$

②  $V_A = \sin(100\pi t)$

$$V_B = \cos(100\pi t)$$

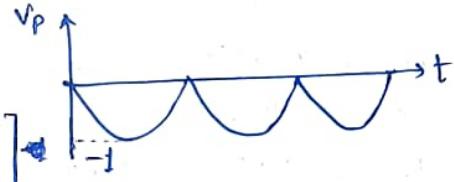
$V_O = 0$  [Since  $V_A$  &  $V_B$  are phase-shifted by 90°]

③  $V_A = \sin(100\pi t)$   $\text{by } 90^\circ$

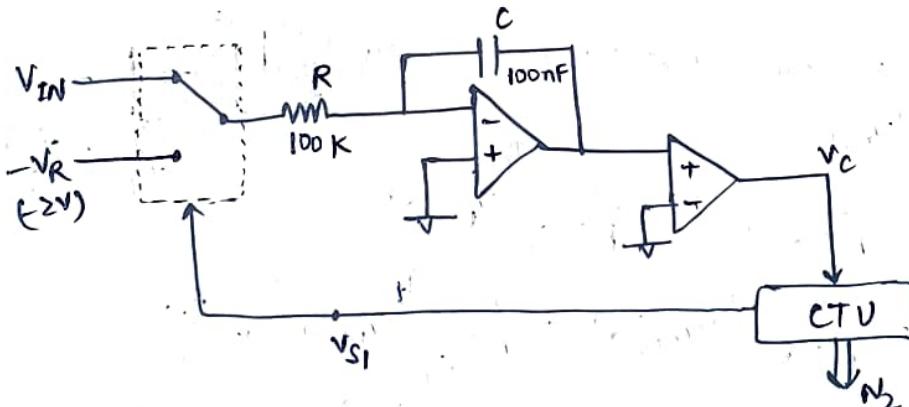
$$V_B = \sin(200\pi t)$$

$$V_O = 0$$

$V_A$	$V_{CP}$	<del>SW</del>	$V_P$
>0	High	A	$-V_A$
<0	Low	B	$+V_A$



Eg.



$$V_{IN} = 1 + 0.01 \sin 100\pi t$$

① Find  $T_1$  to nullify interference.

② Find the value of integrator o/p at the end of integration time.

③ Design dual-slope ADC for capacitive sensor probe.

Soln: ① Integration period,  $T_1 = K_1 T_N$  to nullify +ve & -ve halves equally (50 Hz component removed)

$$V_{IN} = 1 + 0.01 \sin 100\pi t$$

$\downarrow$

$$T_N = 20 \text{ ms}$$

Take  $K_1 = 3$ .

$$\Rightarrow T_1 = 60 \text{ ms.}$$

(B)  $i = V_{IN}/R$

$$\therefore V_{oi} = -\frac{1}{C} \int_0^{T_1} i dt = -\frac{V_{IN}}{RC} T_1 \\ = -\frac{1}{100 \text{ K} \times 100 \text{ nF}} \times 60 \text{ ms} = -6 \text{ V.}$$

Opamp is giving  $-6 \text{ V}$ , so power supply should be at least  $\pm 8 \text{ V}$ .

(C)  $V_R = \sqrt{2} V_R \sin \omega_R t$

$$V_x = \sqrt{2} V_x \sin \omega_x t$$

Unknown {  $\omega_x = 100\pi \text{ rad/s}$

Signal {  $f_x = 50 \text{ Hz}, T_x = 20 \text{ ms}$

$$f_R = 1000 \text{ Hz (20 times)}$$

$$\omega_R = 2000\pi \text{ rad/s}$$

$$\omega_R = K_2 \omega_x$$

$T_1$ :

$$V_n = V_{n1} = -V_{N1} \sin(\omega_x t + 90^\circ)$$

$$V_p = -|V_{n1}|$$

$$V_o = -\frac{1}{RC} \int V_p dt = \frac{1}{RC} \int |V_{n1}| dt$$

$$V_K = \frac{1}{RC} \int_0^{T_1} |V_{n1}| dt = \frac{1}{RC} \left( \int_0^{T_x} |V_{n1}| dt \right) \times \left( \frac{T_1}{T_x} \right)$$

$$= \frac{1}{RC} T_1 \cdot \frac{2}{\pi} V_{N1} \dots \textcircled{1}$$

$$\left[ \because \frac{1}{T_x} \int_0^{T_x} |V_{n1}| dt = \frac{2}{\pi} V_{N1} \right]$$

Power supply to opamp should be more than this.

Design Conditions:

$$\textcircled{1} \quad T_1 = K_2 T_x$$

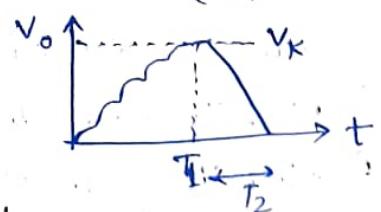
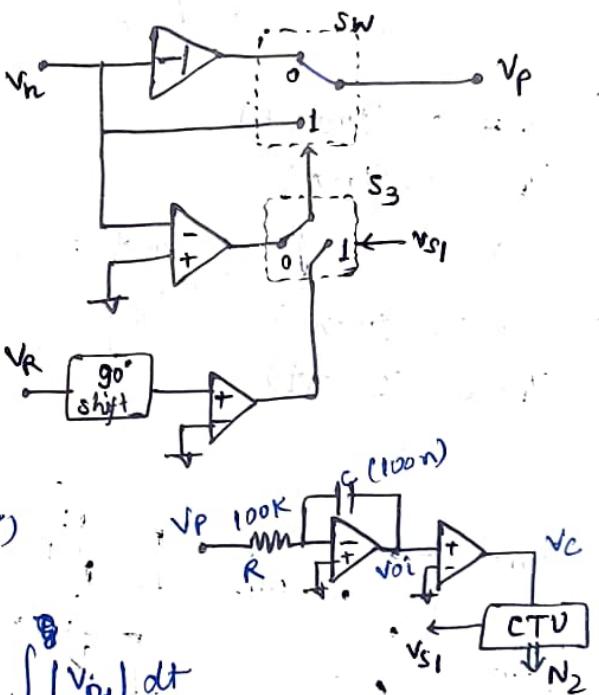
$$\textcircled{2} \quad T_x = K_1 T_R$$

Taking higher  $K$ ,

$$T_1 \uparrow, (T_1 + T_2) \uparrow$$

conversion time  $\uparrow$

$\therefore$  speed  $\downarrow$



T<sub>2</sub>:

$$V_{ns} = \underbrace{V_{N_2} \sin(\omega_R t + 90^\circ)}_{V_{N_2}} - \underbrace{V_{N_1} \sin(\omega_x t + 90^\circ)}_{\text{No role since } \omega_R = k_1 \omega_x}$$

$$V_o = V_k - \frac{1}{RC} \int_{T_1}^{T_1+T_2} |V_{N_2}| dt$$

$$V_o(T_1+T_2) = 0$$

$$\Rightarrow V_k = \frac{1}{RC} \overline{|V_{N_2}|}_{T_2}$$

$$= \frac{1}{RC} \frac{T_2}{T_R} \overline{|V_{N_2}|}_{T_R}$$

$$= \frac{P}{RC} T_2 \cdot 2 \frac{V_{N_2}}{\pi}$$

$$\therefore V_k = \frac{2V_{N_2}}{\pi} \frac{T_2}{RC} \quad \dots \textcircled{2}$$

Equating \textcircled{1} and \textcircled{2},

$$T_1 V_{N_1} = T_2 V_{N_2}$$

$$\Rightarrow \frac{V_{N_1}}{V_{N_2}} = \frac{T_2}{T_1} = \frac{N_2}{N_1} = \frac{V_x \omega_x}{V_R \omega_R}$$

$$\Rightarrow \frac{V_x}{V_R} = \frac{N_2}{N_1} \frac{\omega_R}{\omega_x} = \frac{N_2}{N_1} K_2$$

$$\therefore K_2 = \frac{\omega_R}{\omega_x}$$